

HIGH TEMPERATURE



In Situ and Operando Electrochemical Techniques



huber scientific
novel measurement solutions

Outline:

- Experiments:
 - In situ PLD
 - In situ XPS
 - In situ Auger SEM
 - In situ LASIS
 - In situ NAP XPS
 - In situ XPS
- **How to do/start an in situ experiment**
- **Potential problems on the way**
- Tips & tricks on how to set things up
- **Electrical measurements, electrode arrangements & designs**

iPLD
EXACT-XPS
EXACT-AEM





Join at [menti.com](https://www.menti.com) | use code 1414 1463

In situ definition

In situ ([/ɪn ˈsɪtjuː](#), - [ˈsɑɪtjuː](#), - [ˈsiː-/](#); often not italicized in English)^{[1][2][3]} is a Latin phrase that translates literally to "on site"^[4] or "in position."^[5] It can mean "locally", "on site", "on the premises", or "in place" to describe where an event takes place and is used in many different

Experimental physics [\[edit\]](#)

In [experimental physics](#) *in situ* typically refers to a method of data collection or manipulation of a sample without exposure to an external environment. For example, the Si(111) 7x7 surface reconstruction is visible using a [scanning tunneling microscope](#) when it is prepared and analyzed

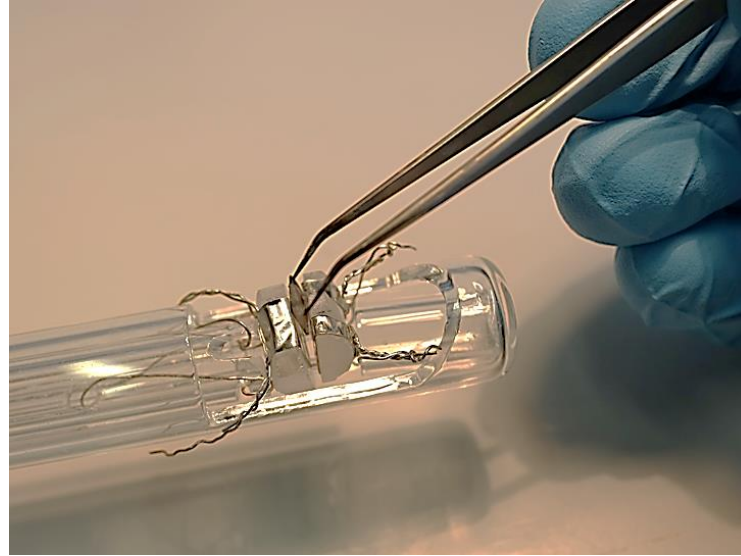
in situ Electrochemistry [\[edit\]](#)

In [electrochemistry](#), the phrase *in situ* refers to performing electrochemical experiments under operating conditions of the electrochemical cell, i.e., under potential control. This is opposed to doing *ex situ* experiments that are performed under the absence of potential control. Potential control preserves the electrochemical environment essential to maintain the double layer

The term "*in situ*" changed to "*operando*" in the research field of catalyst spectroscopy!



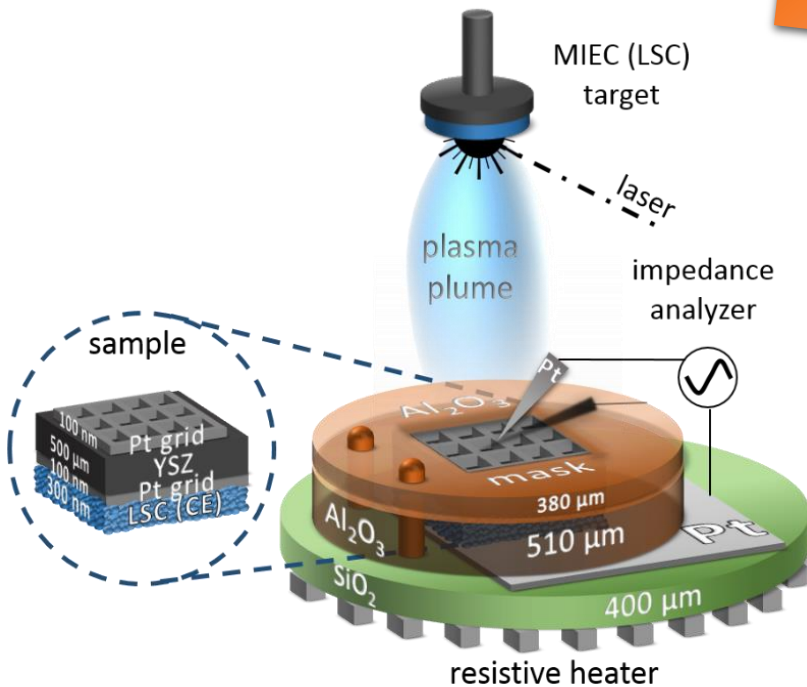
Temperature



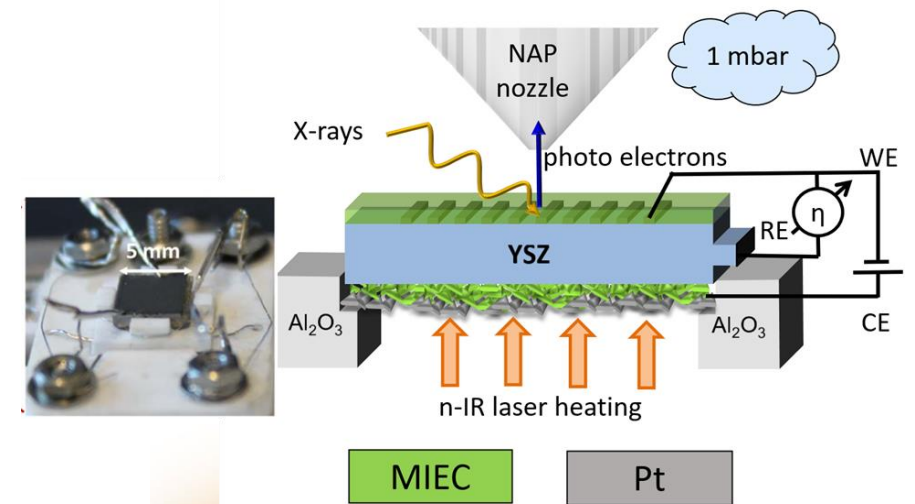
Gasses

Electrical
Measurements

Production/
deposition



Analytical



Experiments

Real-time impedance monitoring in the PLD

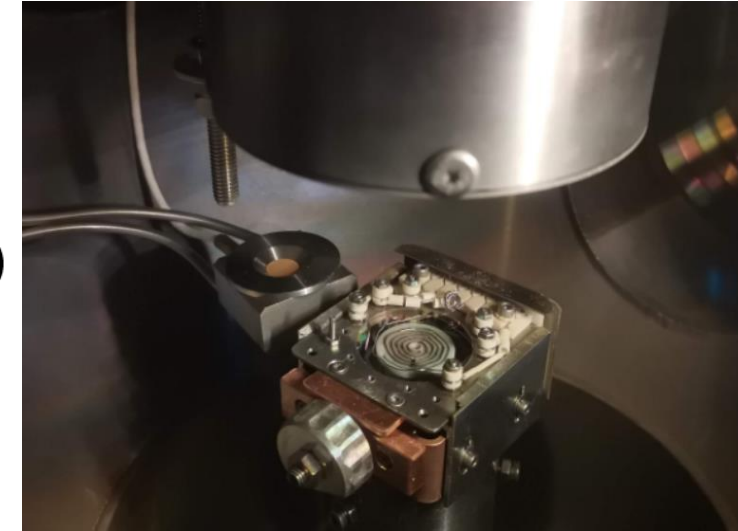
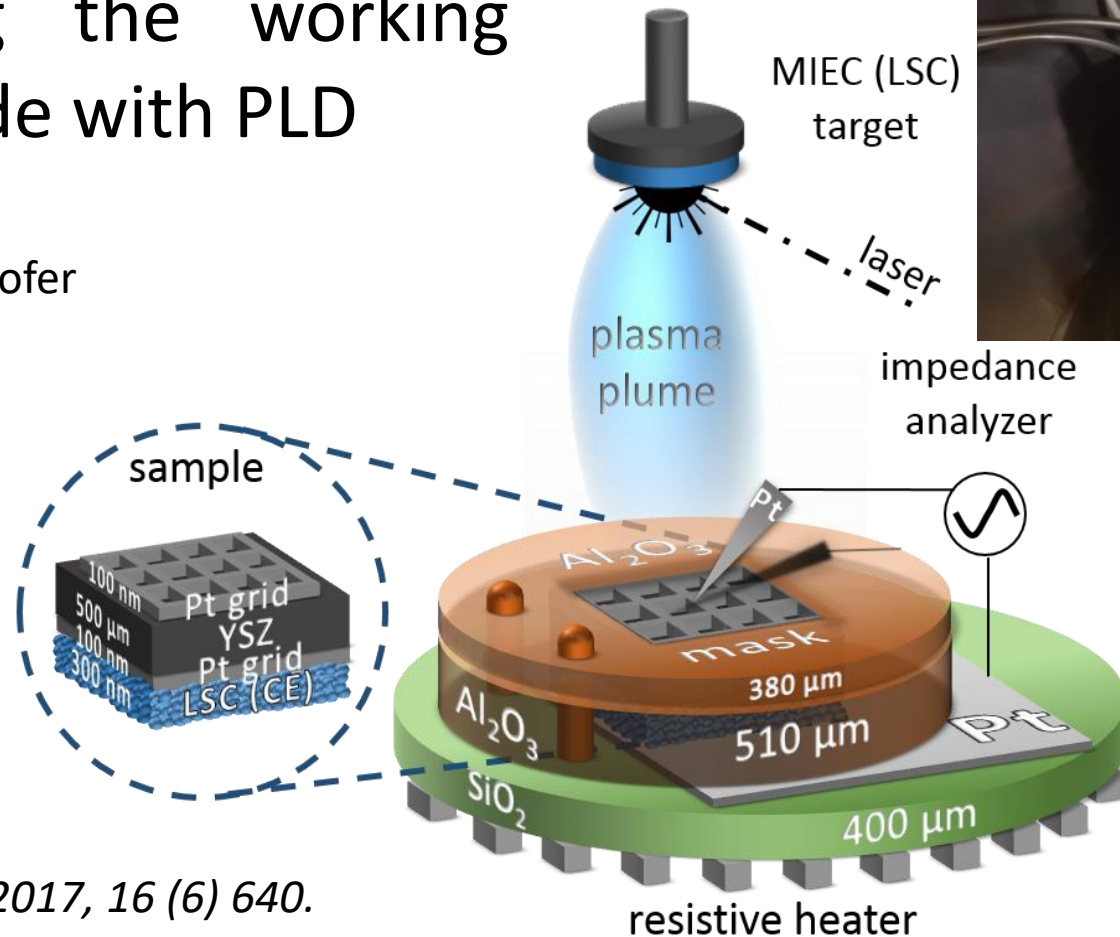
Measuring a cell while growing the working electrode with PLD



Matthäus Siebenhofer
Poster on Tuesday

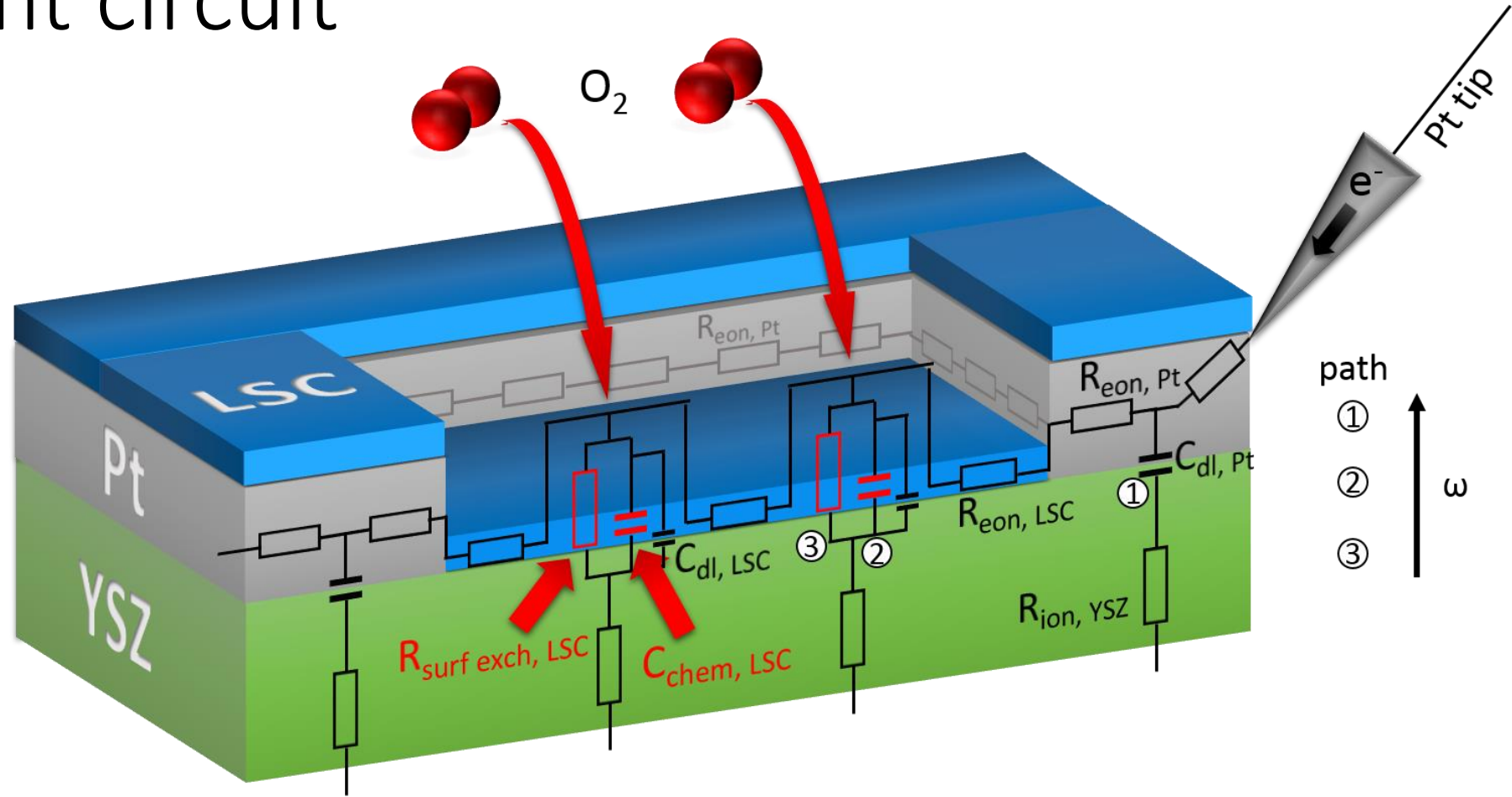
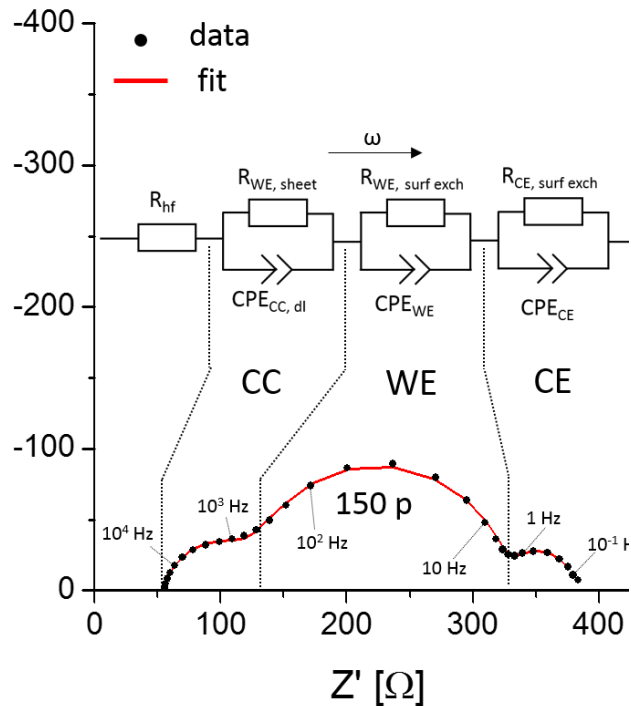


Markus Kubicek
Talk on Friday

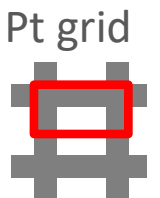


Rupp G.M. et al. *Nature Materials*, 2017, 16 (6) 640.
Rupp G.M. et al. *ACS Appl. Energy Mater.* 2018 1, 9, 4522-4535

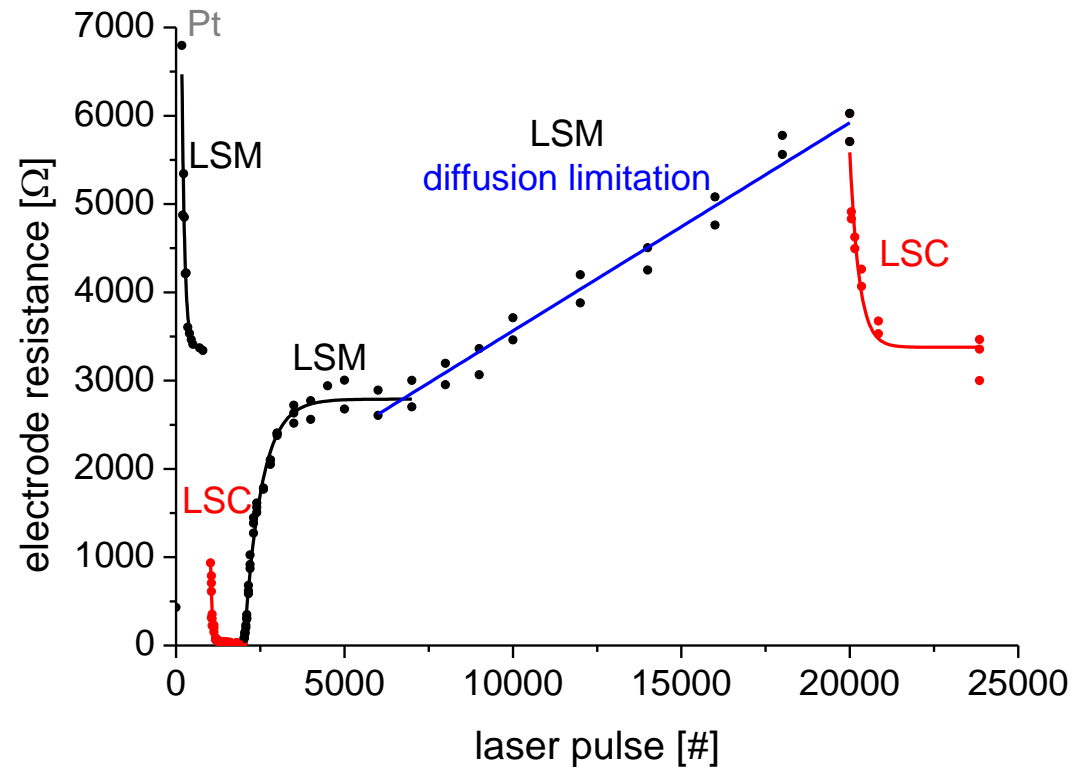
The equivalent circuit



- Equivalent circuit based on Jamnik-Maier model
- Could not be used for NLLS fitting (3D, differential)
- Simplified equivalent circuit for fitting

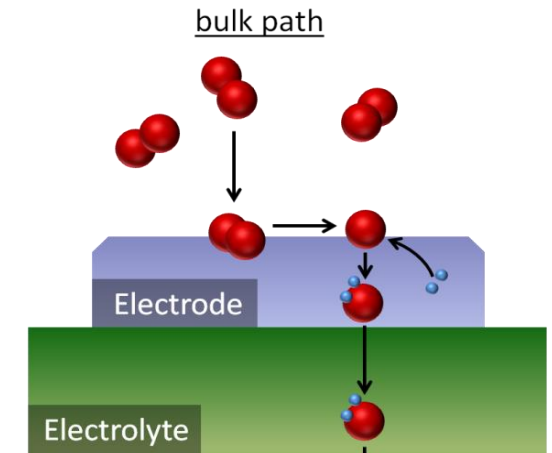


Multilayers of $\text{La}_{0.6}\text{Sr}_{0.4}\text{CoO}_{3-\delta}$ and $\text{La}_{0.8}\text{Sr}_{0.2}\text{MnO}_{3-\delta}$



Impedance of growing
MIEC thin films

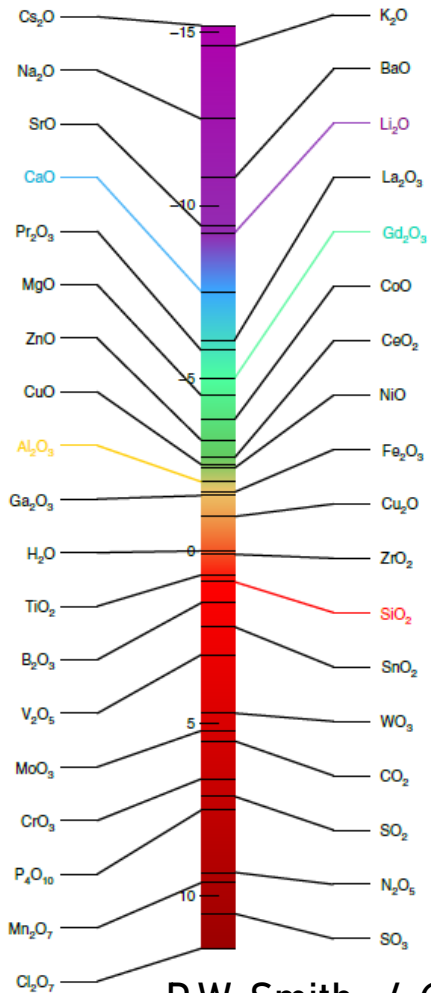
600°C, $4 \cdot 10^{-2}$ mbar $p\text{O}_2$



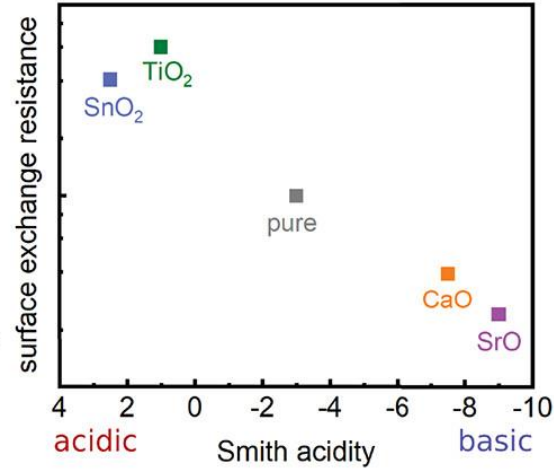
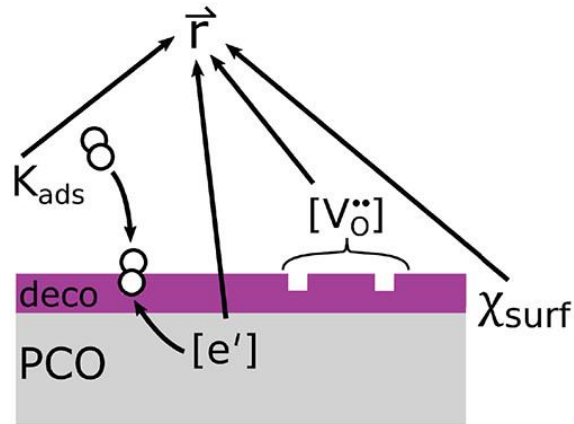
- Determine critical thickness
- Investigate co-limitations
- Customize model thin films (R_{surf} vs. R_{diff})

Surface manipulation

Acidity scale for oxides:
Transfer of O^{2-}



D.W. Smith, *J. Chem. Educ.*, (1987), 64, 6, 480.



surface charge – work function –
catalytic activity

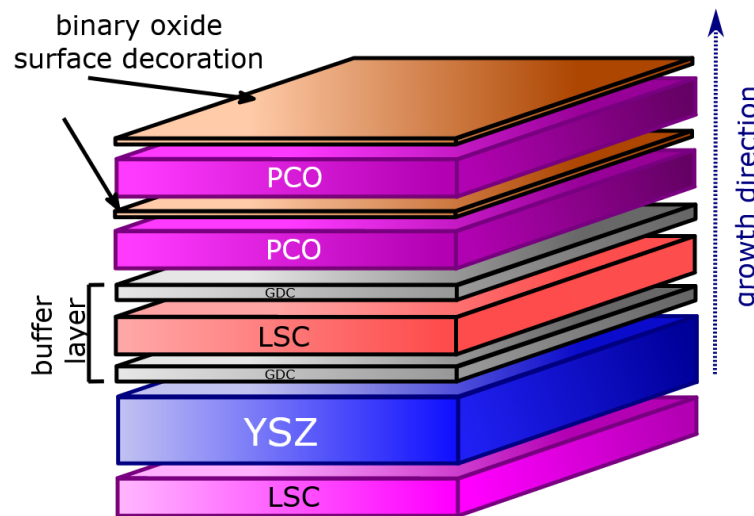
C. Riedl, ... M Kubicek et al.
J. Mater. Chem. A, (2022) ,10, 2973–2986

M Siebenhofer, ..., M Kubicek
J. Electrochem. Soc. (2023) 170 014501

F Fahrnberger, ... M Kubicek
Appl. Surf. Sci., (2023), 640, 158312

M Siebenhofer, ... M Kubicek
J. of Mater. Chem. A, (2023), 11(24), pp.
12827–12836

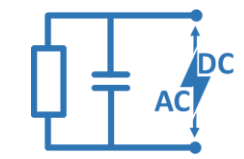
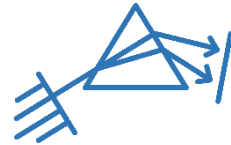
M Siebenhofer, ..., M Kubicek
Nature Comm., (2024), 15, 1, 1730



In situ
thin film growth
in atmosphere

Methods

Optical (UV/VIS/IR) Characterization	X-Ray Based Spectroscopy	X-Ray and Neutron Diffraction	Electron & Ion Beam Methods	Electrical AC & DC Measurements
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Challenges

Temperature Incompatibility 	✓ <i>IR background</i>	✓ <i>desorption of surface species</i>	✓	✓ <i>limited resolution</i>	✓
Pressure Gap 	✓	✓	✓ <i>Neutrons dependence on atmosphere</i>	✓	✓
Set up/Mechanical Incompatibility 	✓	✓ <i>Needs custom made solution</i>		✓	✓

Laser induced breakdown spectroscopy

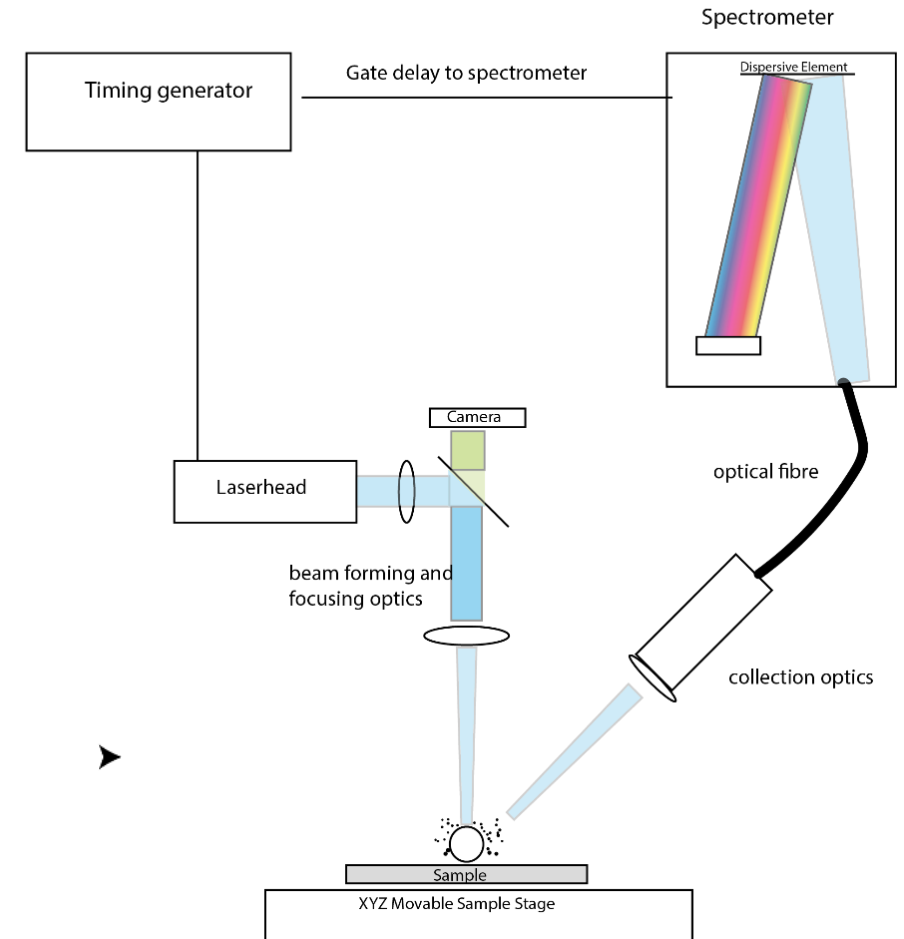
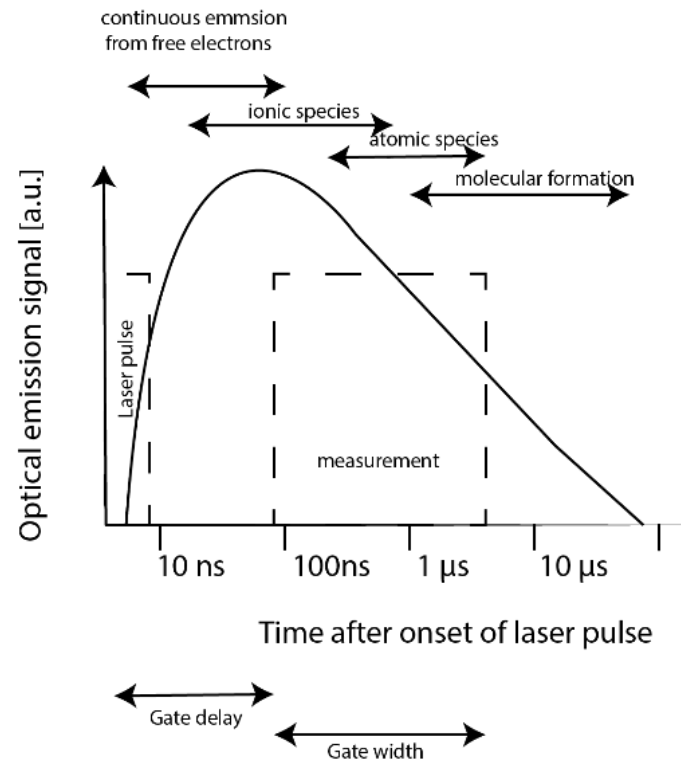
- **Laser pulse evaporates sample**
 - (same mechanism as PLD)
- **Plasma emits characteristic elemental emission → detected and quantified**



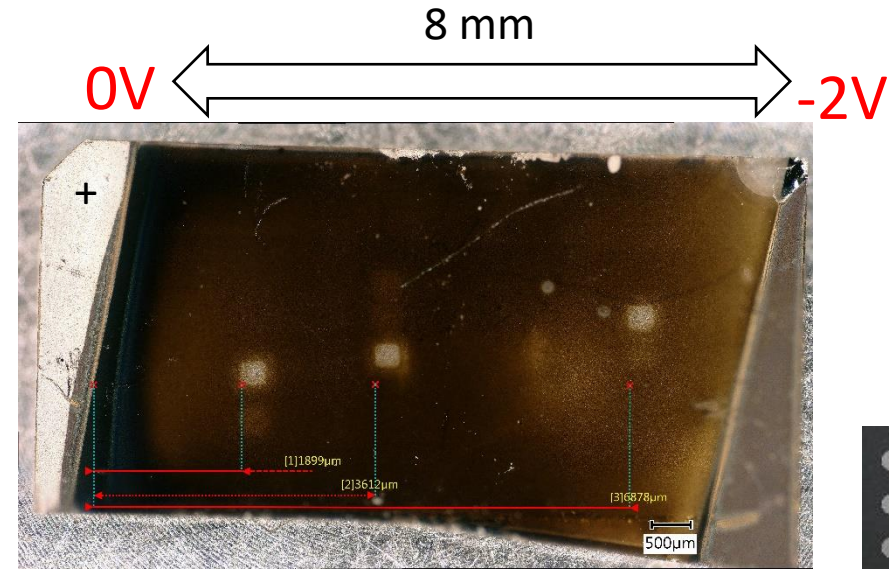
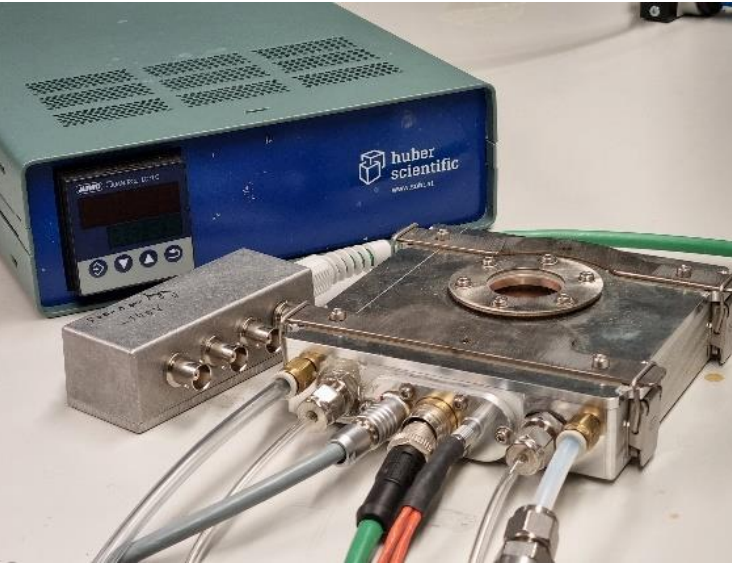
Melanie Anstiss
Tuesday 2A3 St. James
10.30
& Poster on Tuesday



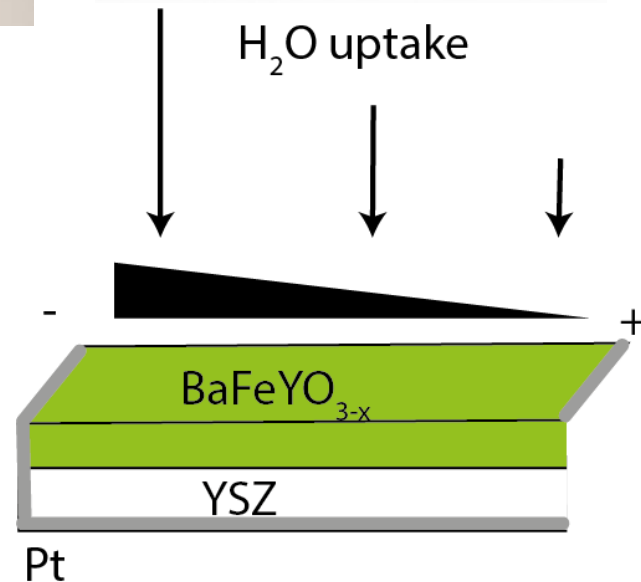
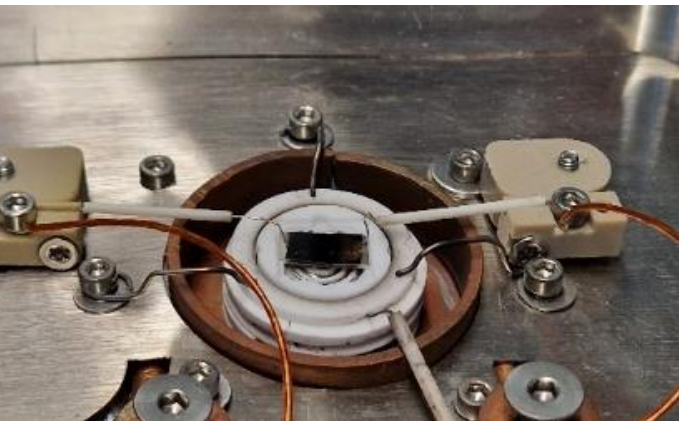
Maximilian Weiss
Poster on Tuesday



In situ LIBS measurements



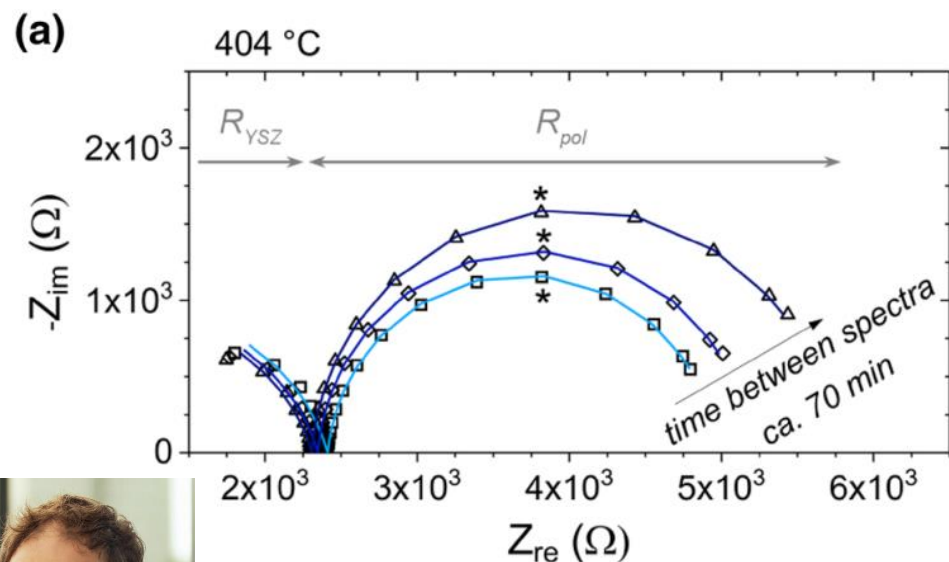
0V	-0.19V	-0.62V	-1.2V	-2V
Voltage drop (measured by microelectrodes)				
0.2	2E-06	2E-17	1E-32	1E-53 bar
Effective p(O ₂)				



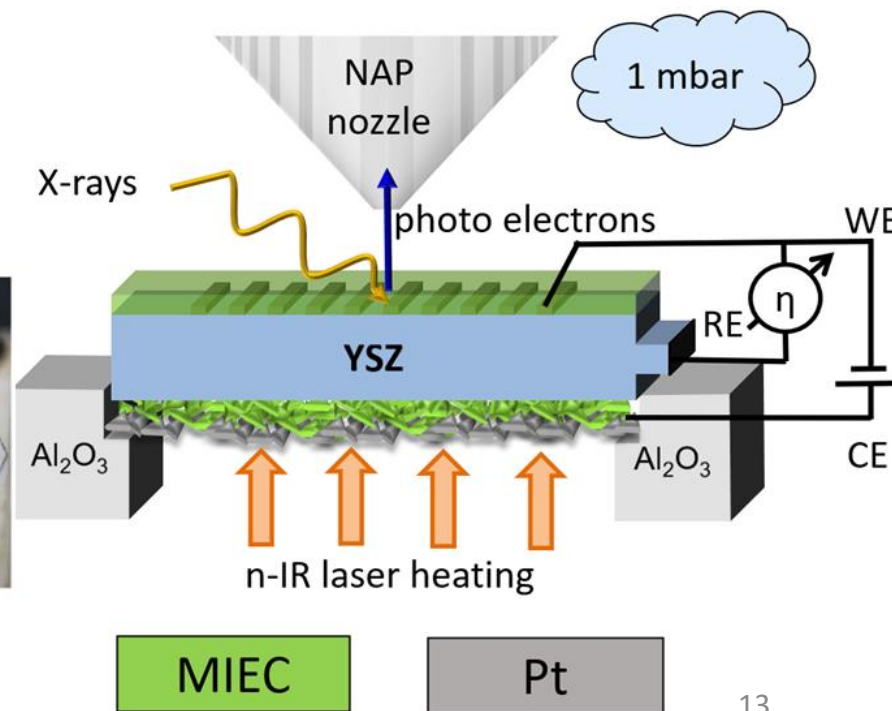
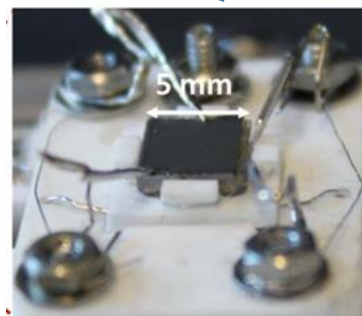
- Voltage / p(O₂) drop across sample
- Large p(O₂) range on just one sample
- Measure OH uptake laterally

NAP-XPS + EIS measurements

- Direct correlation of surface chemistry and activity
- Example: Sr segregation on $\text{La}_{0.6}\text{Sr}_{0.4}\text{CoO}_{3-\delta}$ (LSC) electrodes



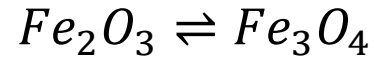
Andreas Nenning
Talk and poster on
Tuesday



ELECTROCHEMICAL OXYGEN ACTIVITY CONTROL (EXACT) AEM IN UHV

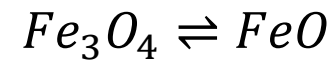
CE conditioning

goal: constant $\mu(\text{O})$ in CE
high CE capacity



1/3 e⁻ per Fe atom

-500 mV vs. air



2/3 e⁻ per Fe atom

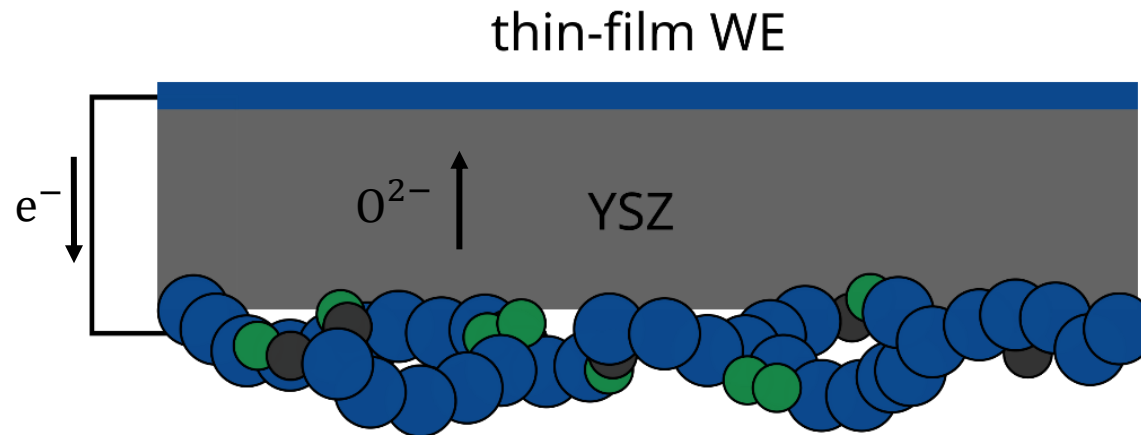
-890 mV vs. air



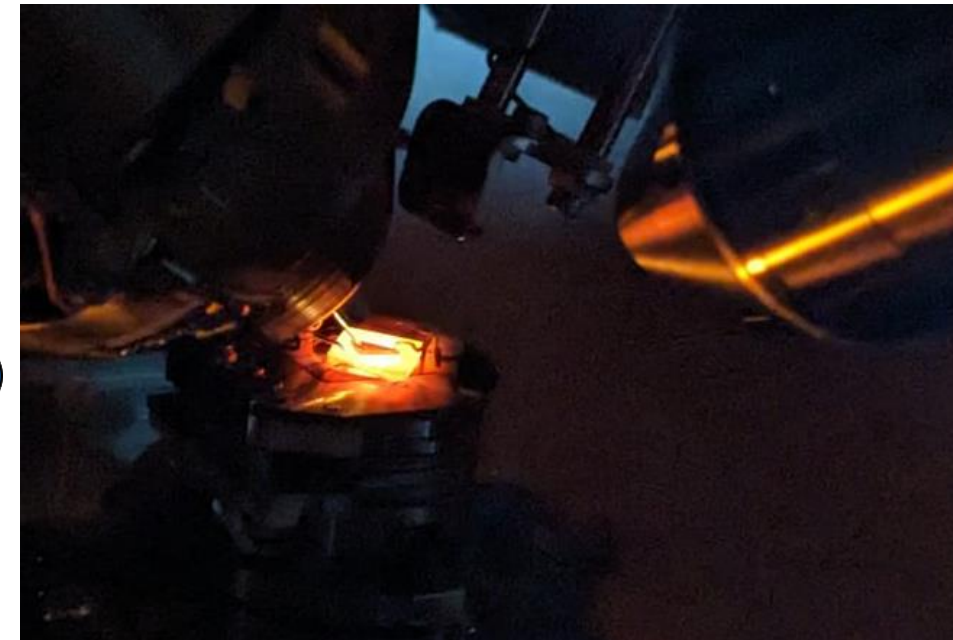
2 e⁻ per Fe atom

-1050 mV vs. air

- GDC10
- Fe₂O₃
- Fe₃O₄
- FeO
- Fe metal



$$a(\text{O}_2)_{CE} = e^{\left(\frac{2\Delta G_f(\text{FeO})}{RT}\right)}$$



T = 750 °C

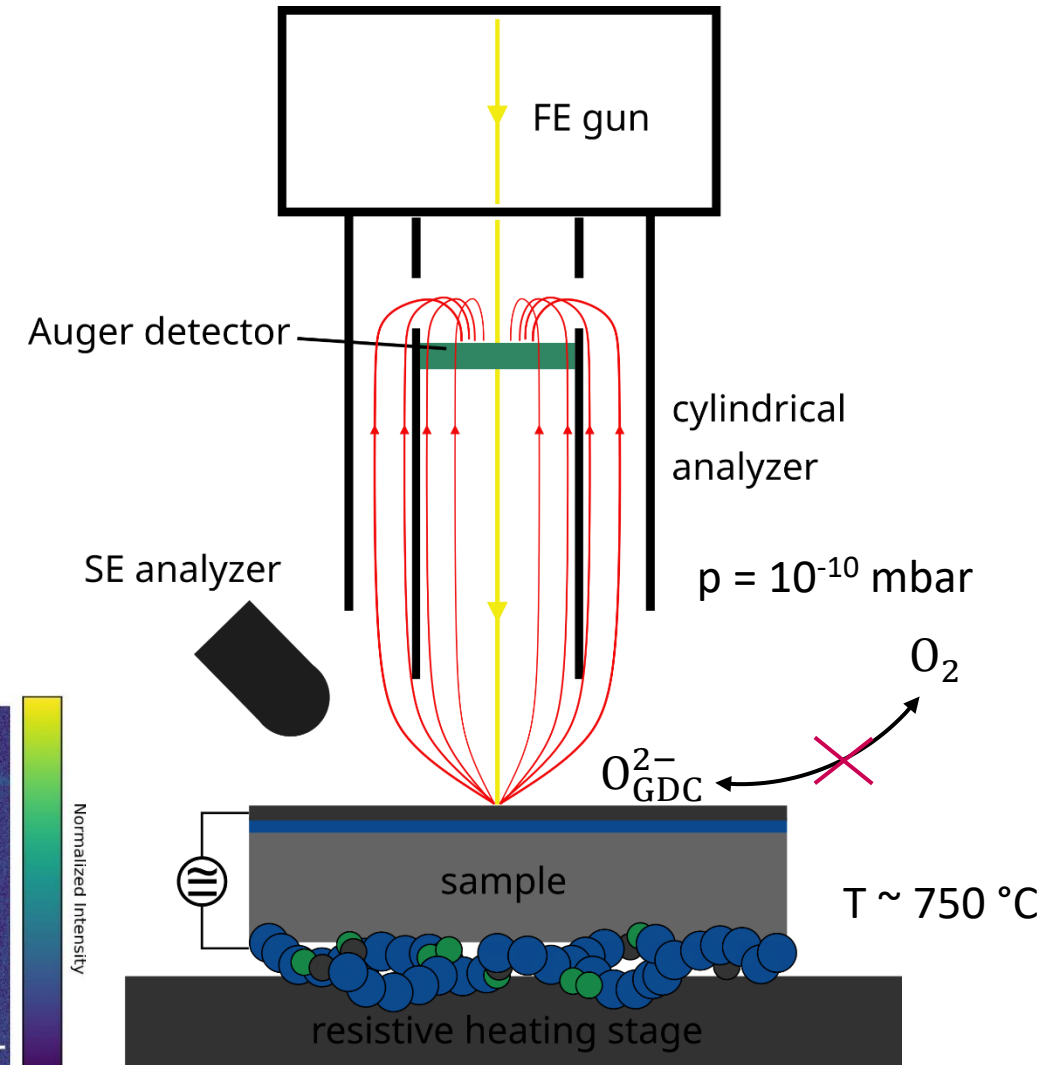
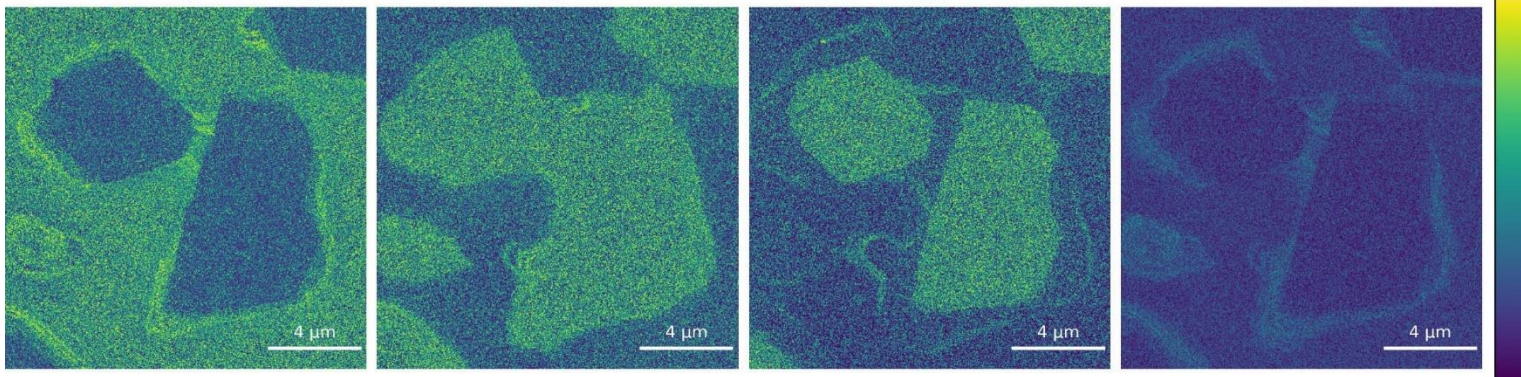
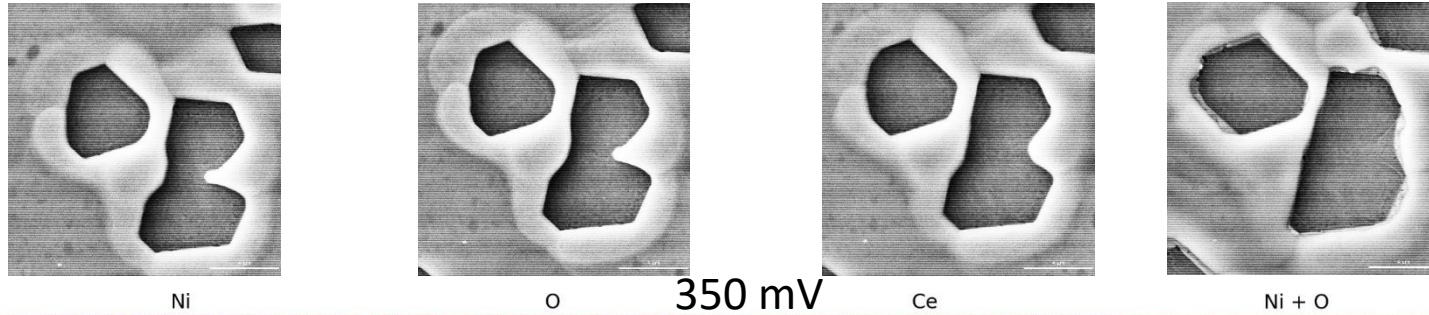
Christian Melcher

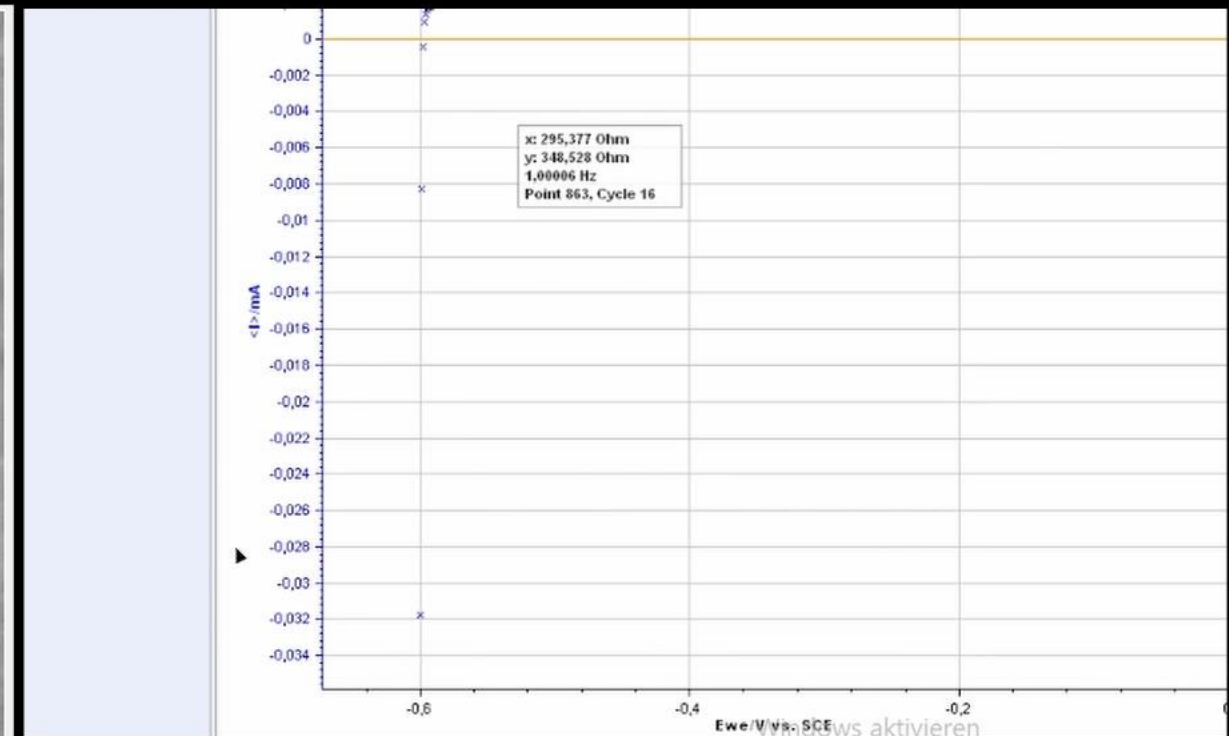
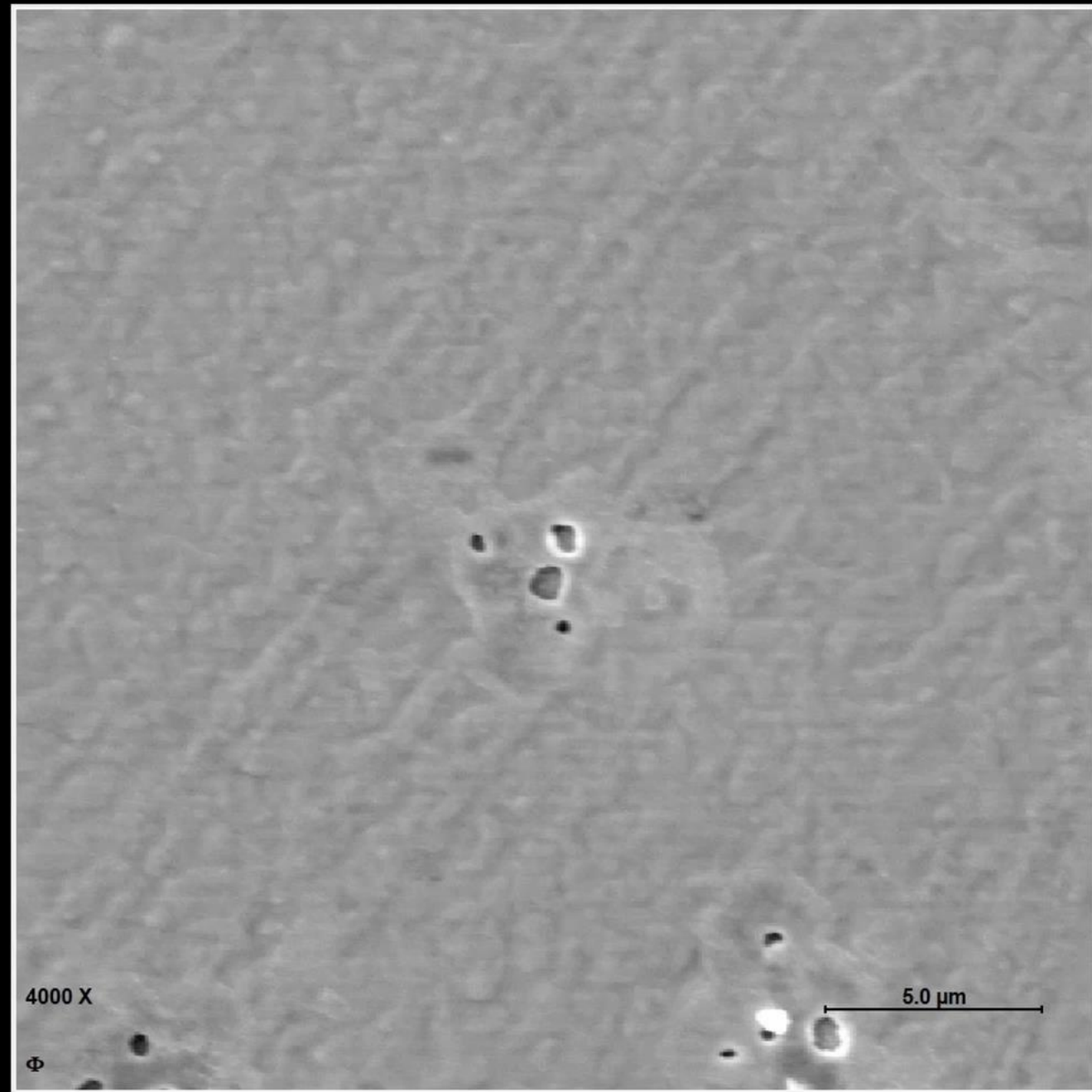
Monday 16:35, 5A4 Room: Moore

In situ Auger electron microscopy (AEM)

Ni thin film on GDC

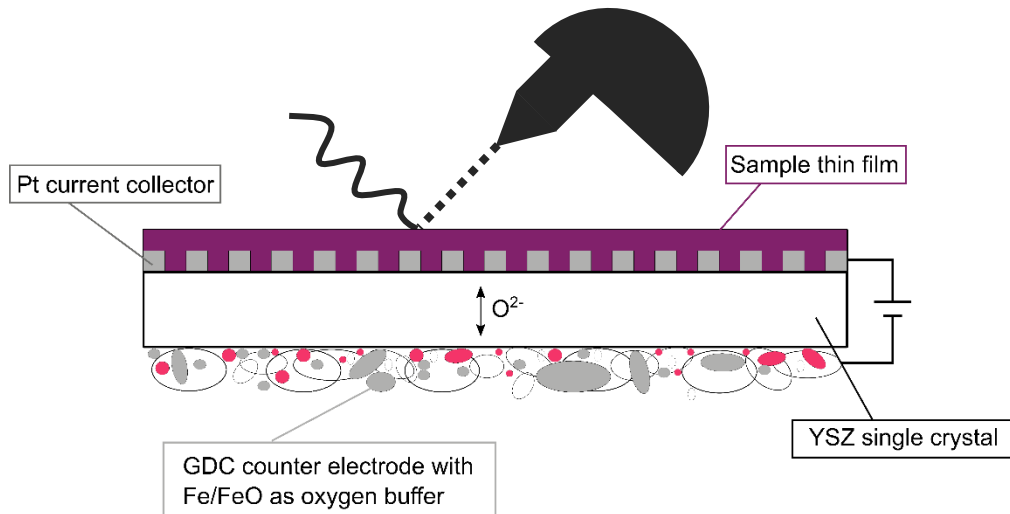
- SEM imaging
- spatially resolved surface spectroscopy
- elemental mapping
- UHV conditions required



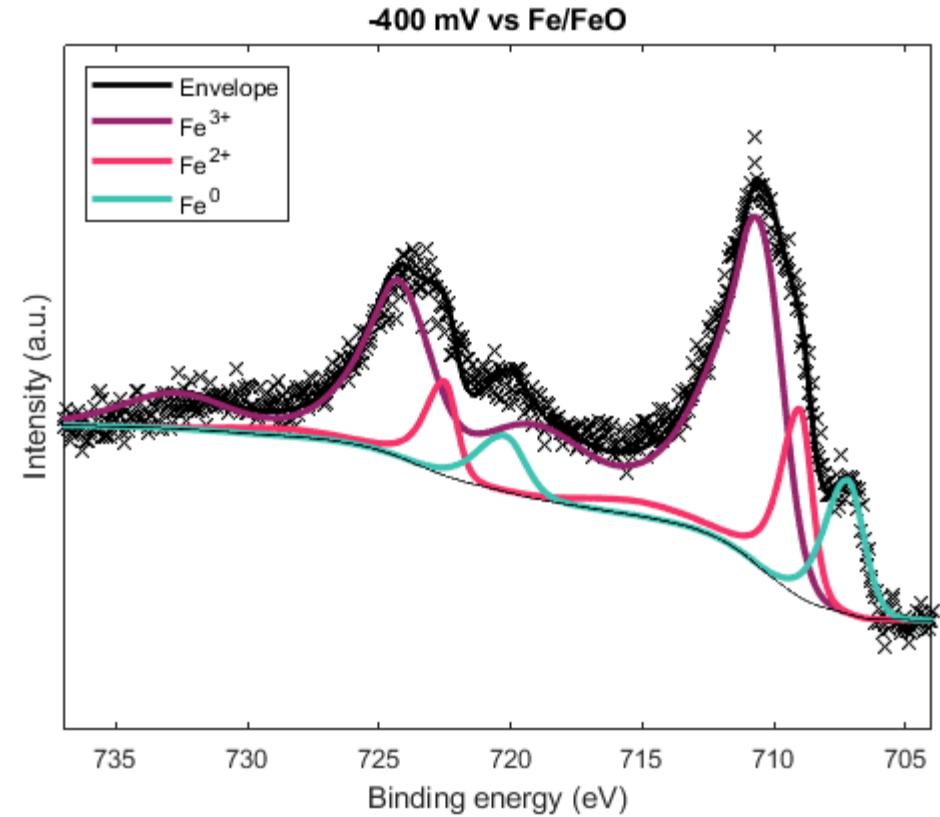


00:00:00:00

ELECTROCHEMICAL OXYGEN ACTIVITY CONTROL (EXACT) XPS



$$a(\text{O}_2)_{WE} = e^{\left(\frac{4F \cdot U + 2\Delta_f G^0(\text{FeO})}{RT}\right)}$$



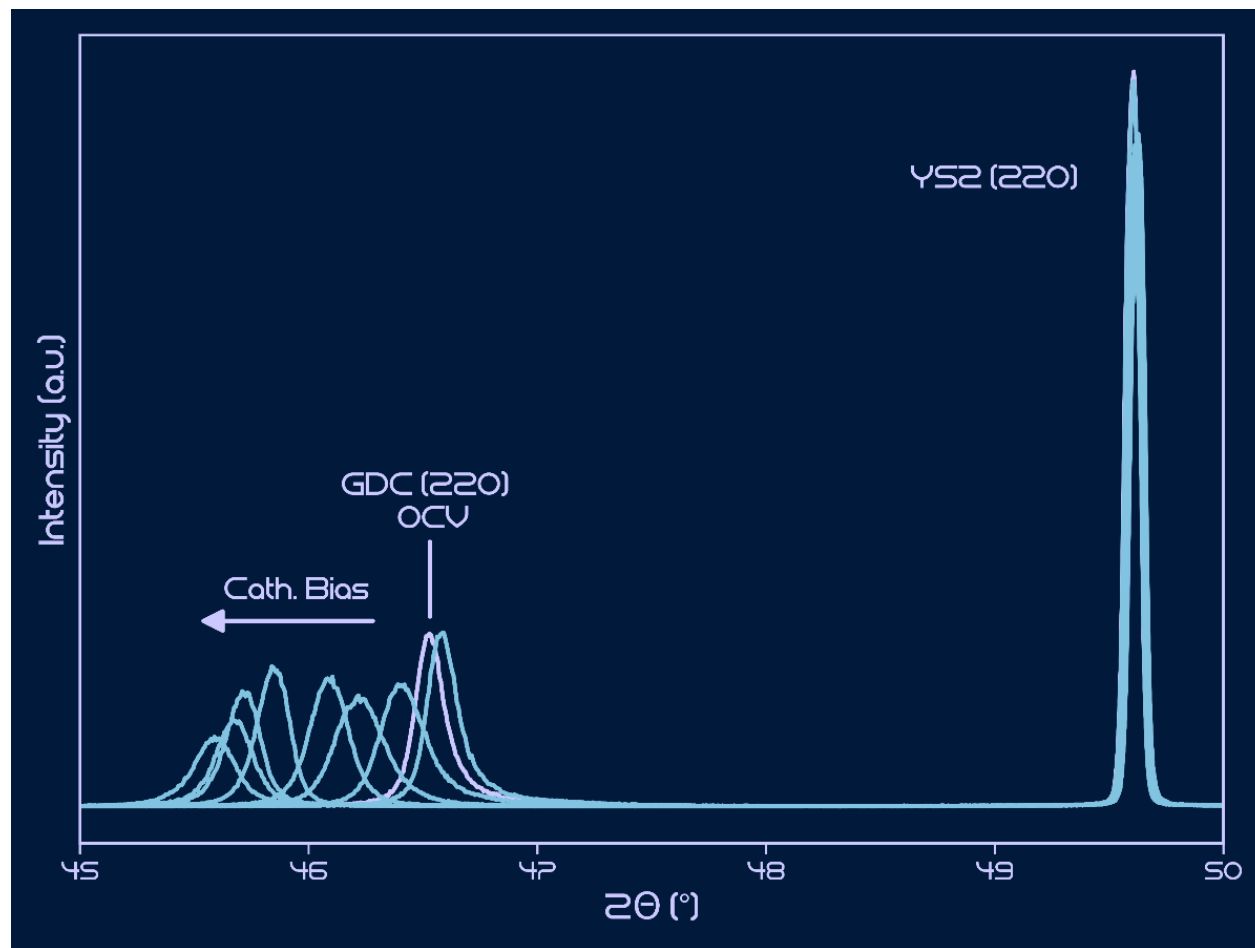
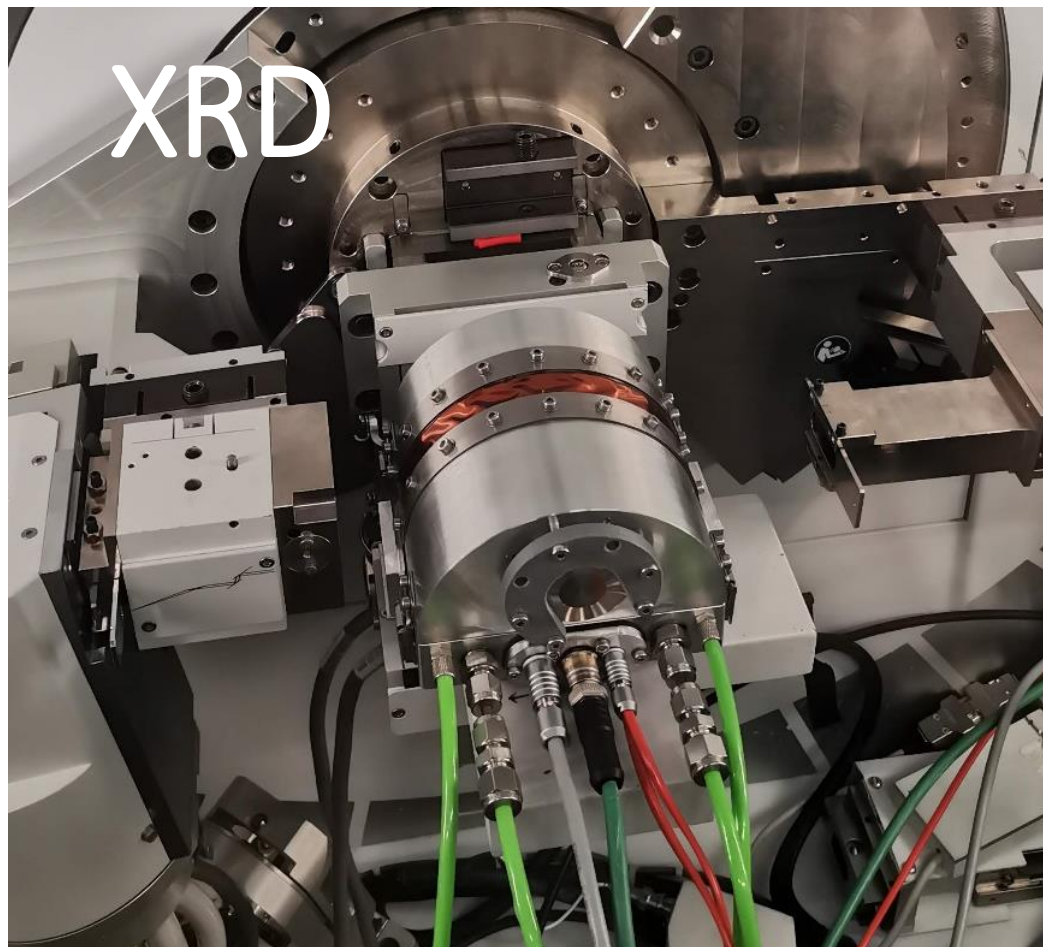
600 °C, UHV



Stanislaus Breitwieser
Talk on Monday



Andreas Nenning
Talk and poster on
Tuesday



Kirsten Rath

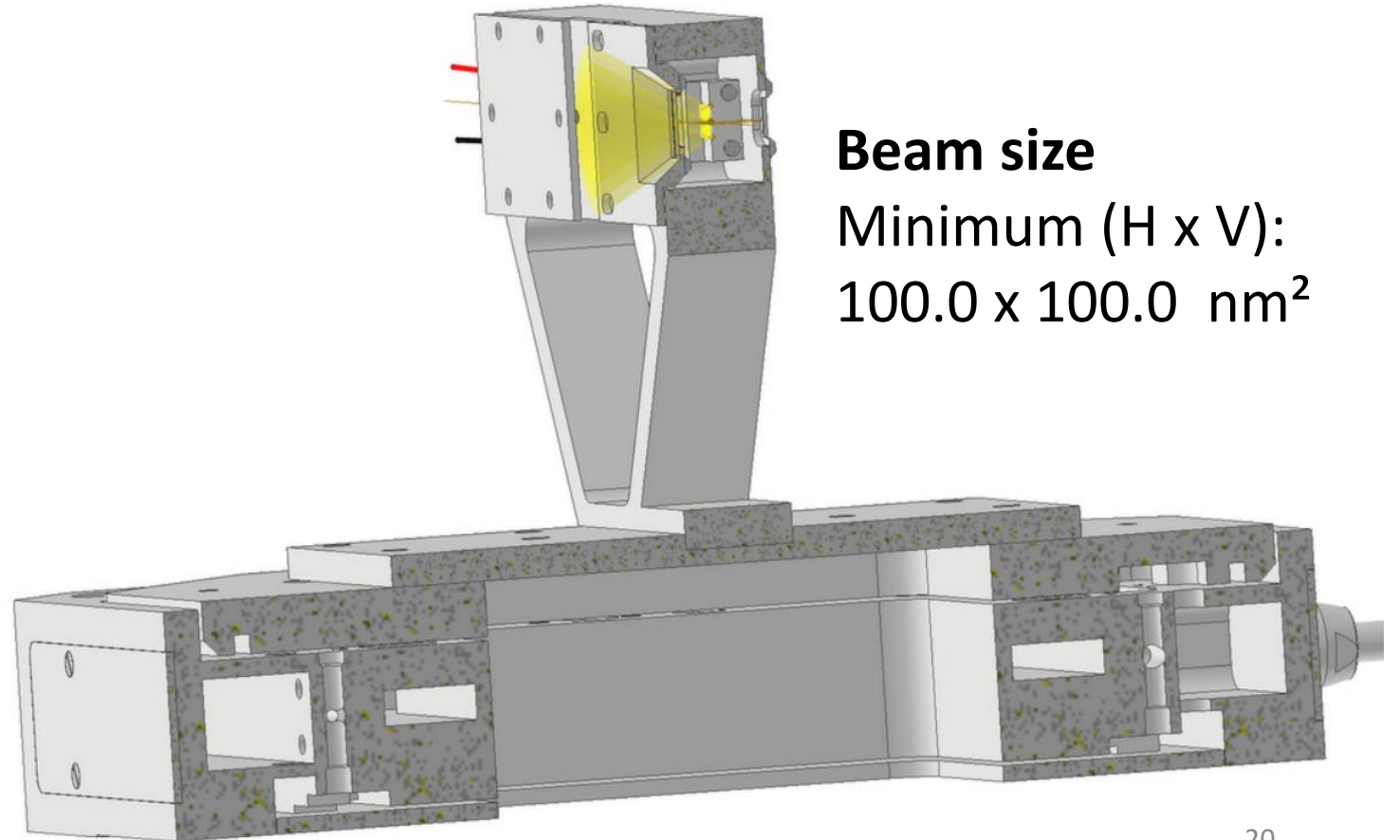
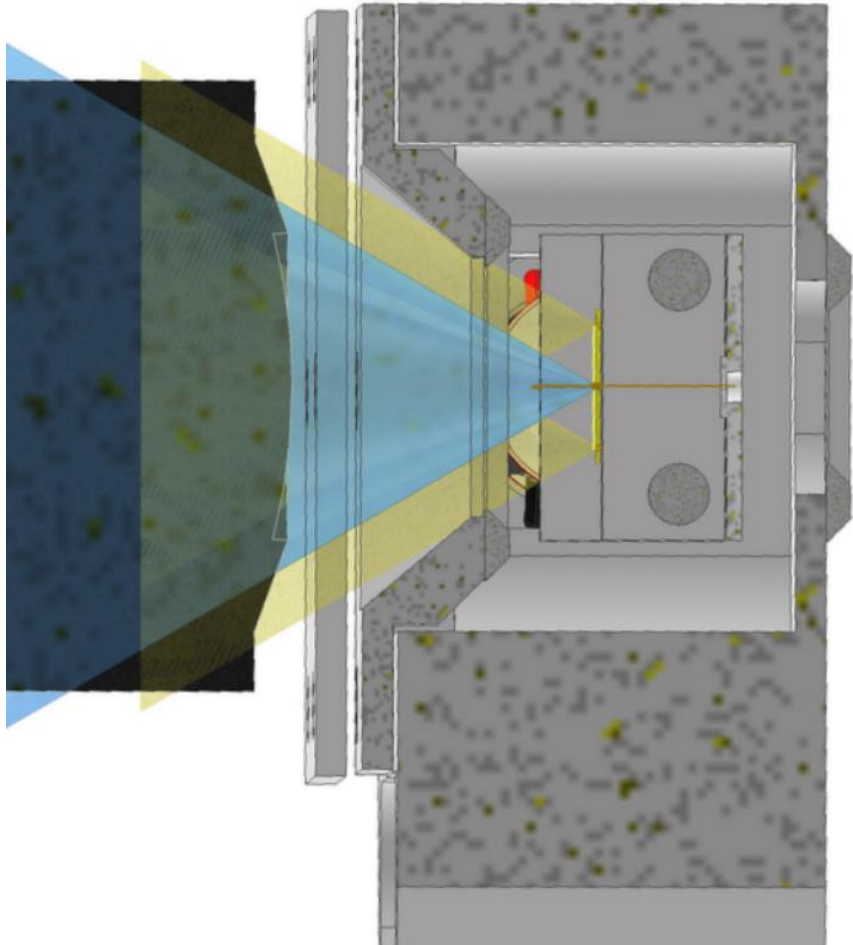
Talk on Monday 3A4 Moore 12:05

GDC thin film on YSZ

- Compression with anodic bias
 - Expansion with cathodic bias
- YSZ reflex does not shift!

Solid-State Lithium-Ion battery

ESRF ID13 Microfocus BL



Beam size
Minimum (H x V):
100.0 x 100.0 nm²

How to start an in situ project

a) heating

f) sample transfer

b) electrical measurements

e) gasses

g) sensor at the sample

d) polarization

c) cooling

Material incomparability

UHV chambers → in situ chambers
UHV heaters contain molybdenum

Formula	Melting point [°C]
Mo	2623 ⁽¹⁾
MoO ₂	1100 (decomposition) ⁽¹⁾
MoO ₃	801 ⁽¹⁾



high vapor pressure!
sublimates noticeably at 700 °C

(1) www.webelements.com/compounds/molybdenum/molybdenum_dioxide.html

IAP / Tools / Vapor Pressure Calculator

Substance	Mo	▼
Temperature	1173.2	K
	900	°C
Vapor Pressure	3.48e-22	bar ▼
MORE...		
Gas Density	2.15e+3	per m ³ *
Evaporation/Subl. Rate	2.7e5	per (m ² s) **
Erosion	4.3e-24	m/s **
Melting Temperature	2890	K
Vapor pressure at Melting P.	4.32e-5	bar



From: Michael Schmid,
www.tuwien.at/en/phy/iap/tools/vapor-pressure-calculator

Structural materials for in situ heater



- Preferable: high temperature oxides
 - e.g. Alumina, Zirconia, Sapphire, Quartz glass,...
- Metals, Ni-based alloys
- Water cooled parts
 - Non high temperature materials possible
 - **BUT anticipate a cooling failure!**



Nickel tetracarbonyl & Iron pentacarbonyl

- CO & Ni
- CO & Fe

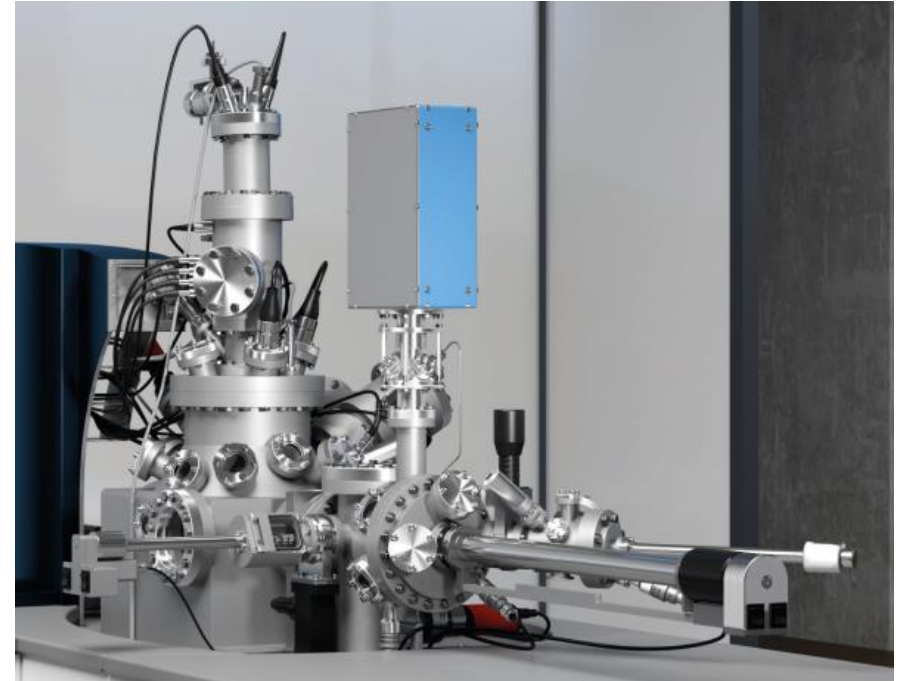
(e.g. stainless steel)

GHS labelling:	
Pictograms	
Hazard statements	H225, H300, H301, H304, H310, H330, H351, H360D, H410
Precautionary statements	P201, P202, P210, P233, P240, P241, P242, P243, P260, P271, P273, P280, P281, P284, P303+P361+P353, P304+P340, P308+P313, P310, P320, P370+P378, P391, P403+P233, P403+P235, P405, P501
NFPA 704 (fire diamond)	

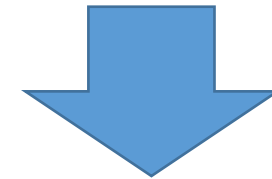
Flash point	4 °C (39 °F; 277 K)
Autoignition temperature	60 °C (140 °F; 333 K)
Explosive limits	2–34%
Lethal dose or concentration (LD, LC):	
LC ₅₀ (median concentration)	266 ppm (cat, 30 min) 35 ppm (rabbit, 30 min) 94 ppm (mouse, 30 min) 10 ppm (mouse, 10 min) ^[3]
LC _{Lo} (lowest published)	360 ppm (dog, 90 min) 30 ppm (human, 30 min) 42 ppm (rabbit, 30 min) 7 ppm (mouse, 30 min) ^[3]

Plastic components

- Not hydroscopic:
 - PEEK
 - Polyethylene
 - Polypropylene
 - PTFE (Teflon) **Max temperature 170°C !**
 - PVC
 - Polyimide (Kapton)



Using scroll vacuum pump
with Teflon tip seal



Fluorine poisoned surface

Contacts and electrodes

- Platinum
 - Platinum Iridium alloys (better mechanical properties & harder)
 - Platinum Rhodium alloys (higher temperature stability)
- Tungsten, Tungsten Carbide
- Gold (very soft/ for sealing)
- Silver

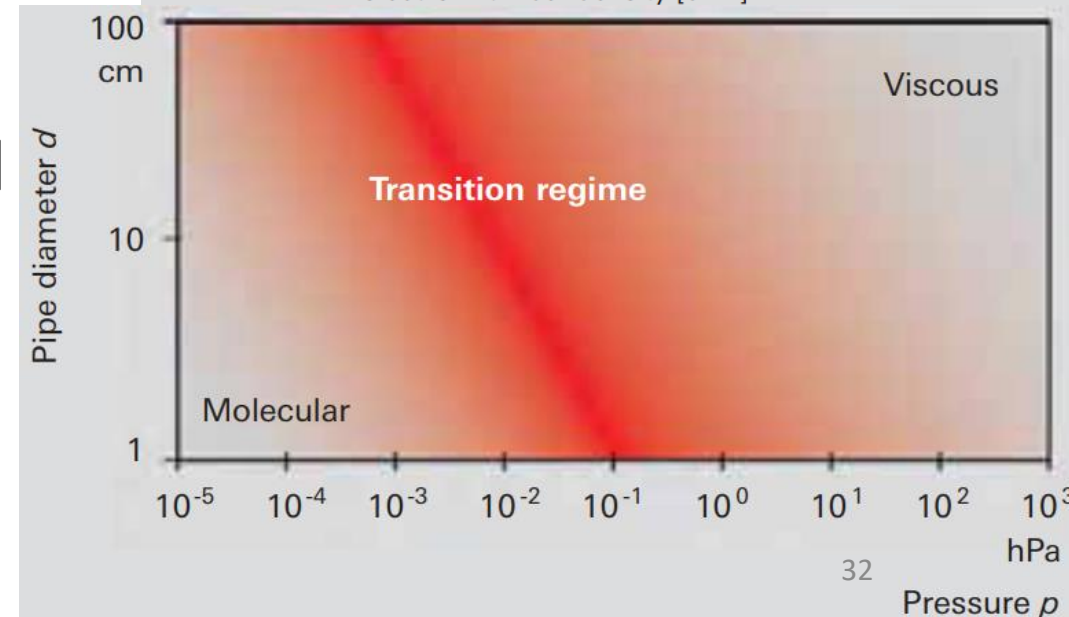
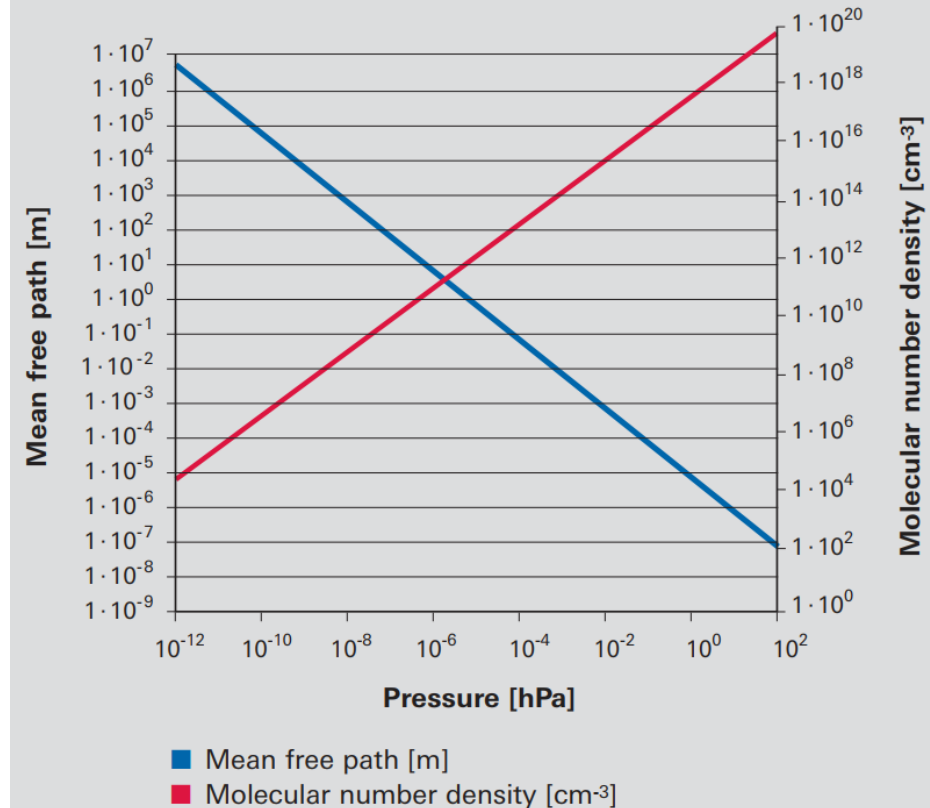


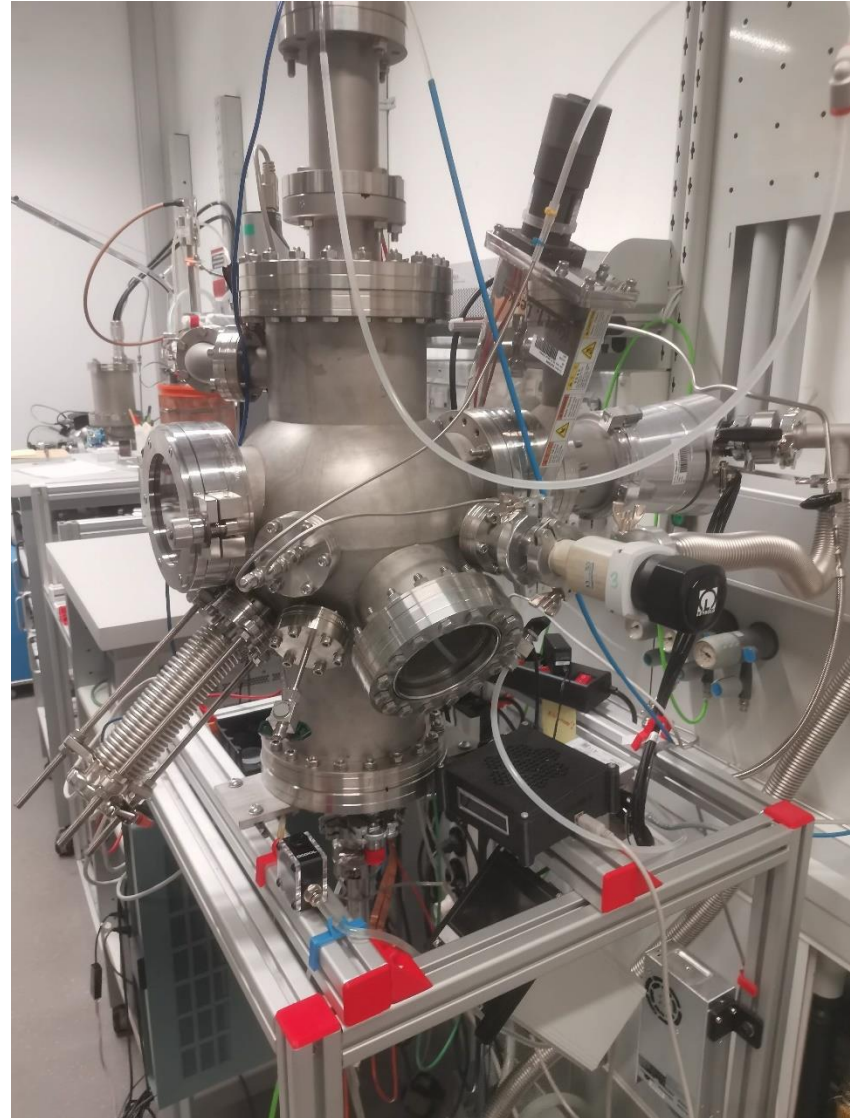
Substance	Ag	▼
Temperature	973.15	K
	700	°C
Vapor Pressure	2.37e-9	bar ▼

From: Michael Schmid, www.tuwien.at/en/phy/iap/tools/vapor-pressure-calculator

In situ / ex situ Clean surface necessary?

- In situ in same chamber/ transport?
- Mean free path at pressure regime?
- Temperature of components
 - **Radiation**
 - Parts in line of sight?
 - **Convection**
 - Mean free path at pressure regime?
 - Cooling effects!
 - **Conduction**
 - Cooling effects!
 - Sensitive parts connected?
- Simple leak test
 - Linear → **leak**
 - Asymptotical → **outgassing**

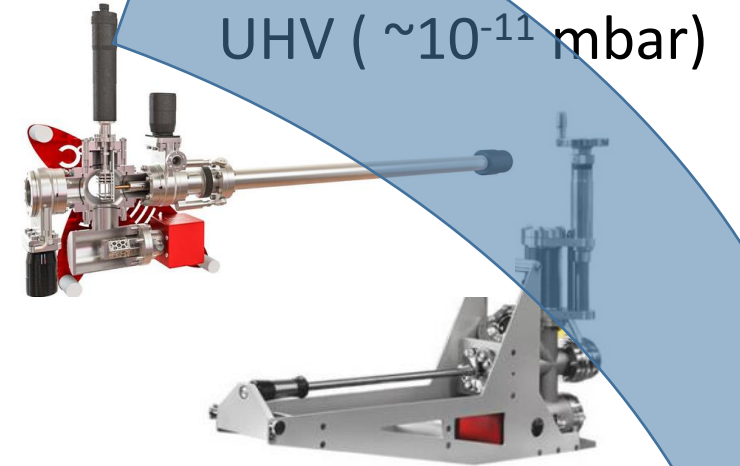
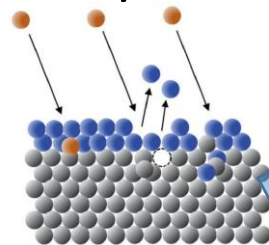




Transport

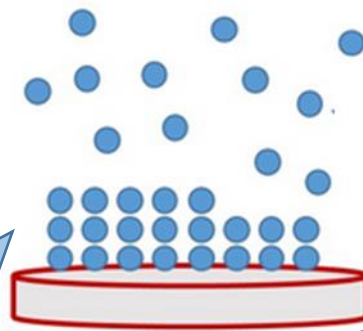
- Which contaminants are a problem?
 - **Not from transport:** chromium, fluorine, silicon, heavy metals, ...
 - **From transport:** carbon, sulphur, water, CO₂, acidic gases, ...
- **Cooling/heating:** cation diffusion, phase segregation, ...
- **Surface cleaning:** changing the surface

In air +
plasma/ ion cleaning



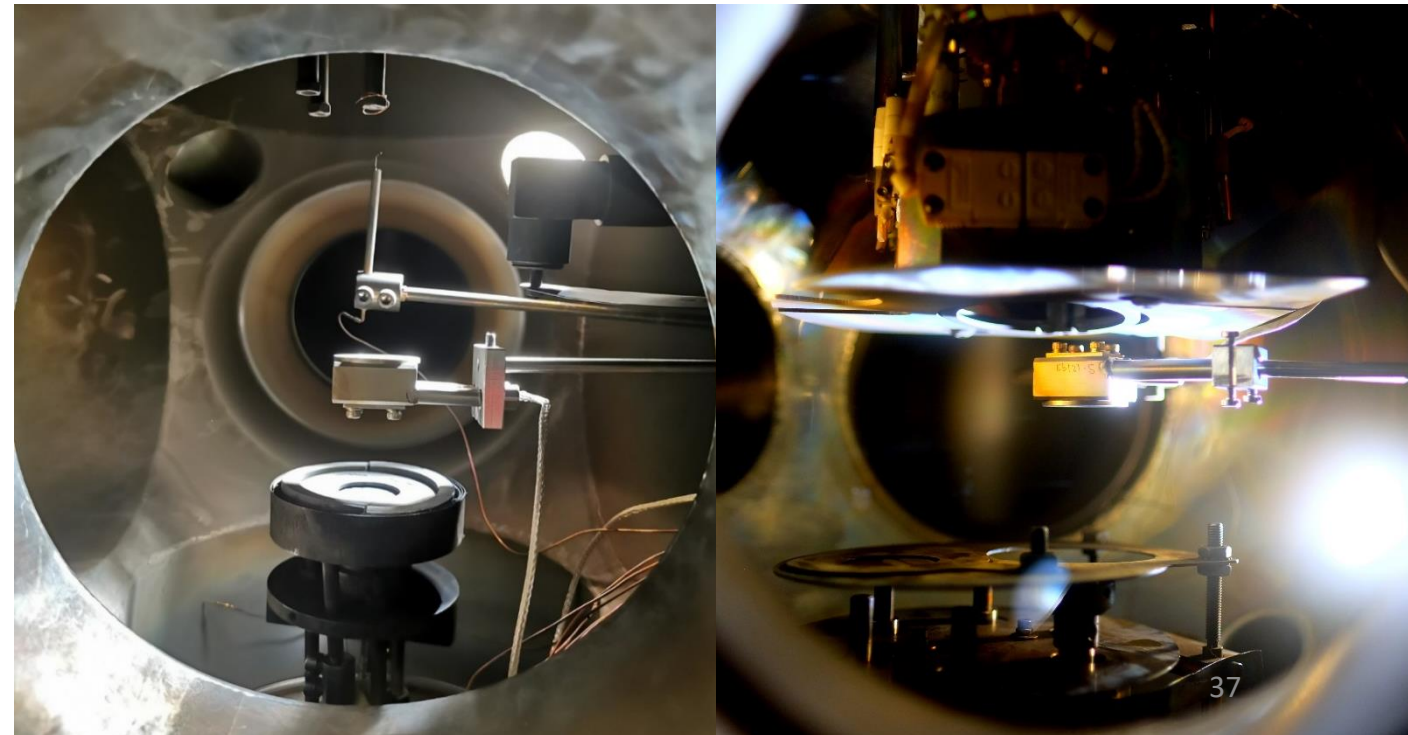
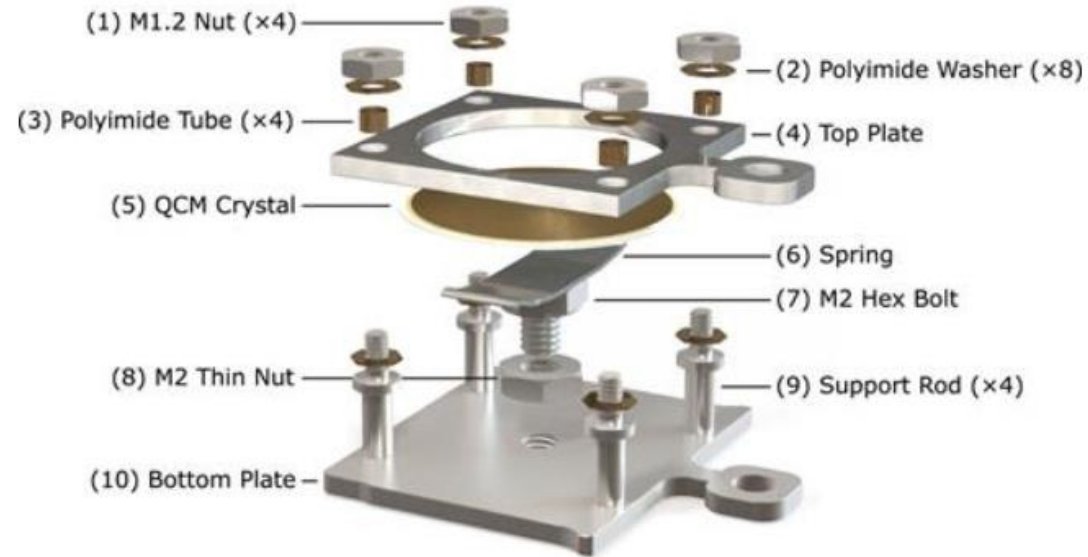
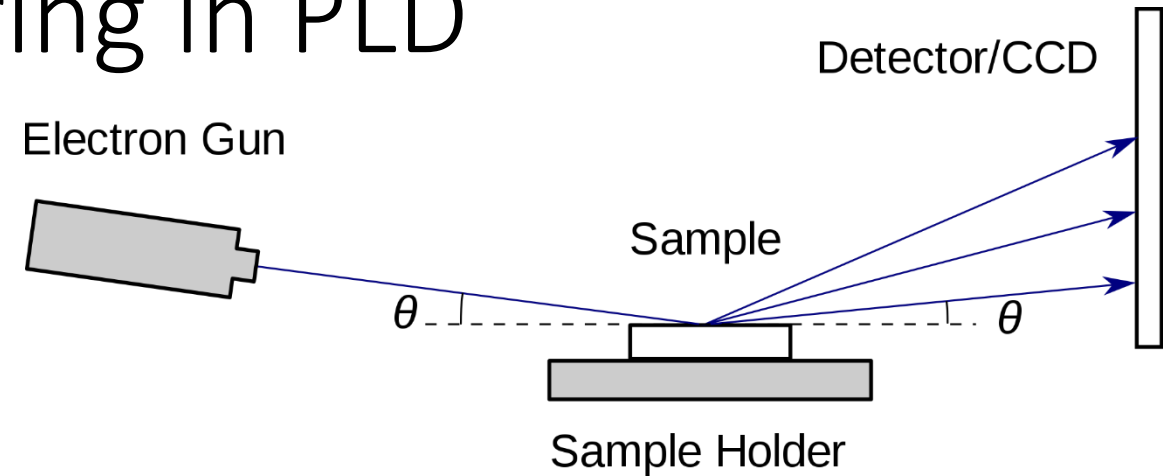
Inert gas/ low vacuum

in air + heating



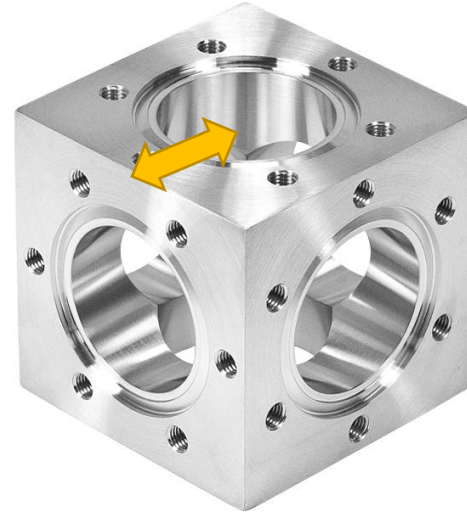
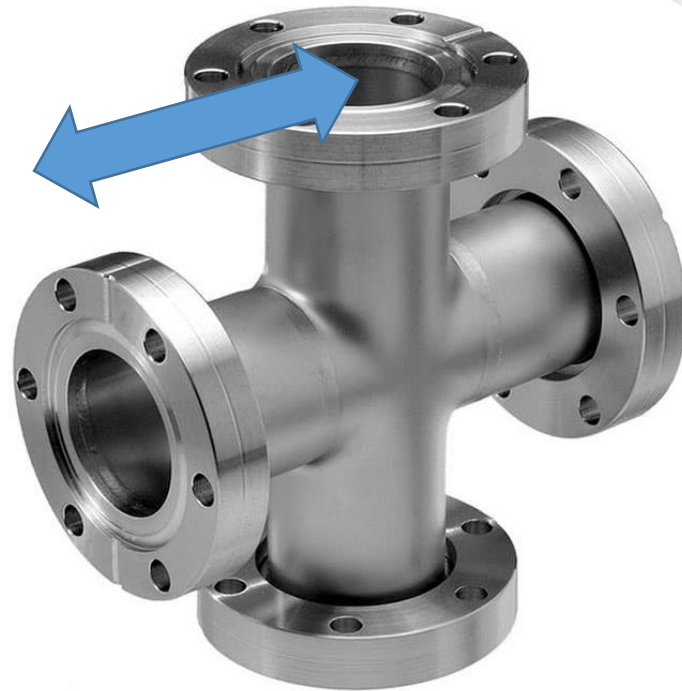
In situ thickness monitoring in PLD

- Rheed
- Quartz micro balance



Important (small) points/problems

Transfer, chamber shape etc.

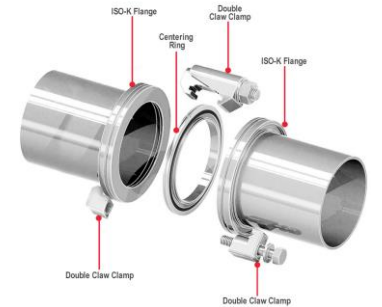


< $1 \cdot 10^{-7}$ mbar?

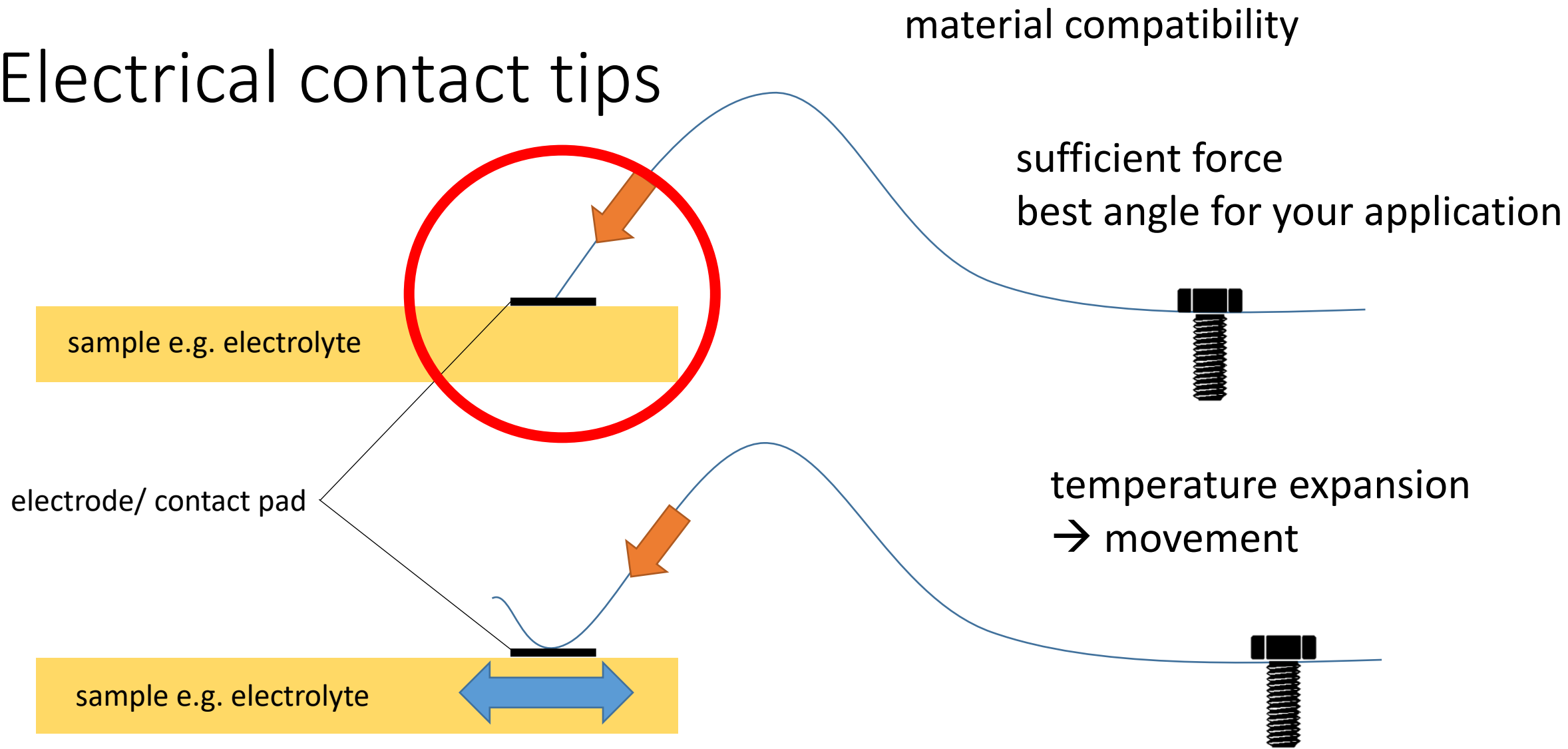


Pressure range?

Don't shoot sparrows with cannons!

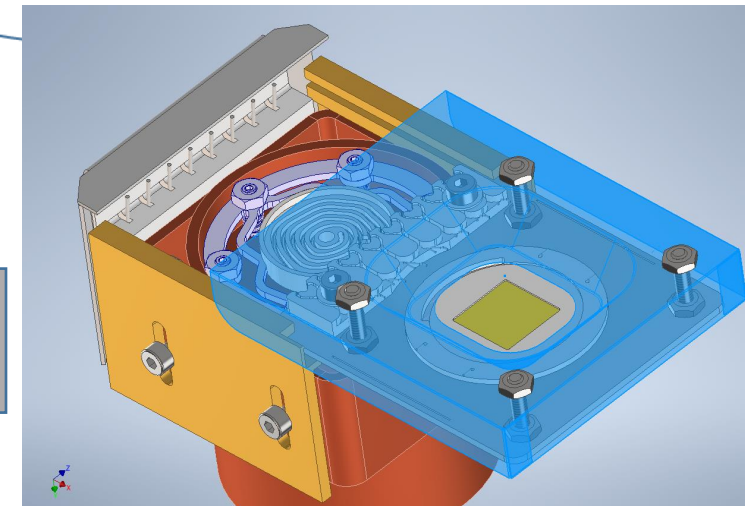
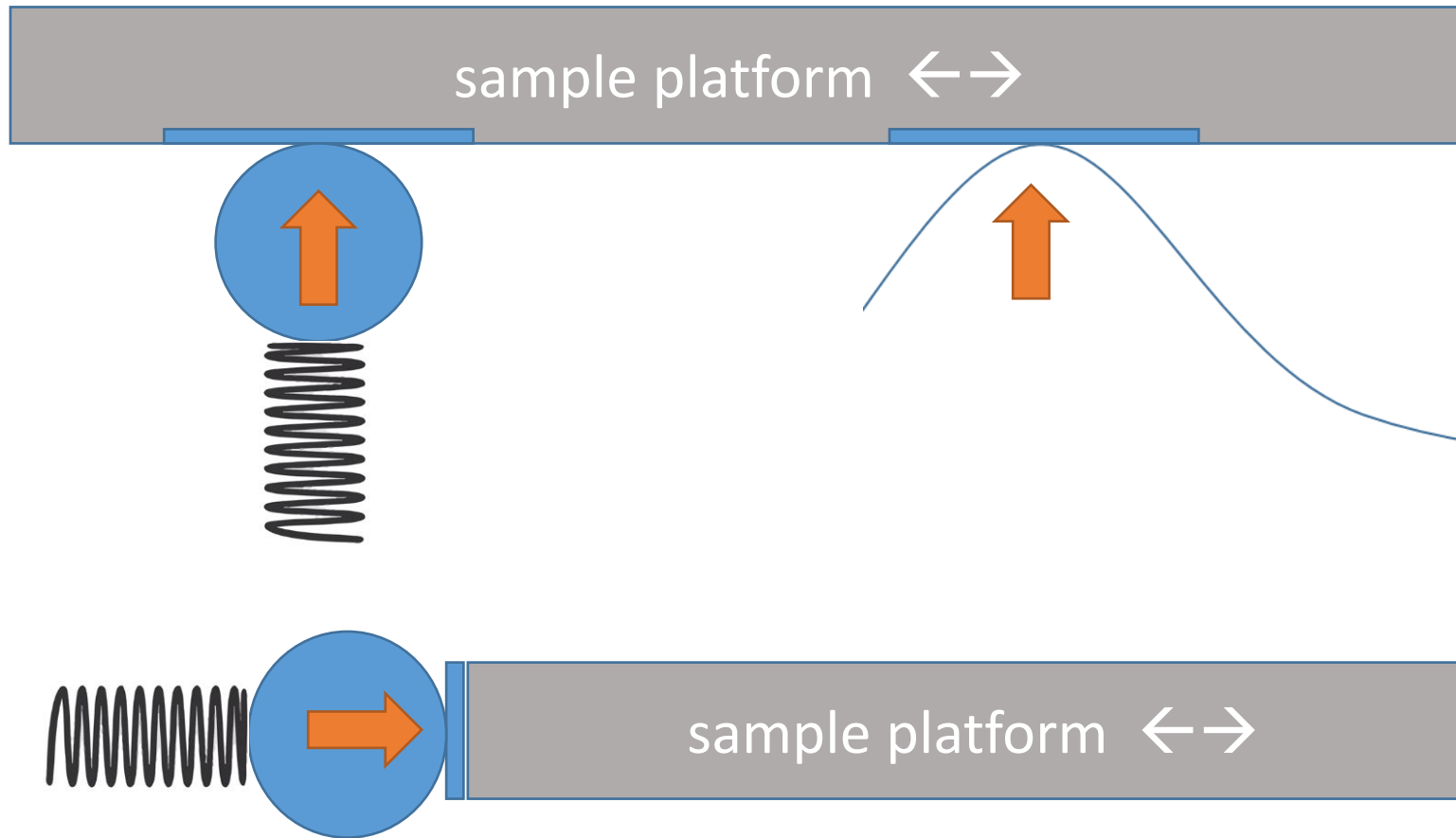


Electrical contact tips



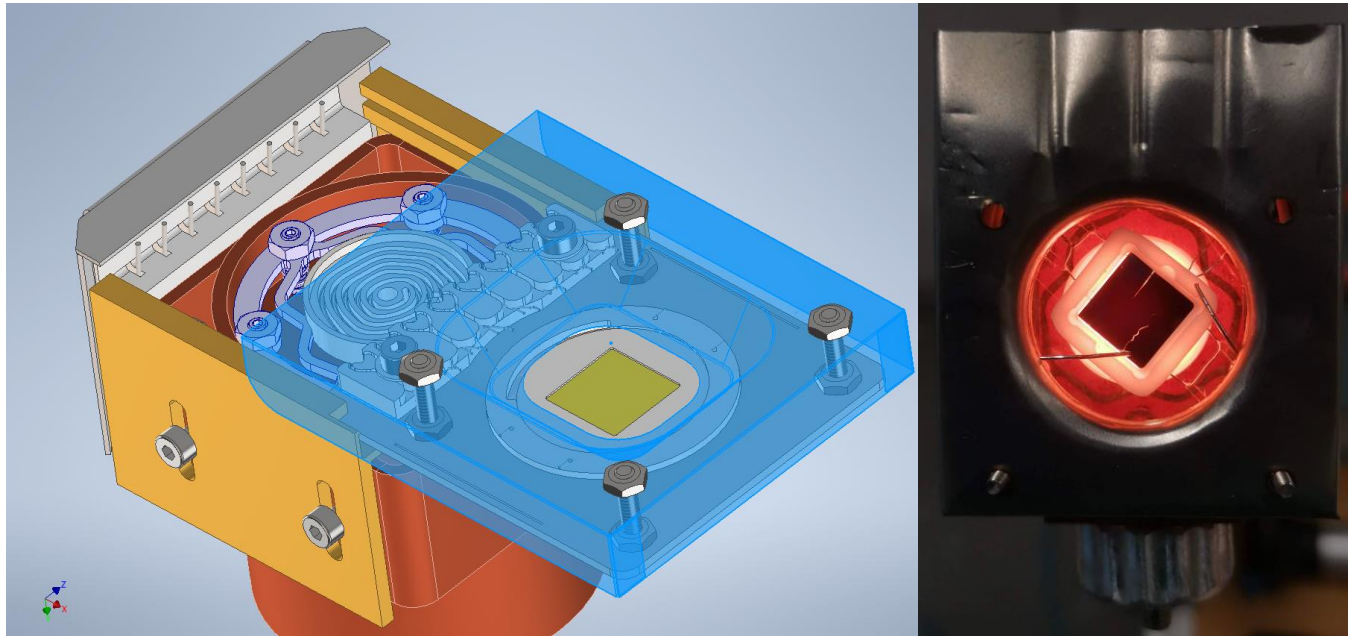
Spring loaded sliding contacts

Corrosion issues!
Use TC type S

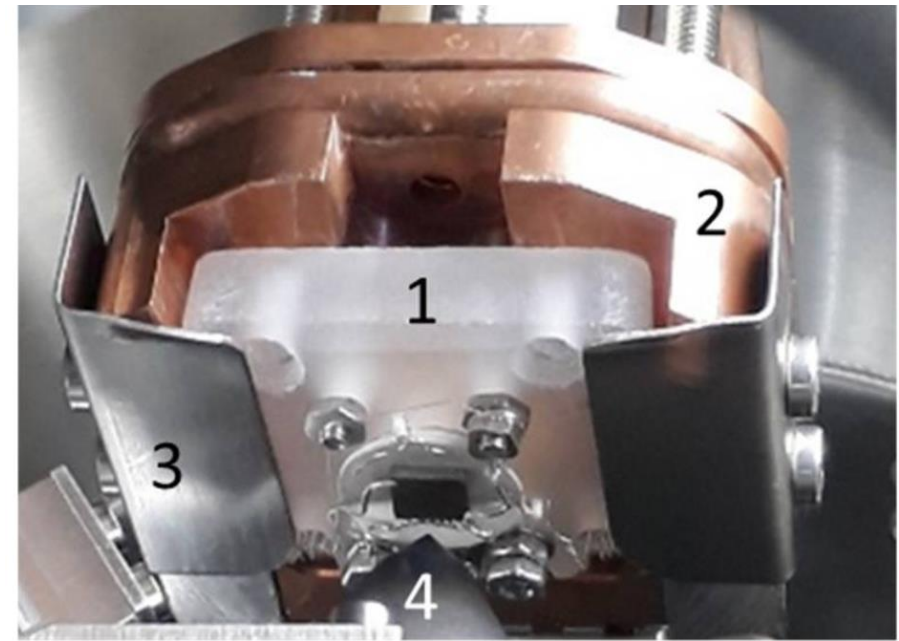


Sample platforms

PVD systems (HV)



NAP-XPS (UHV)



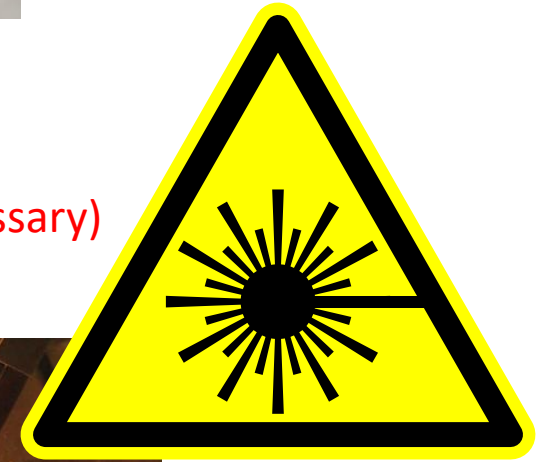
Heating

- **conduction, convection and radiation**
- **1000 → 10 mbar (laminar flow)**
- **10e⁻⁴ mbar thermal conductivity of the gas low**
 - Radiation → line of sight, distance
 - Convection → gas pressure & gravity
 - Heat conduction → material properties



resistive

Small is beautiful
(only heat what's necessary)



laser

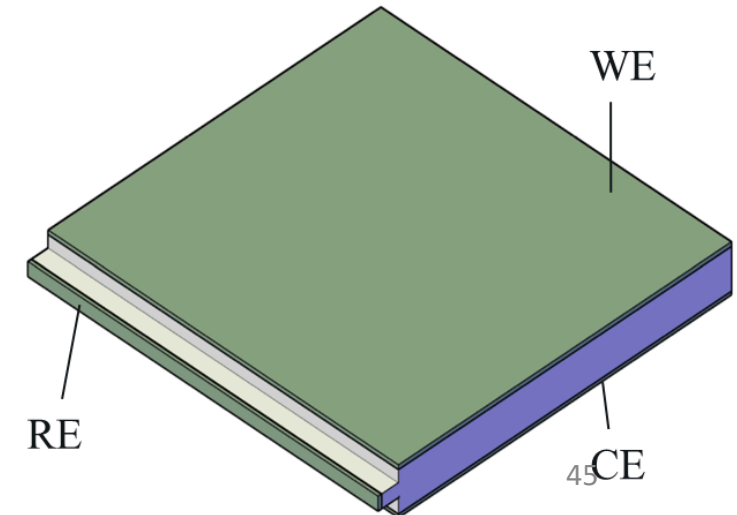
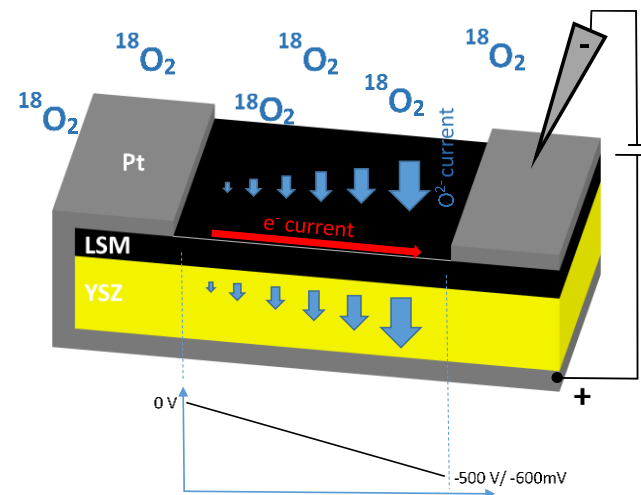
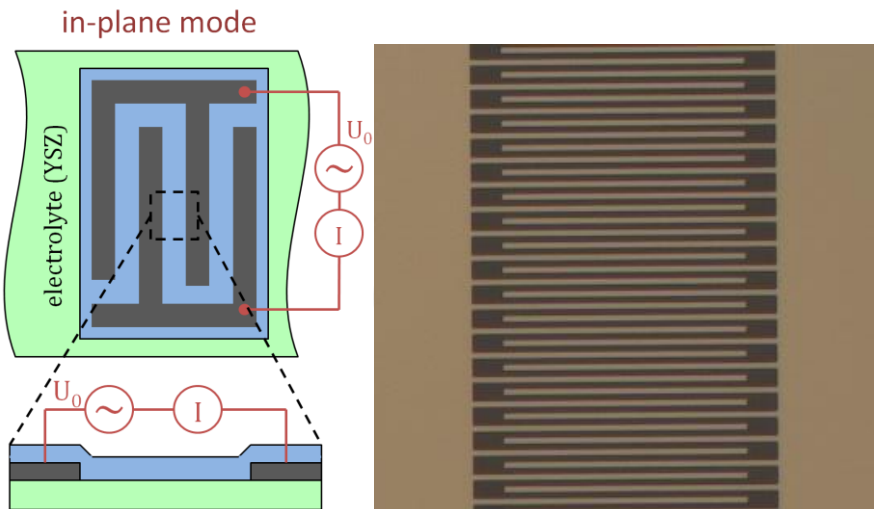
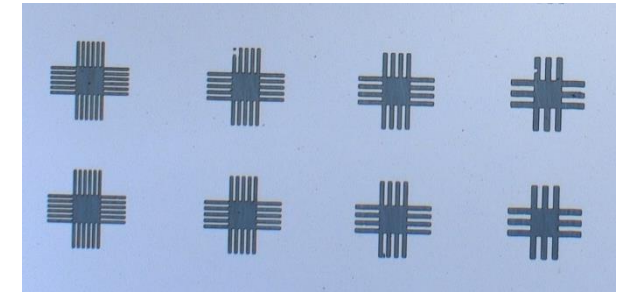
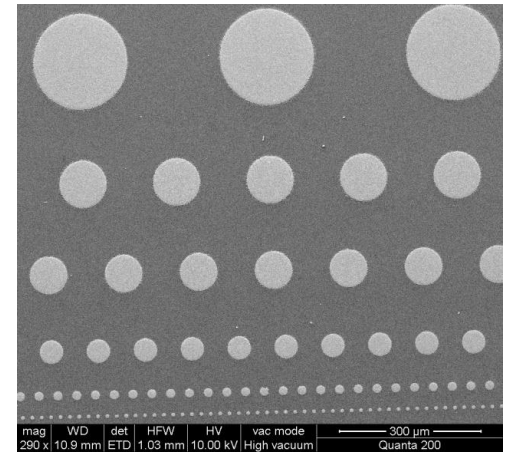


radiation

Electrode shapes & electrical measurements

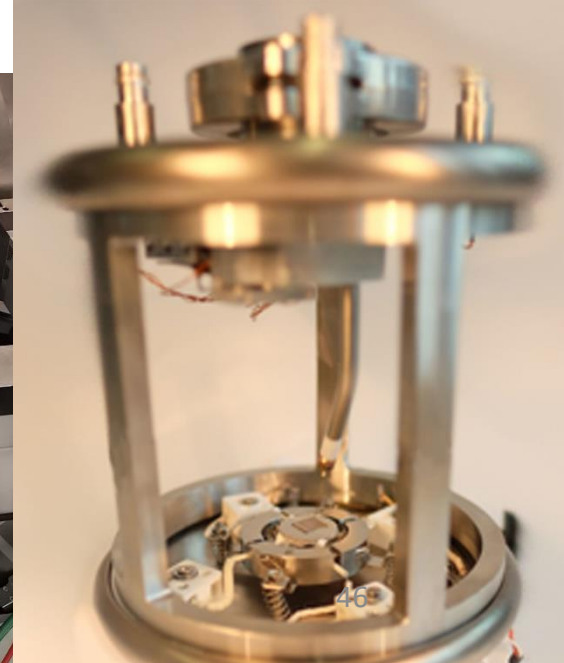
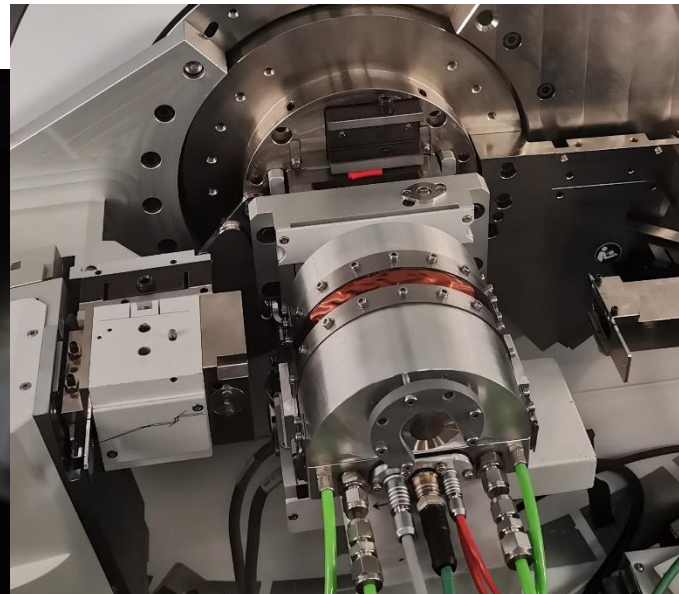
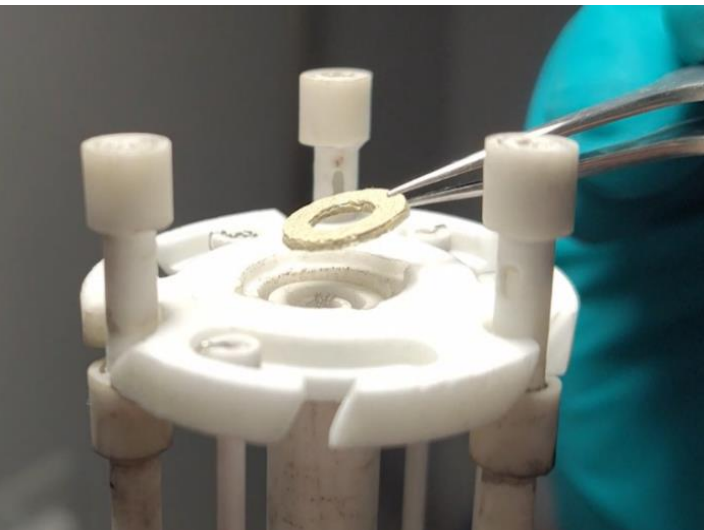
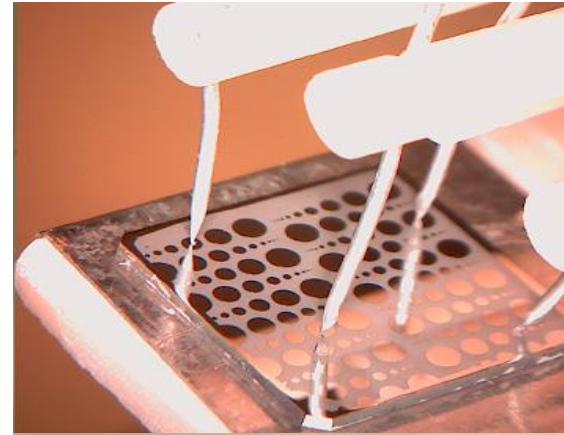
Electrical measurements

- Symmetric cell
- Asymmetric cell
 - Large difference in R and C of WE & CE
 - Microelectrode
 - Reference electrode
- Special geometries

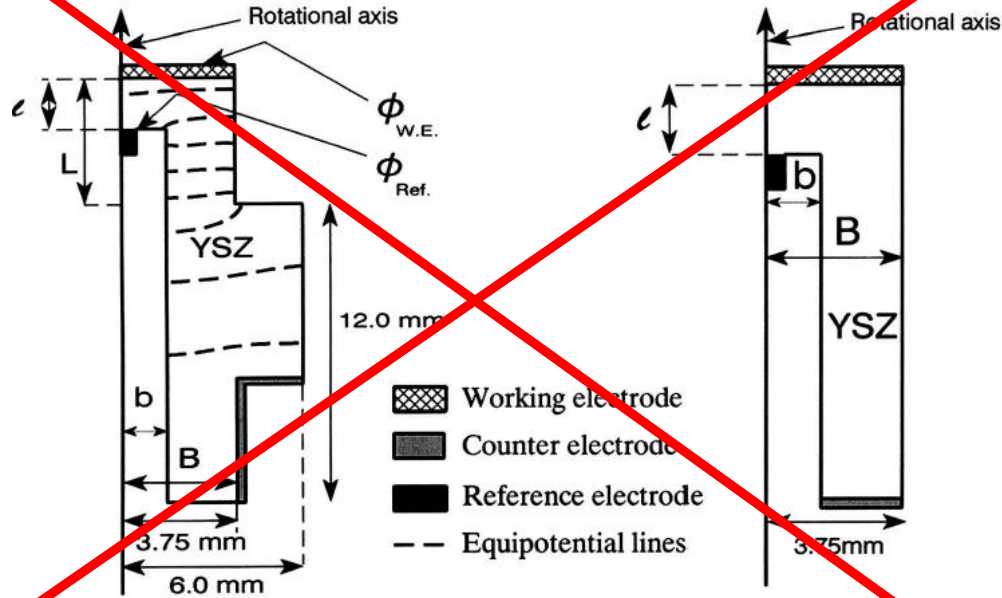


Advantages of micro patterned thin film electrodes

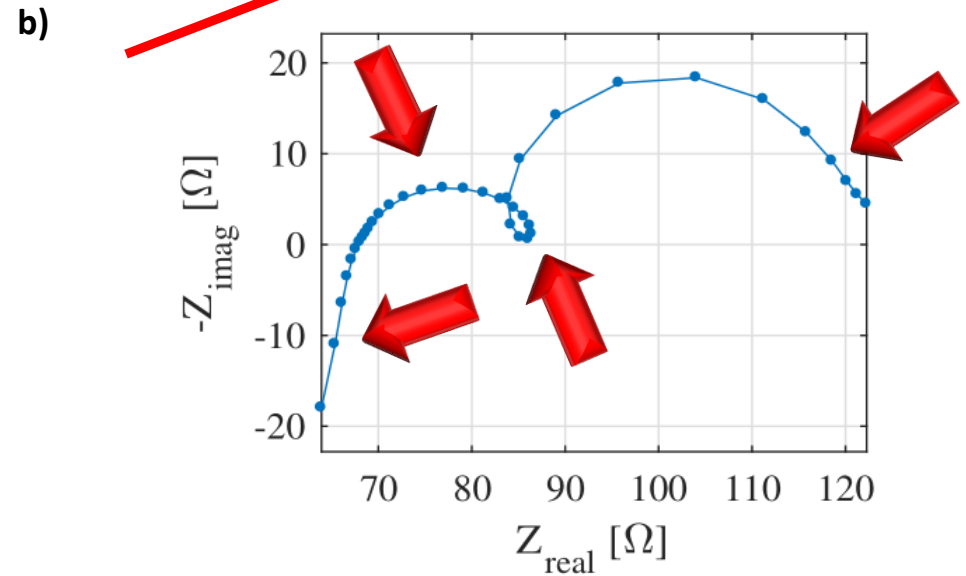
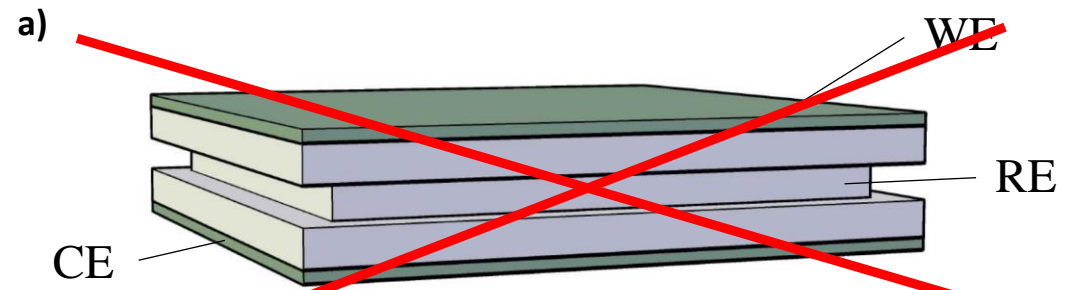
- Well-defined geometry (variable L3PB, ...)
- No reference electrode
- Large number of electrodes
- Direct access to active surfaces
- Current voltage measurements



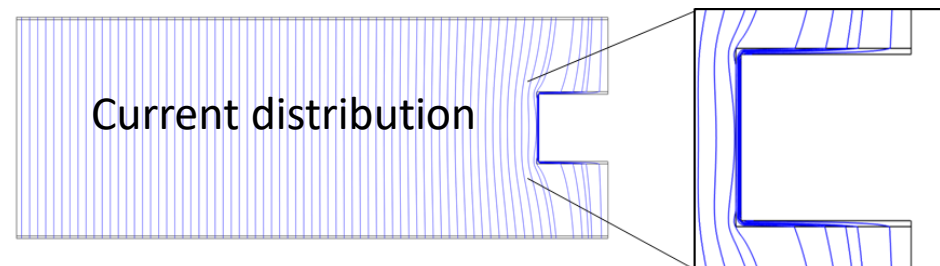
Reference electrodes



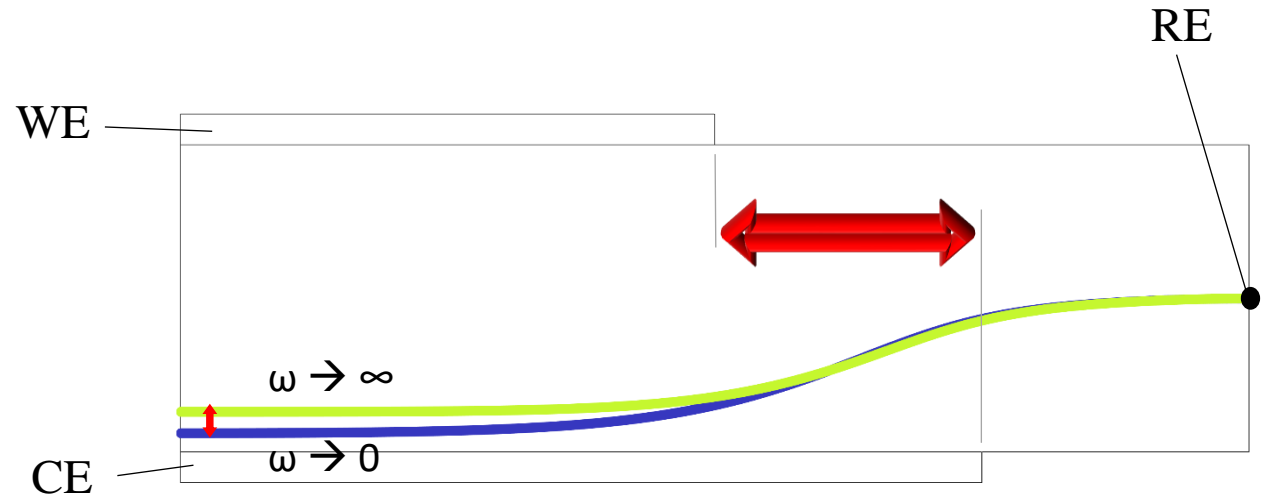
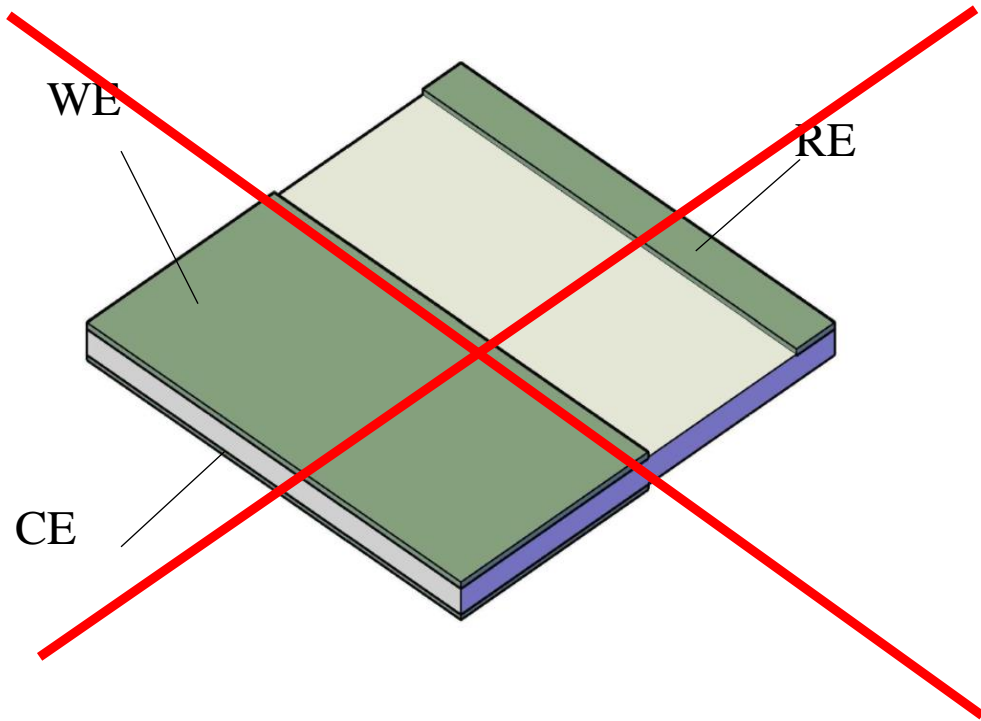
J. Winkler et al., Journal of The Electrochemical Society 145.4 (1998), pp. 1184-1192



- a) **Ring geometry** arrangement with carved reference electrode
 b) Impedance spectra of LSF on YSZ single crystal sample indicating **four measurement errors**



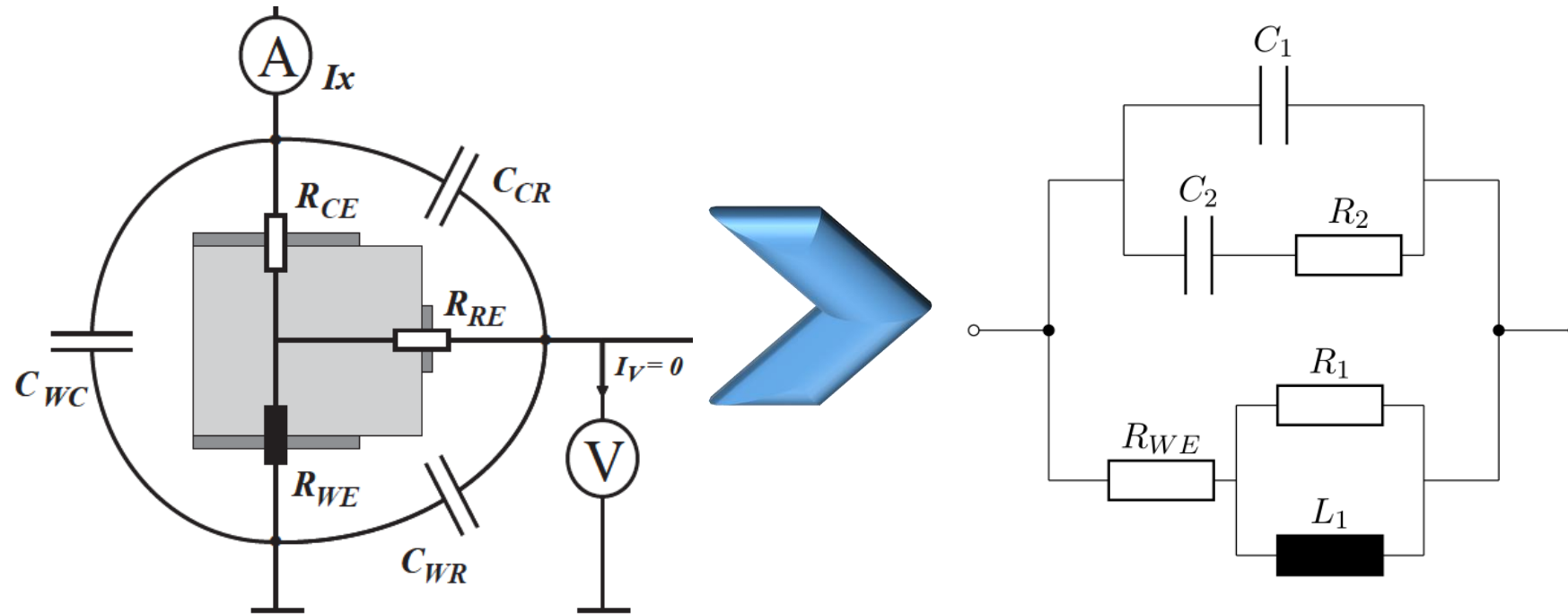
Widely used 3-terminal measurements



effect of misaligned electrodes

- asymmetric WE and CE
- potential shift in the reference potential from high to low measurement frequency

High resistive samples/ High frequencies

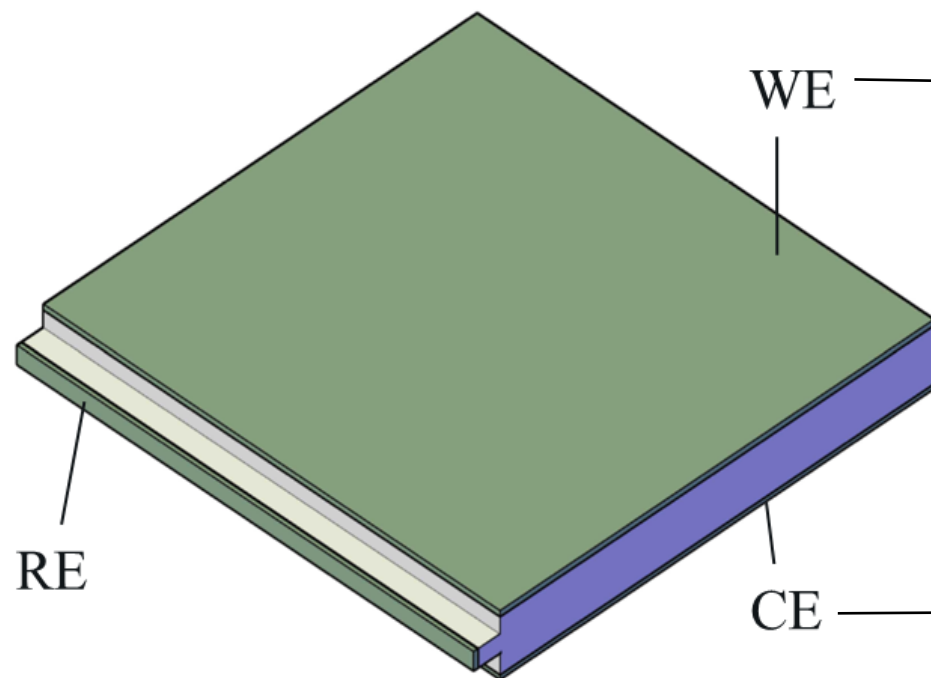


3-point transfer characteristic

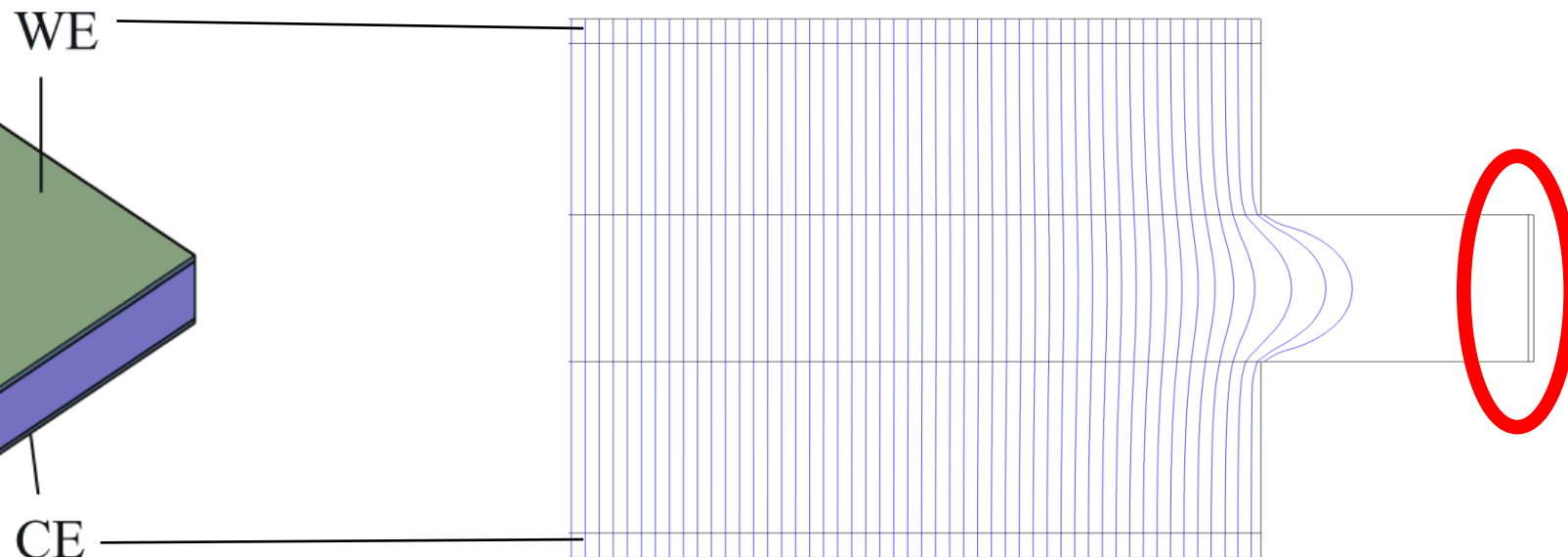
$$\underline{Z}(\omega)_{3\text{-point}} = \frac{V}{I} = \underline{Z}(\omega)_{2\text{-point}}, \text{ equivalent}$$

The novel “WING GEOMETRY”

a)



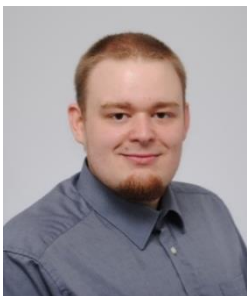
b)



a) Wing geometry

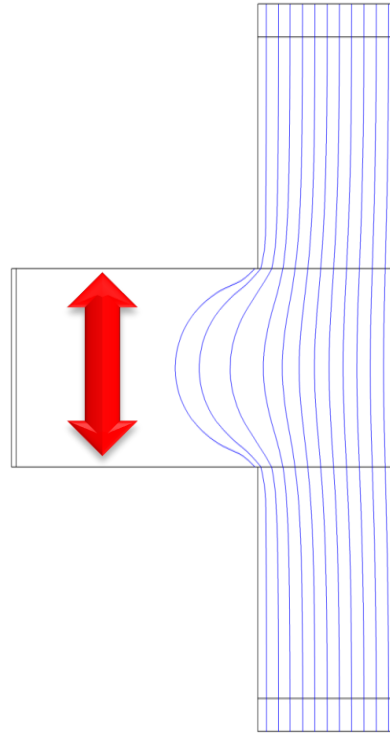
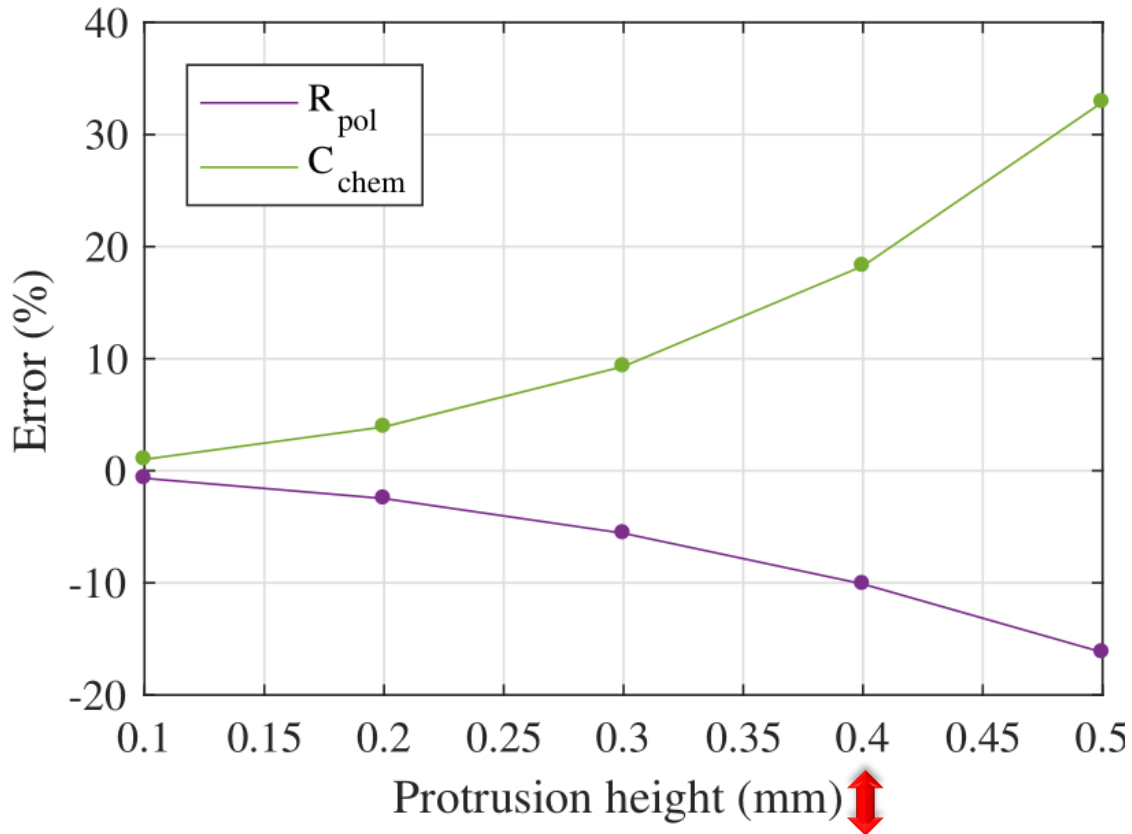
b) Current distribution ($\omega \rightarrow \infty$)

- minimal measurement errors
- affordable
- suitable for different applications



Alexander Schmid

The novel “WING GEOMETRY”



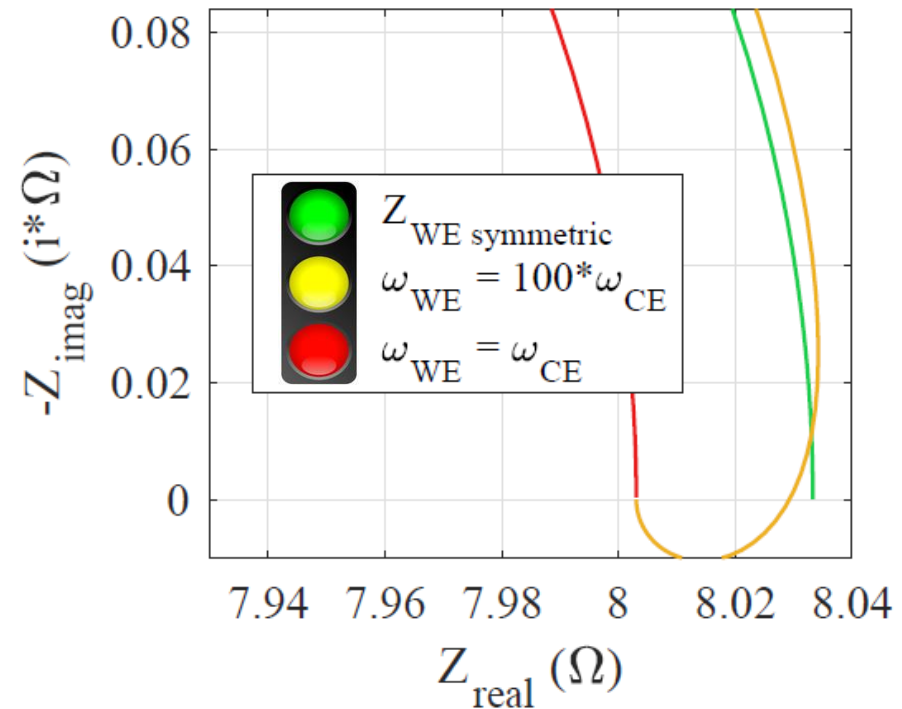
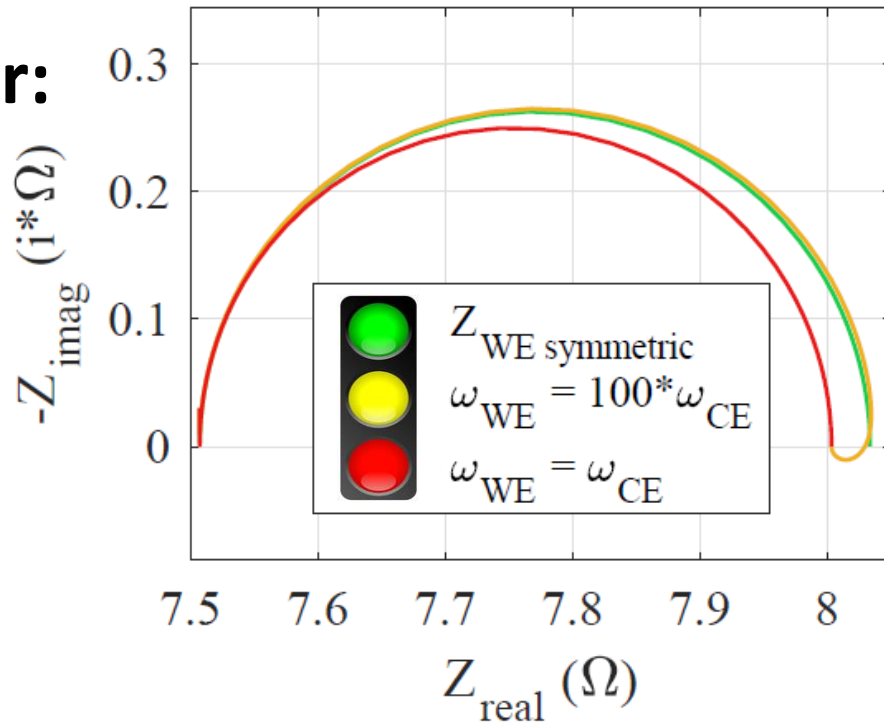
Measurement errors for worst case scenario
(low-resistive electrodes and identical
relaxation times)

3 Error sources:

1. **3-point transfer characteristic** (high ohmic electrodes and high frequencies)
2. **Reference potential shift caused by WE/CE**
 - Geometrical asymmetry
 - Resistive asymmetry
 - Capacitive asymmetry
3. **Short circuit effect**

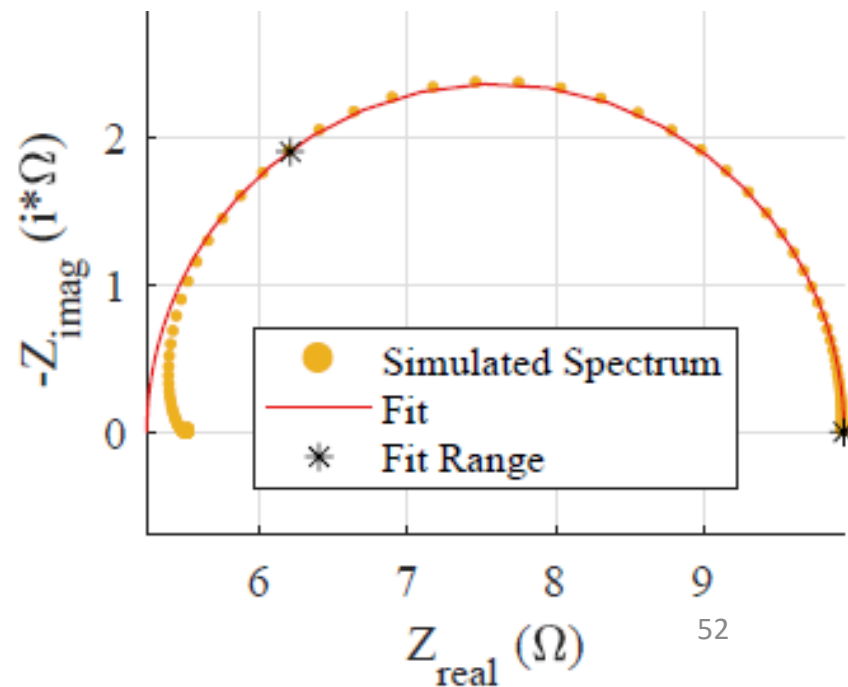
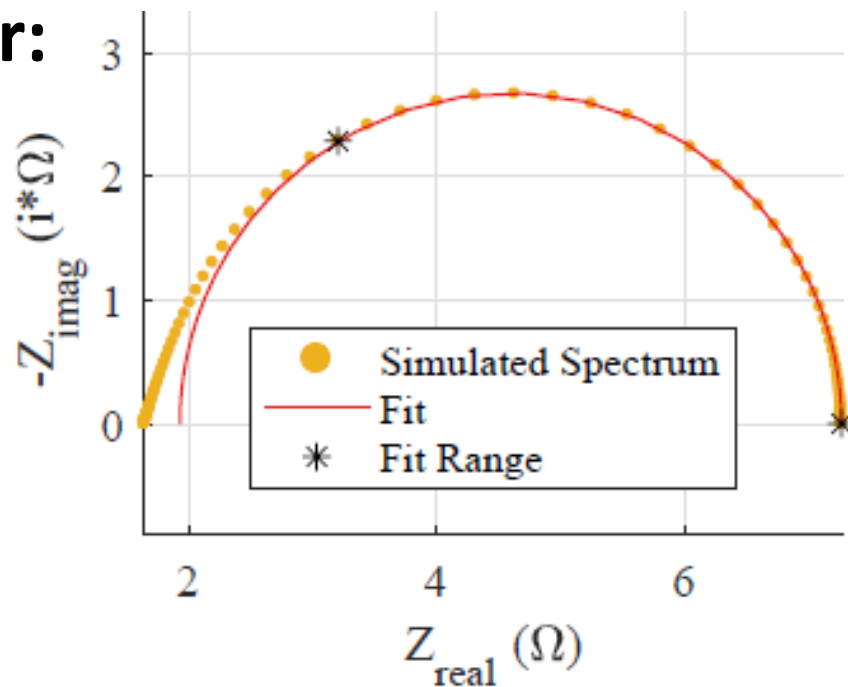
Low frequency error:

$$\omega = \frac{1}{RC}$$

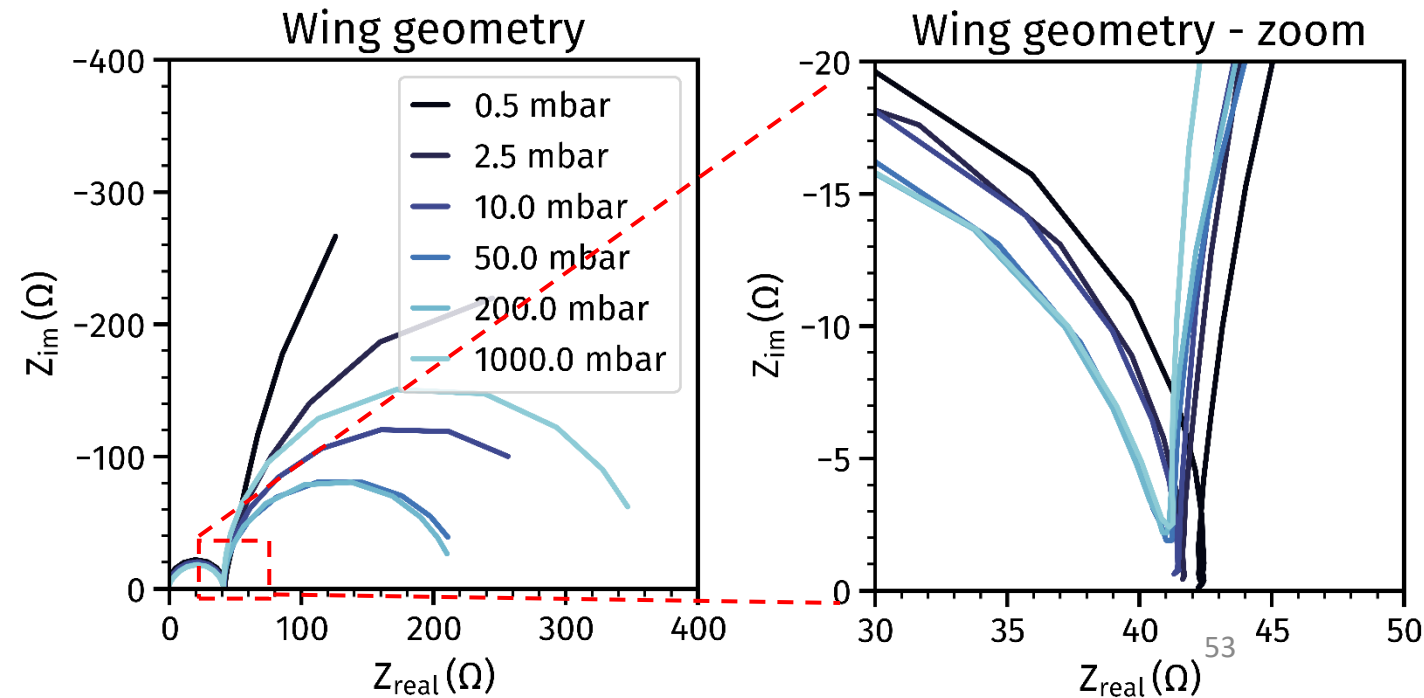
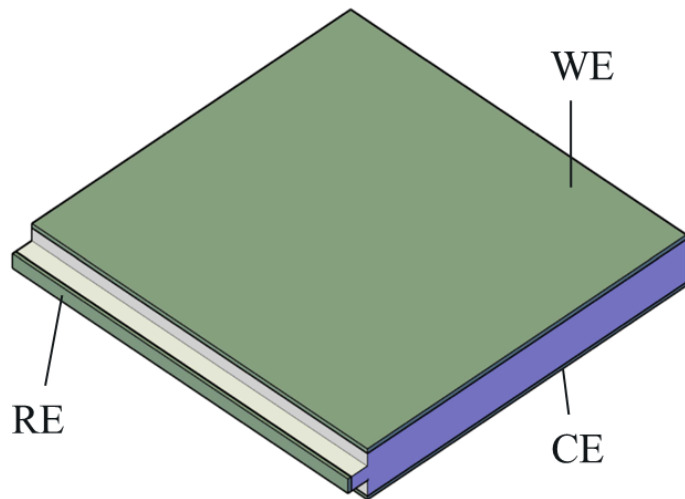
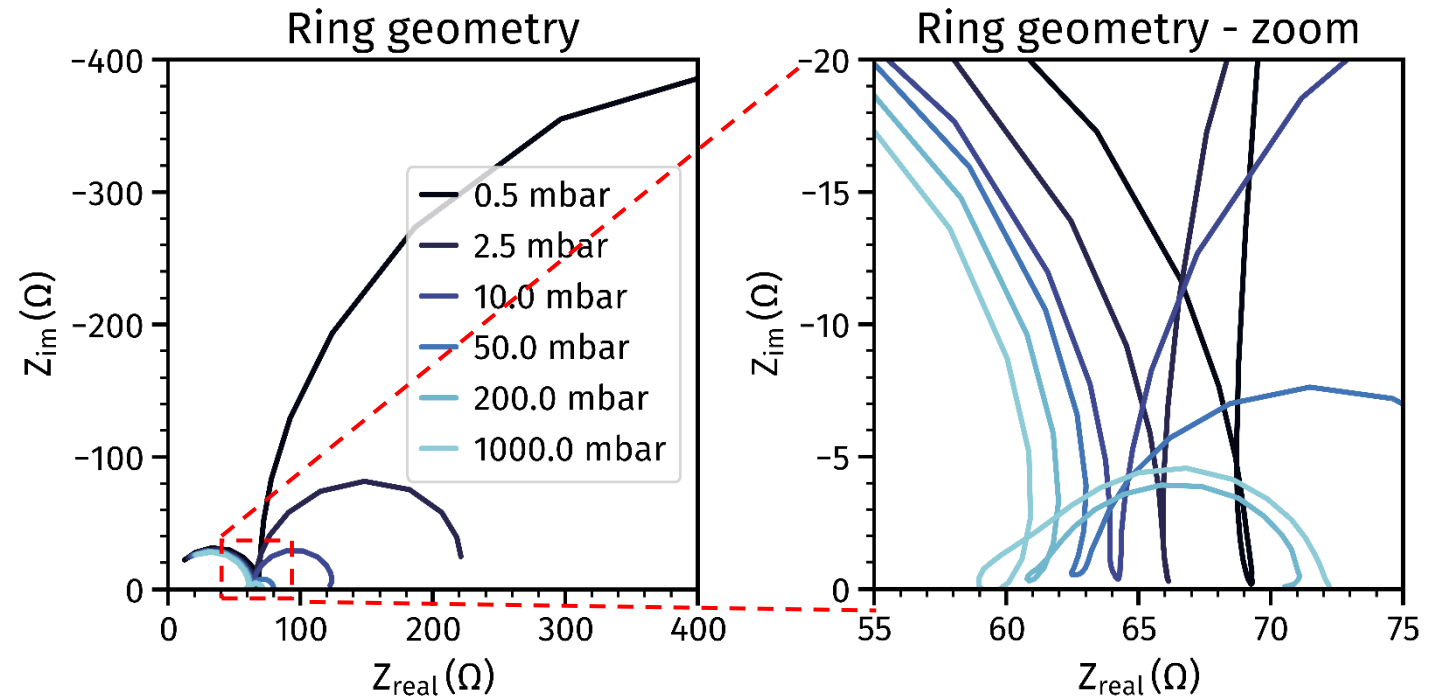
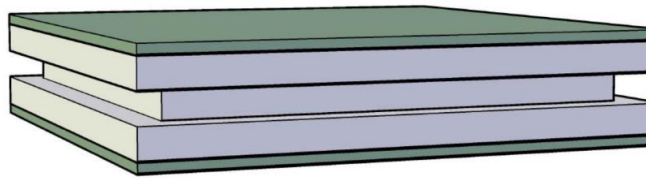


High frequency error:

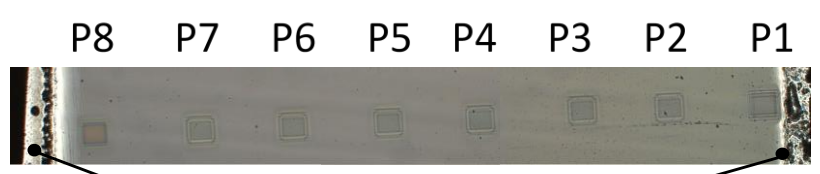
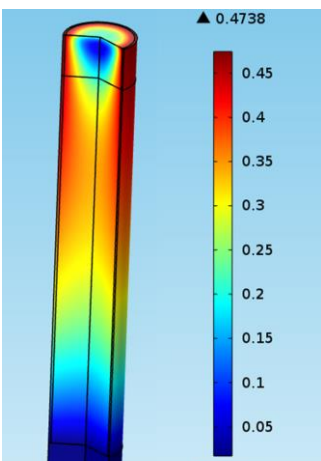
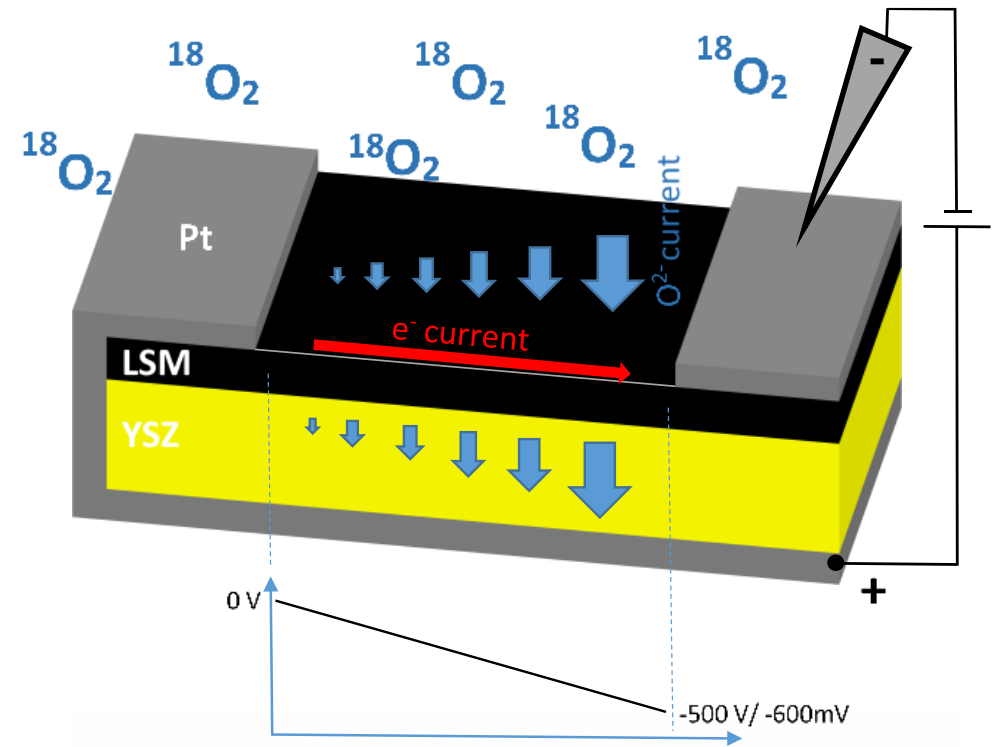
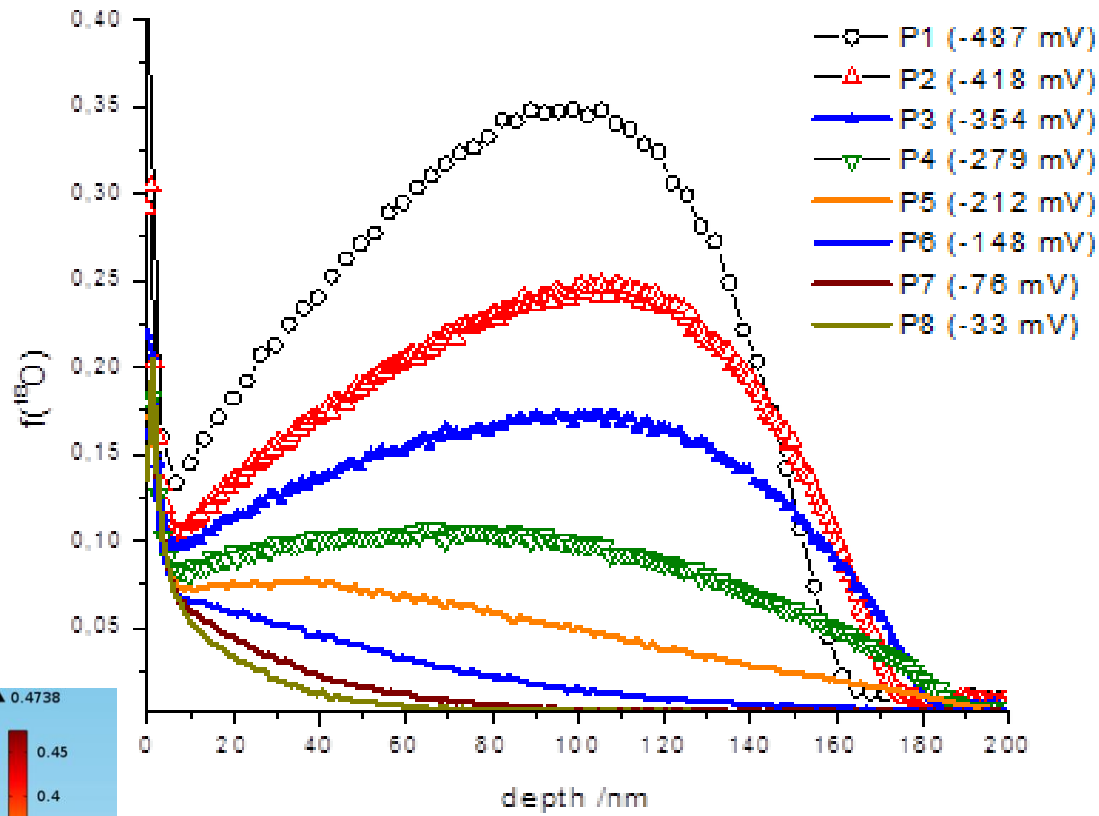
- cross check CE vs RE
- switch WE, CE
- get an idea of WE/CE asymmetry



The novel "WING" vs. "RING GEOMETRY"

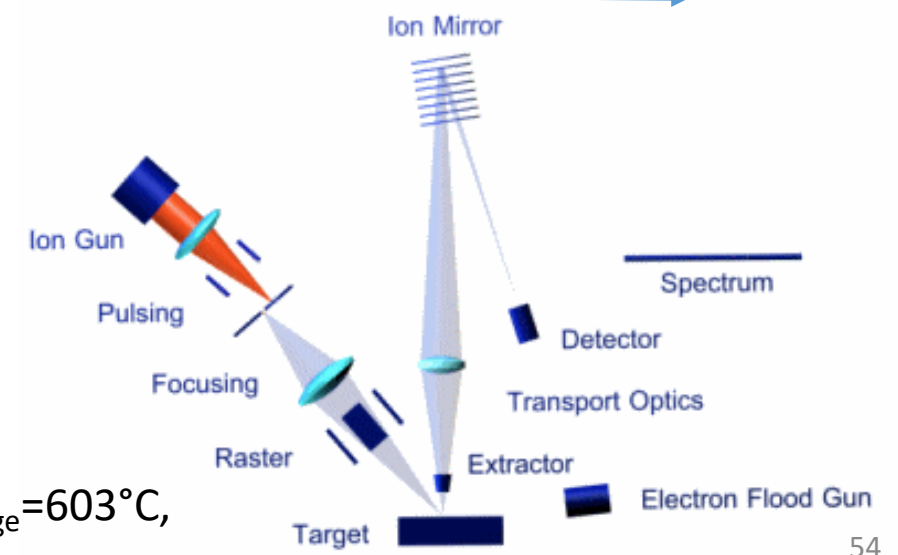


New experimental design for polarization experiments



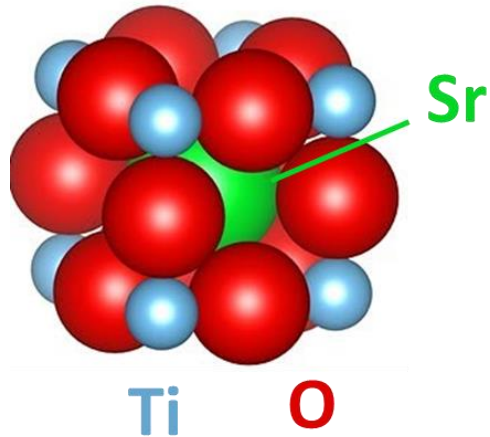
Platinum electrodes
(distance=7.865 mm)

LSM_{600} , $T_{\text{exchange}}=603^\circ\text{C}$,
 $V=-500\text{ mV}$;



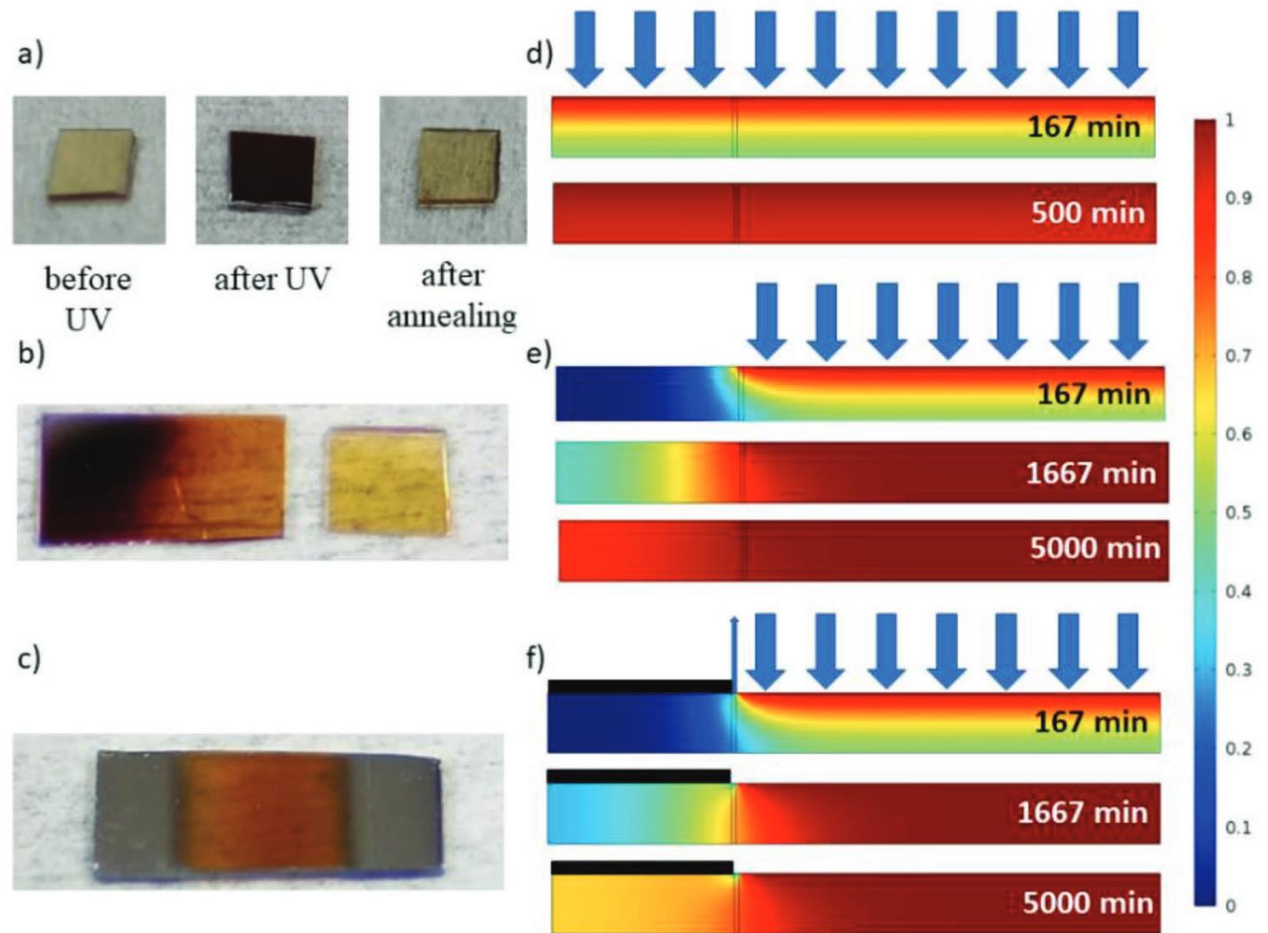
Temperature & light gradient issues

Light experiments (shadowing problem)

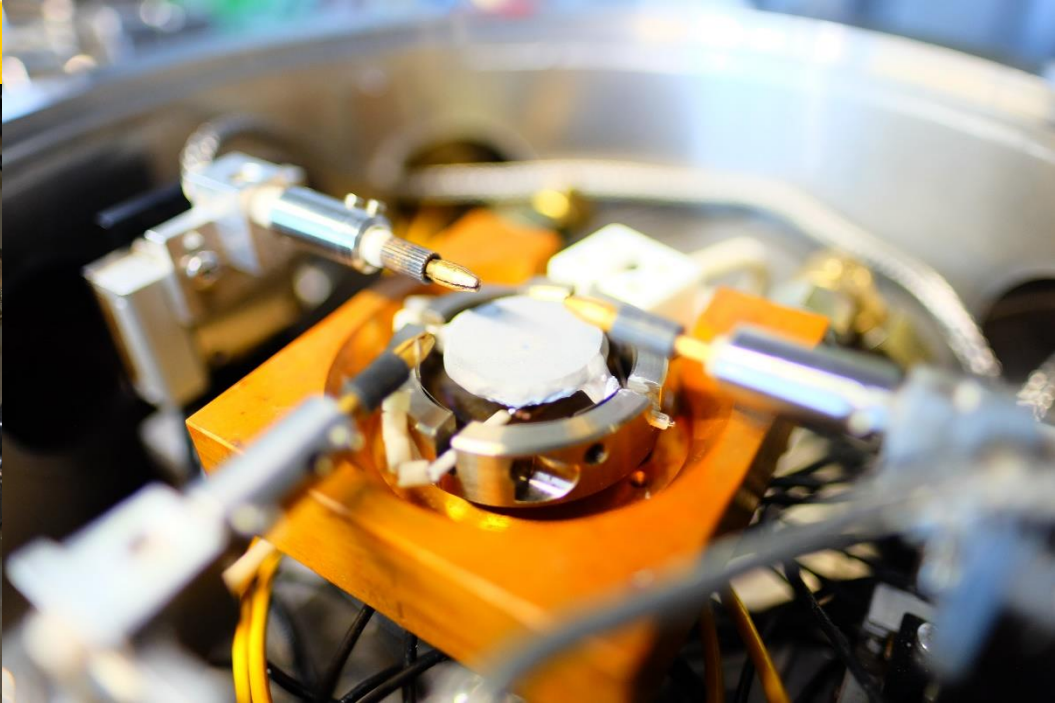
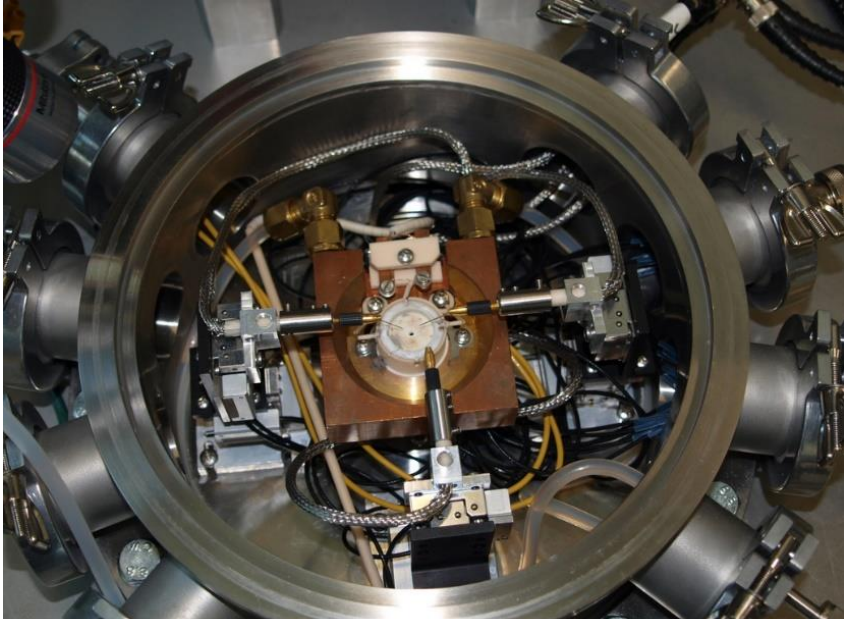
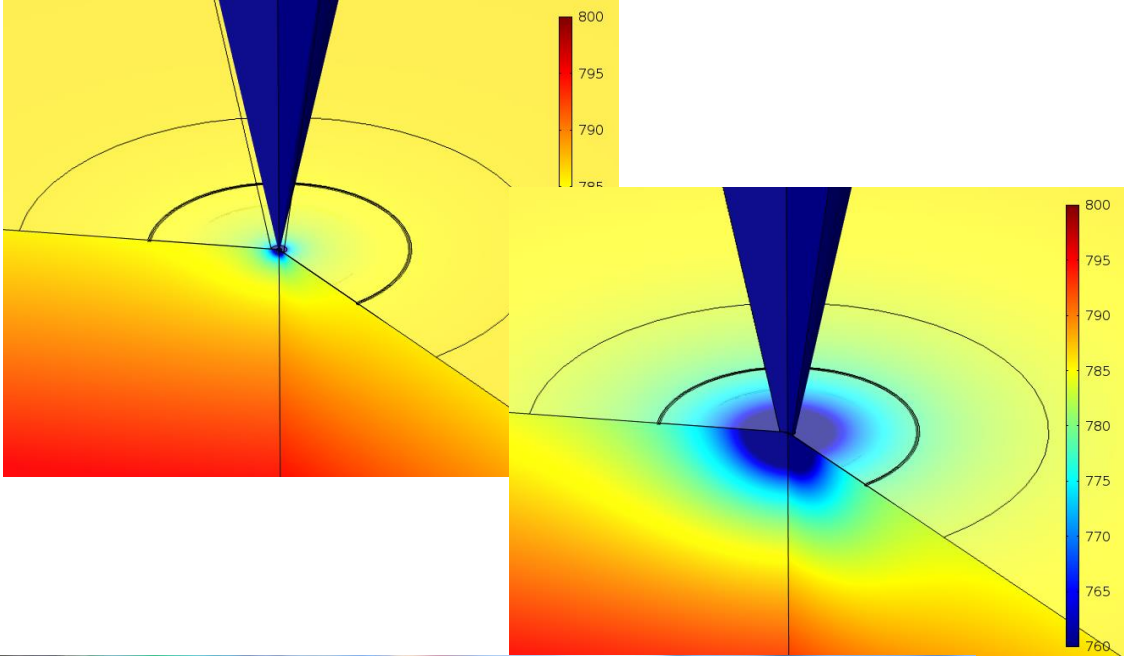
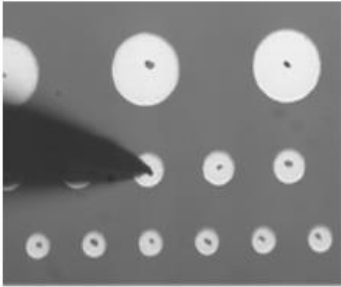
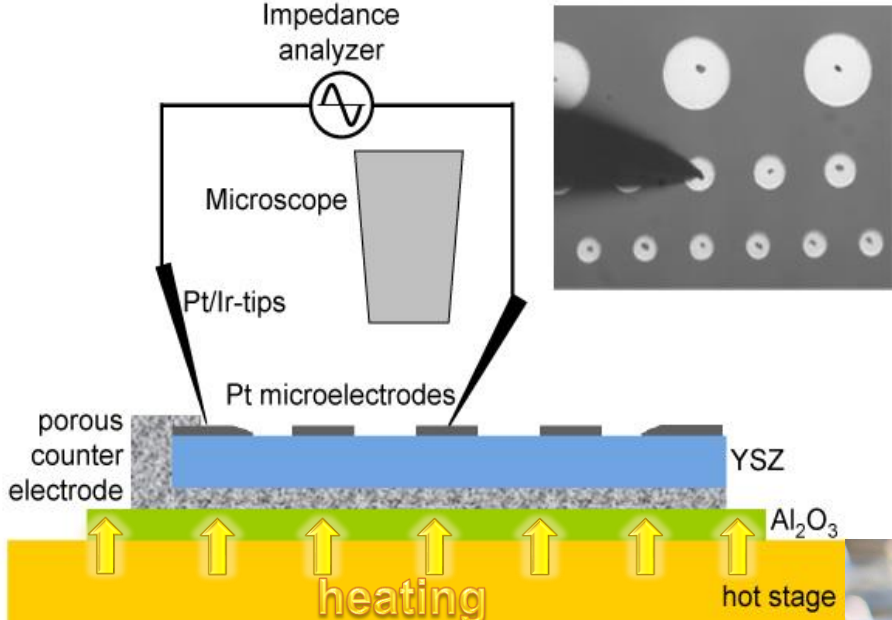


Opto-Ionic effects in SrTiO₃

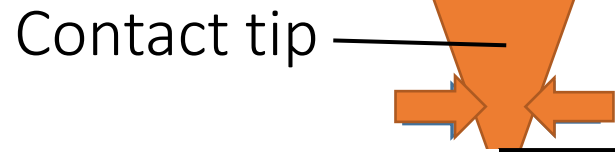
- Perovskite structure
- Model electroceramic
- Indirect bandgap ~3.2 eV



Asymmetric heating



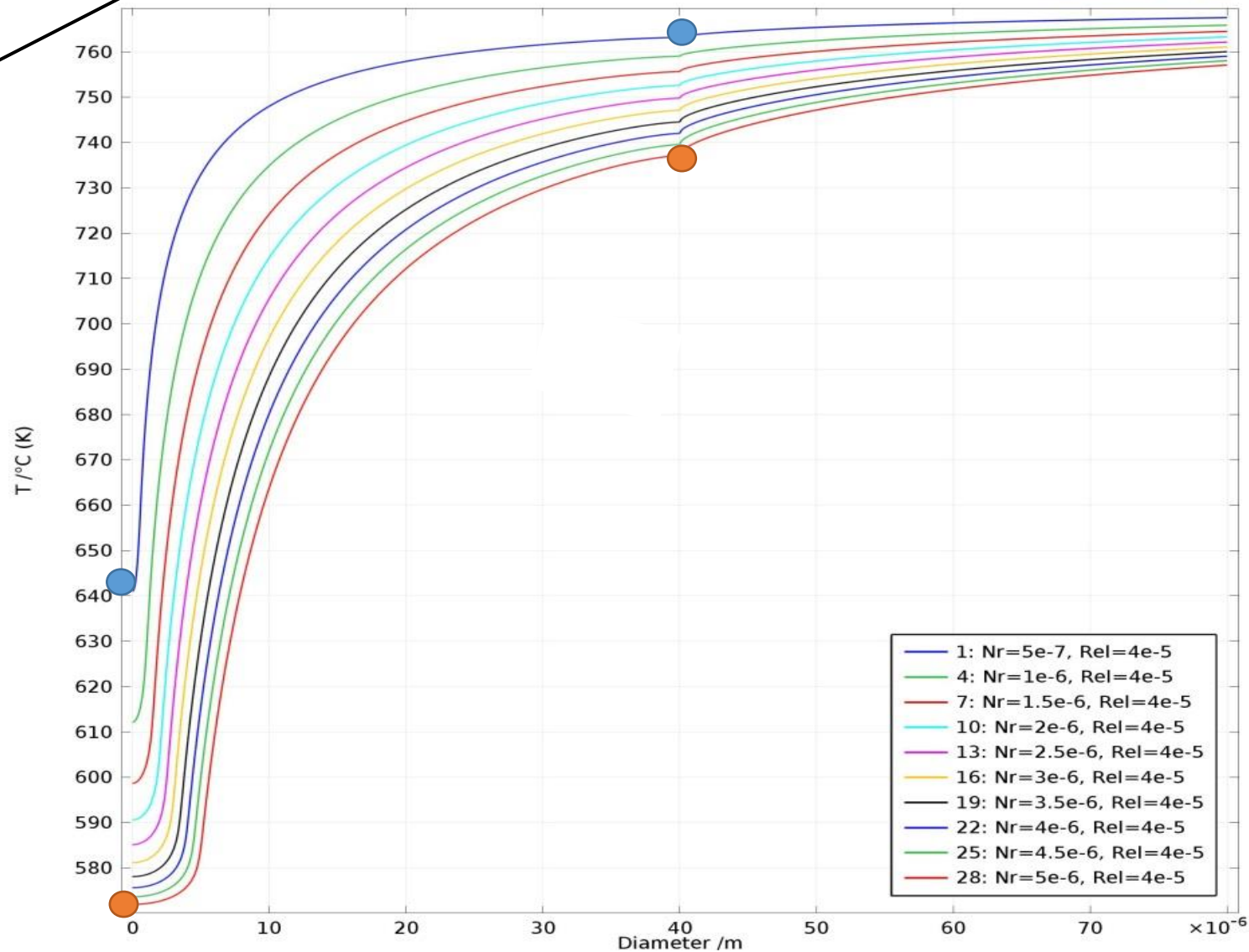
Finite element calculations



Contact tip

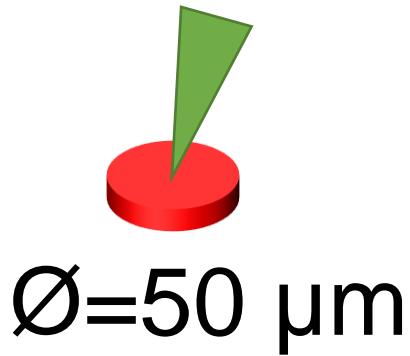
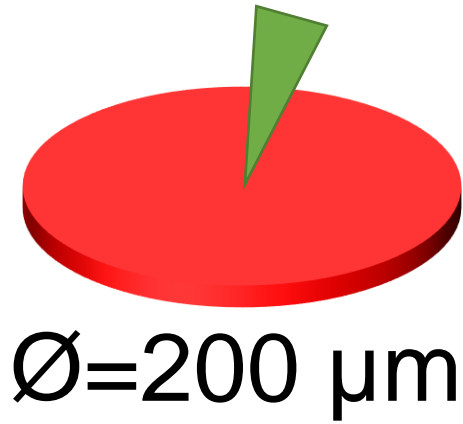
Electrode

Electrolyte



T. M. Huber, et. al. Solid State Ionics 268 (2014): 82-93

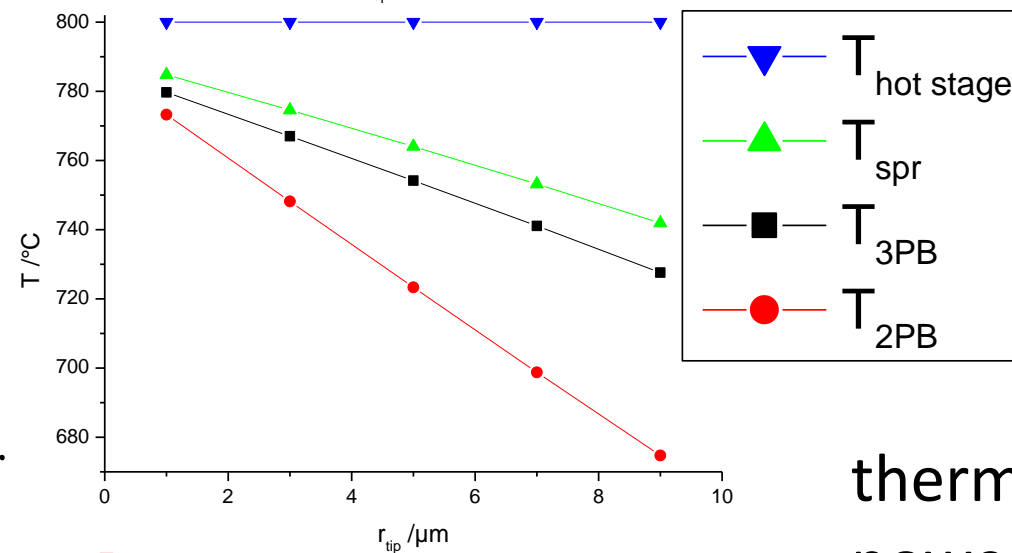
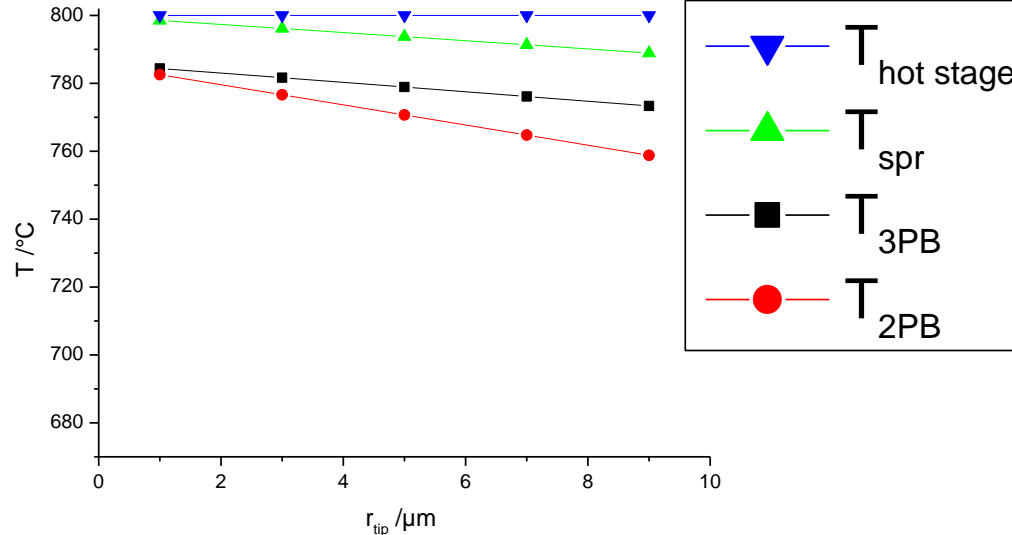
Temperatures at differently sized electrodes



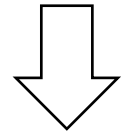
$$T_{2PB} = \frac{4}{d_{ME}^2} \int T(r) \cdot r \cdot 2 \cdot dr$$

problem: $\Delta T \rightarrow$ thermo voltage

E. Ahlgren, F. W. Poulsen; Solid State Ionics 70/71(1994) 528-532



$$\sigma_{ion} = \frac{1}{2d_{ME}R_0} = \sigma^* \cdot e^{-\frac{E_a}{k_B T}}$$

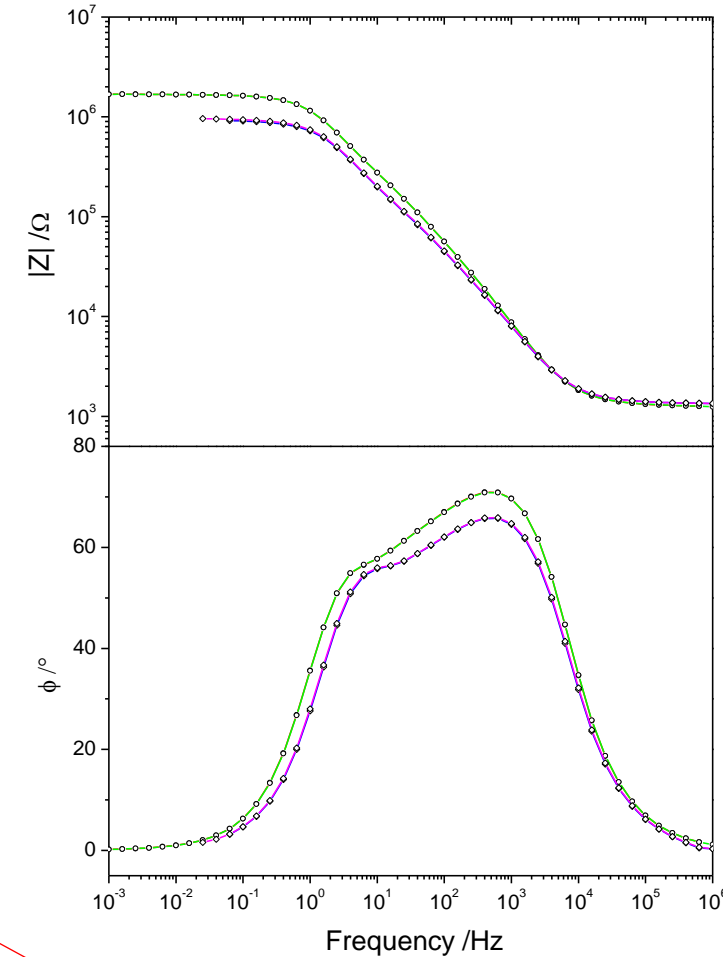
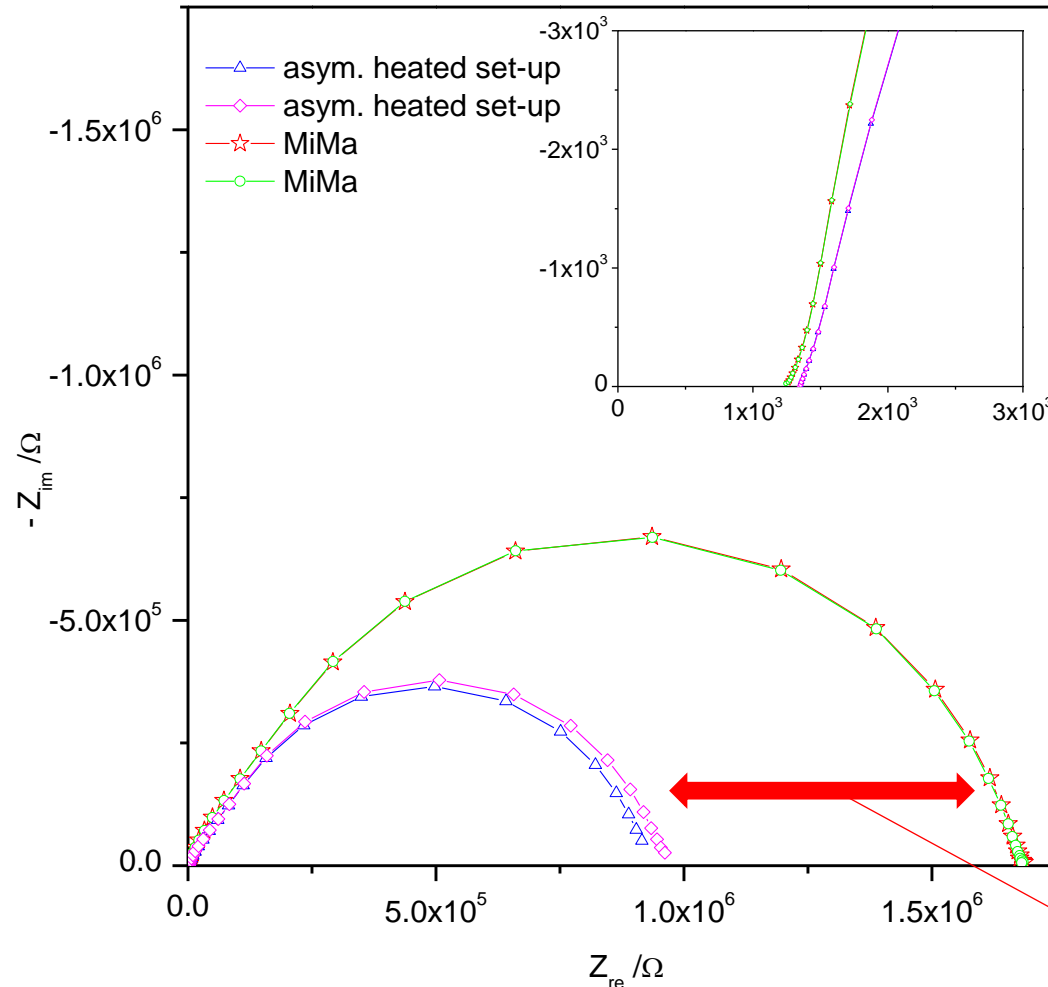


$$T_{spr} = \frac{E_a}{k_B \cdot \ln(2d_{ME}R_0)}$$

thermoelectric
power (0.486 mV/K
YSZ in air [1])

Impedance spectroscopy on microelectrodes

145 μm squared LSM microelectrode at 760 $^{\circ}\text{C}$



error induced by thermovoltage



Institute of Chemical Technologies
and Analytics



**huber
scientific**

novel measurement solutions

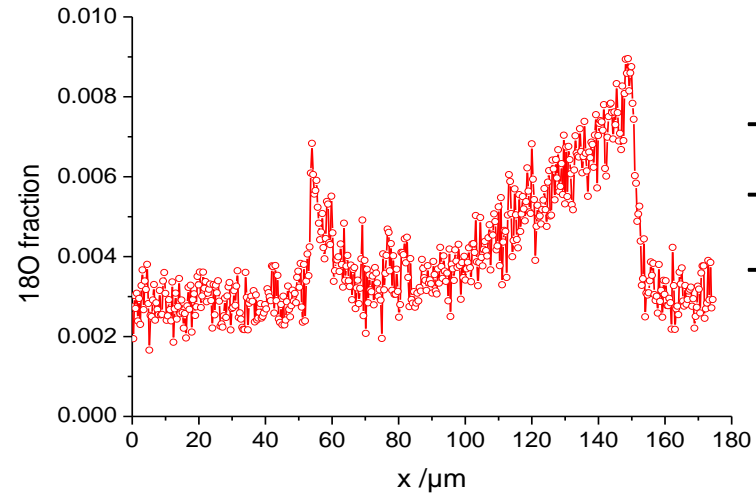
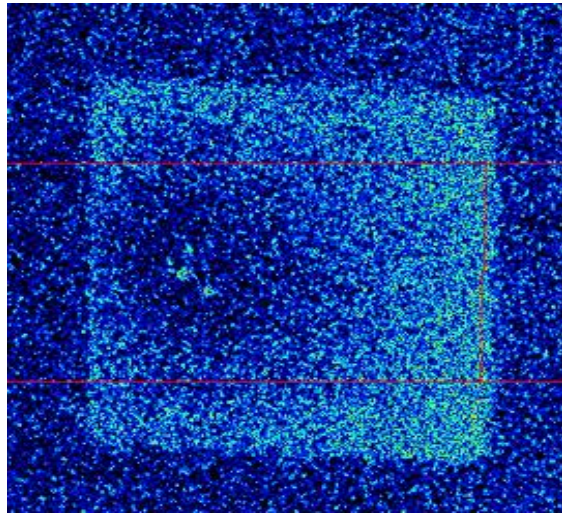


PIZZA

- Surface de wetting → Mozzarella

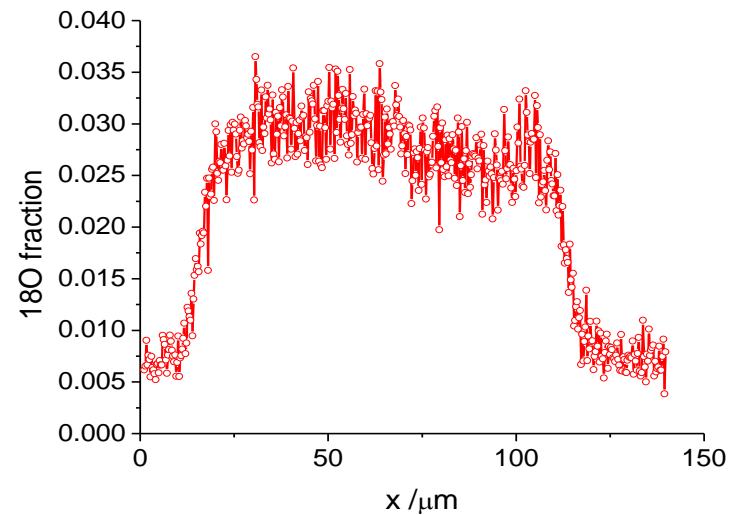
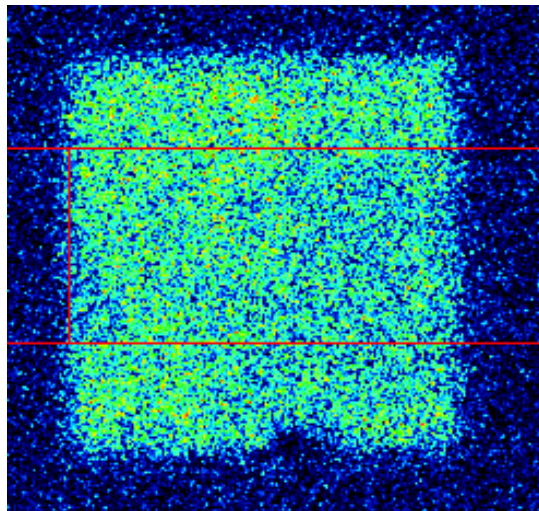
DC-polarization with ^{18}O tracer

asymmetrically heated set-up



- 369°C
- -850 mV bias
- $5 \cdot 10^{-8}$ A

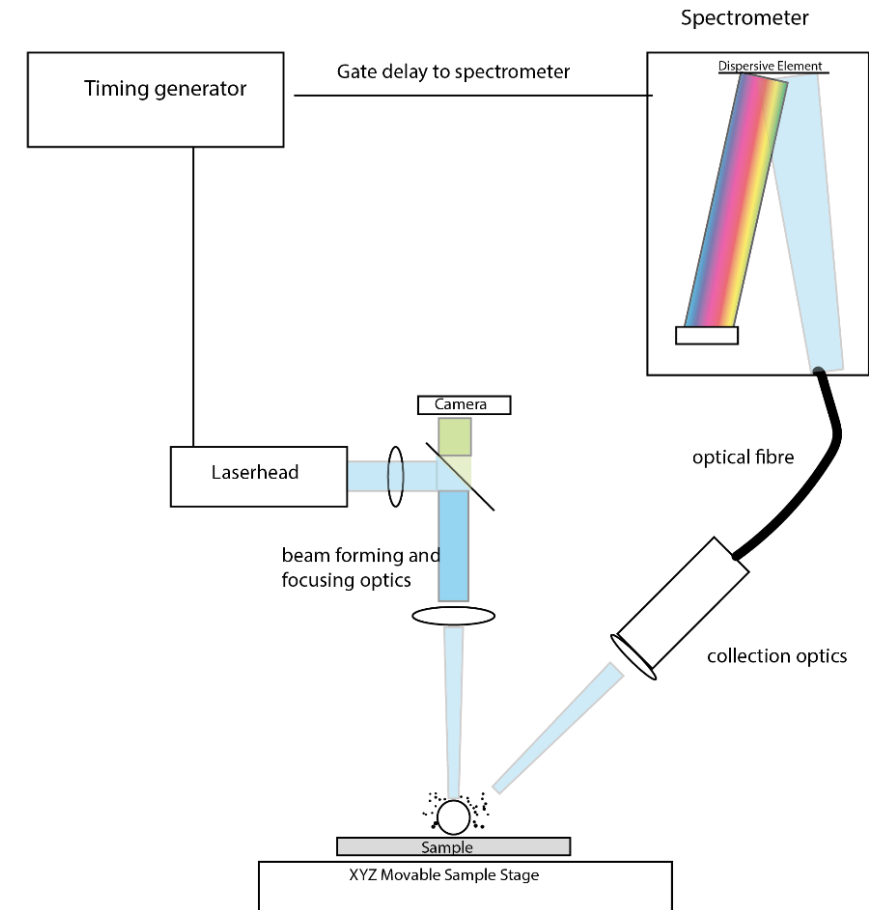
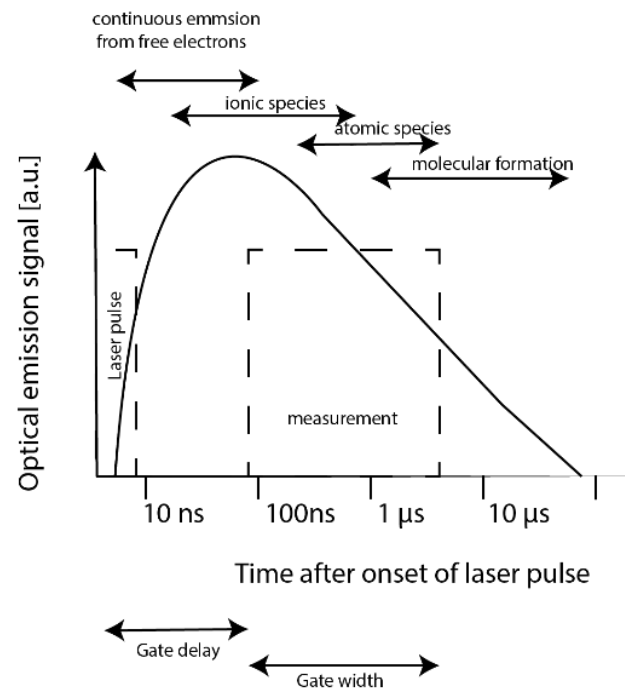
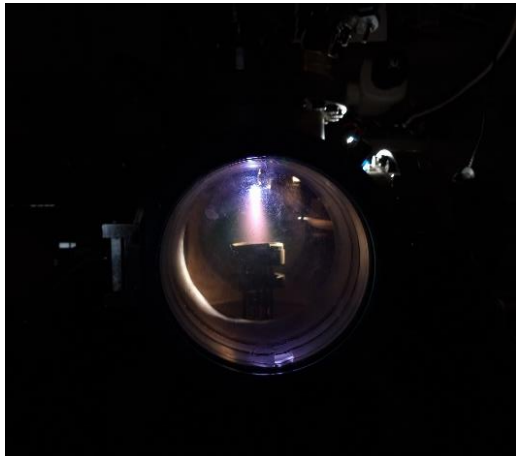
symmetrically heated set-up



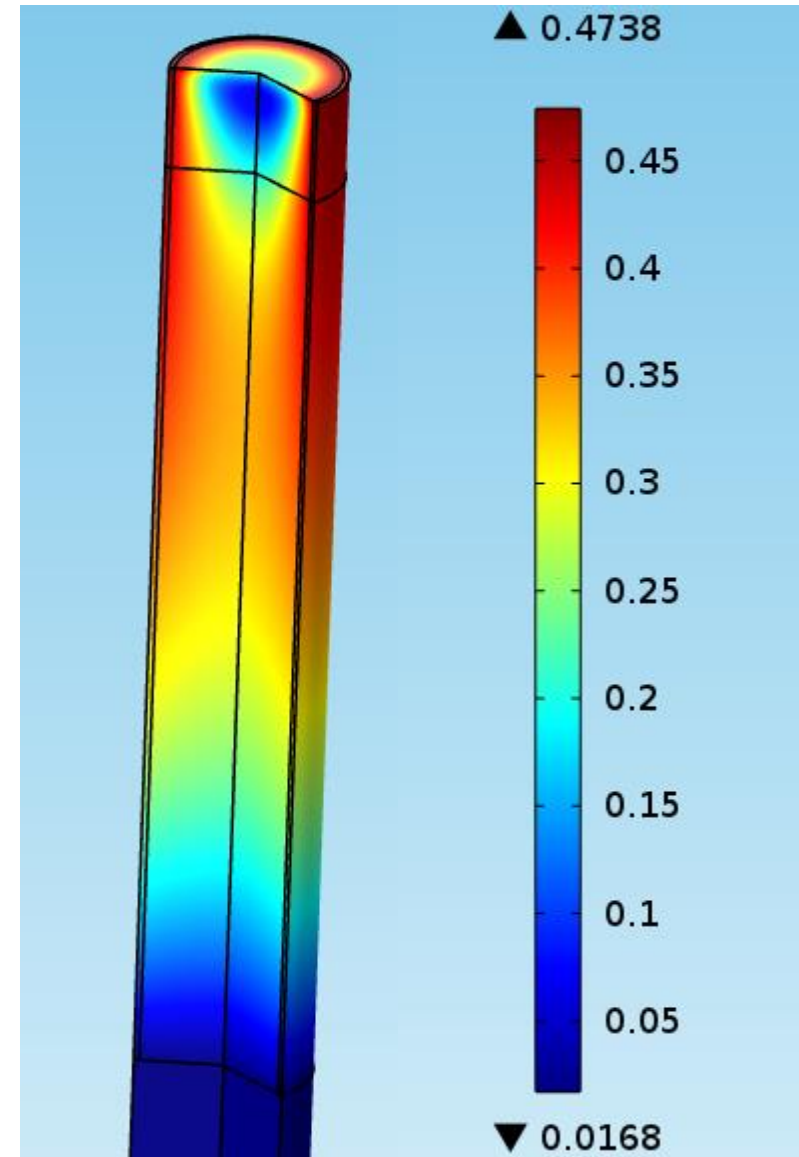
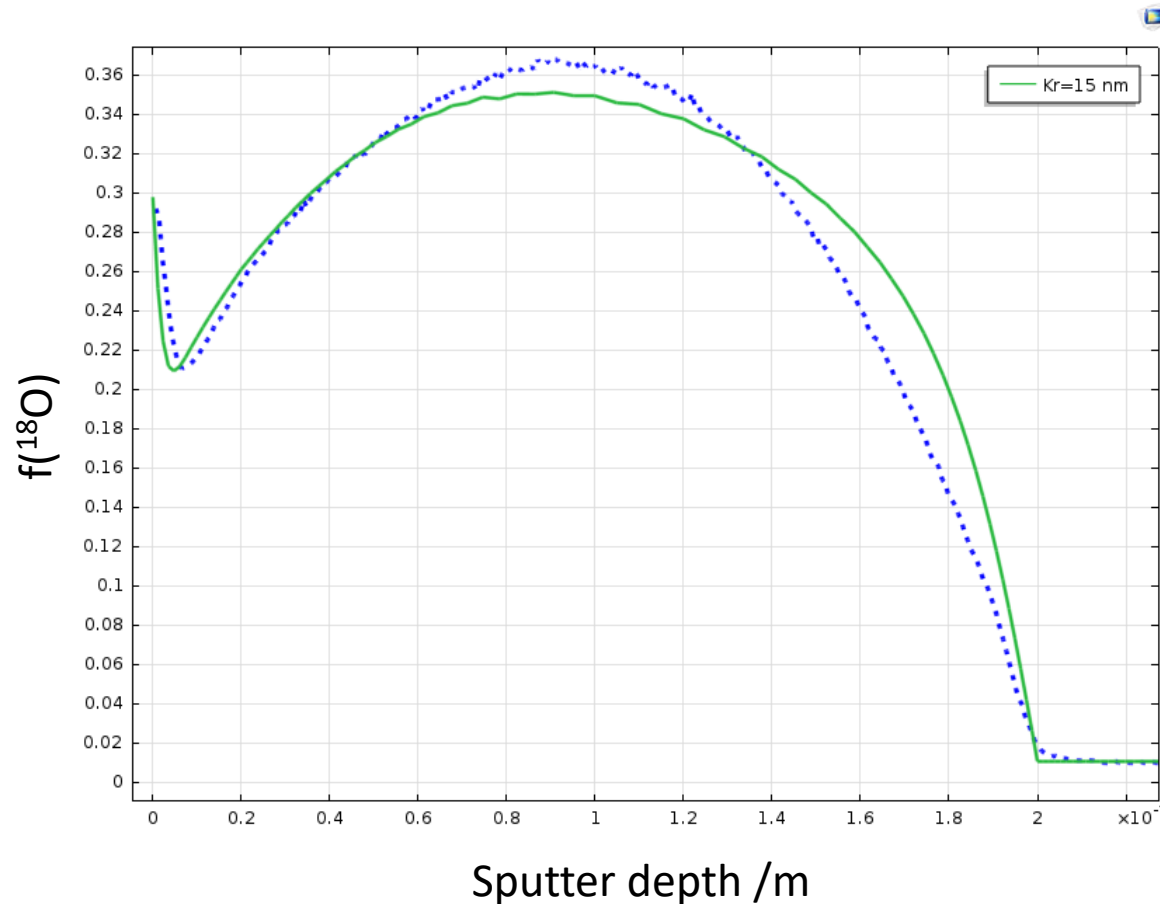
- 466°C
- -900 mV bias
- $7.5 \cdot 10^{-7}$ A

Laser induced breakdown spectroscopy

- **Laser pulse evaporates sample**
 - (same mechanism as PLD)
- **Removed material forms plasma**
- **Plasma emits characteristic elemental emission** → detected and quantified

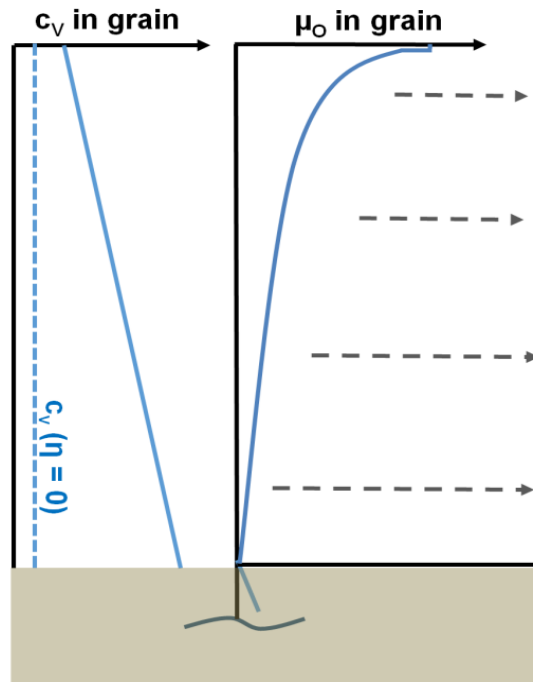


Apparent uphill diffusion /finite element fitting

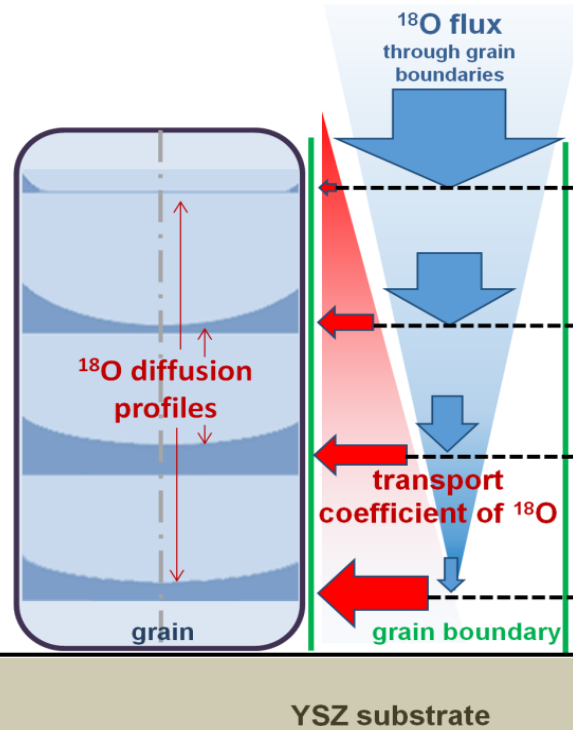


Evolution of apparent uphill diffusion

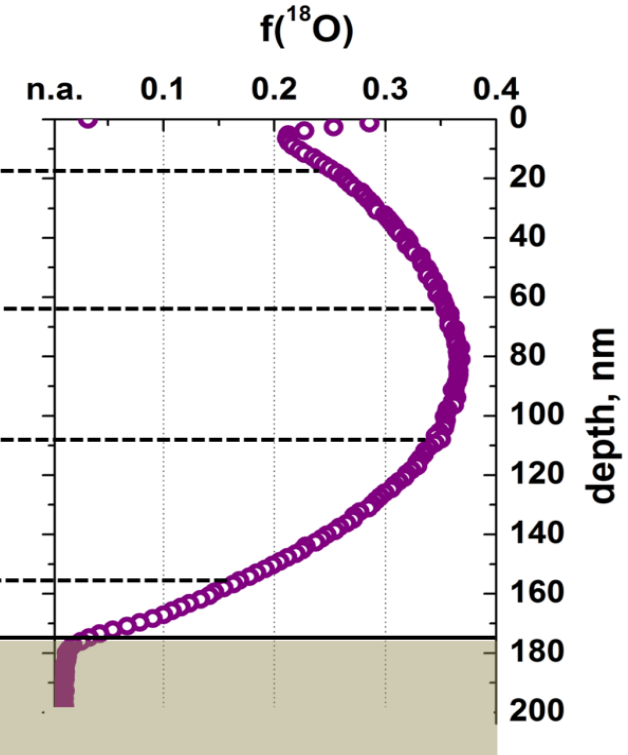
a) chemical potential and vacancy concentration distribution



b) ^{18}O exchange

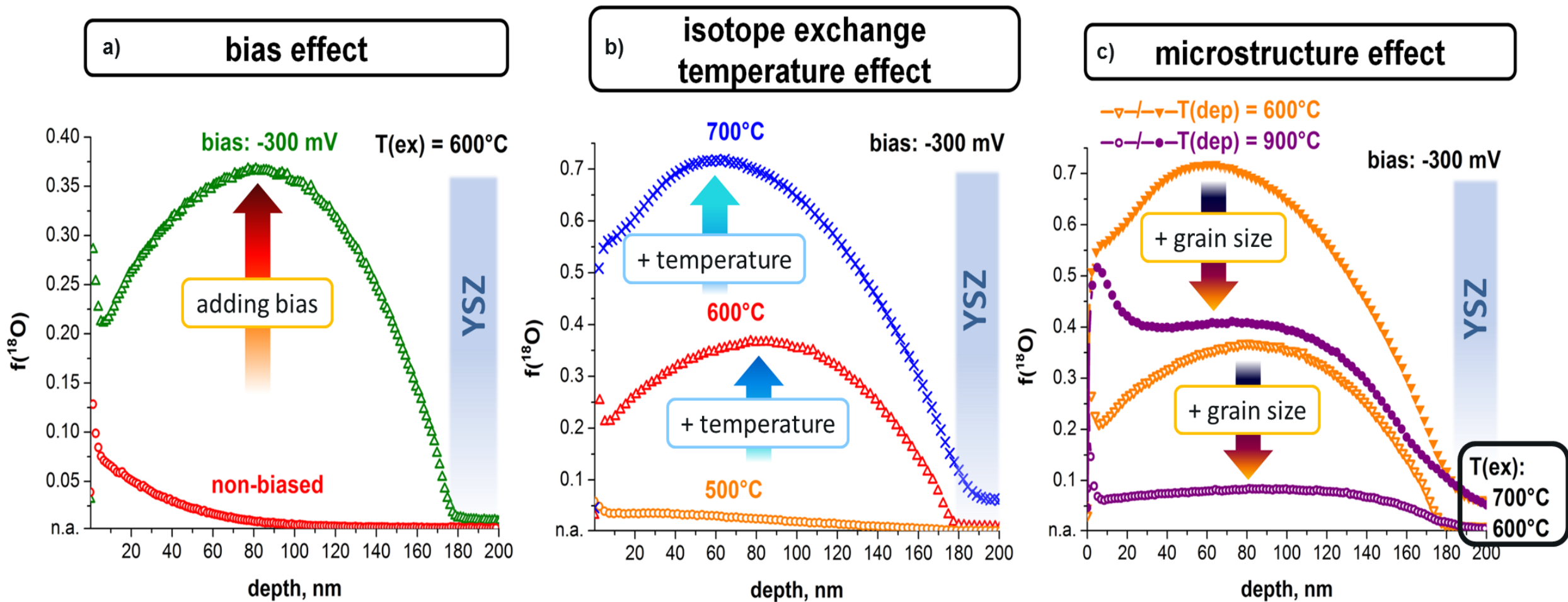


c) ^{18}O diffusion profile

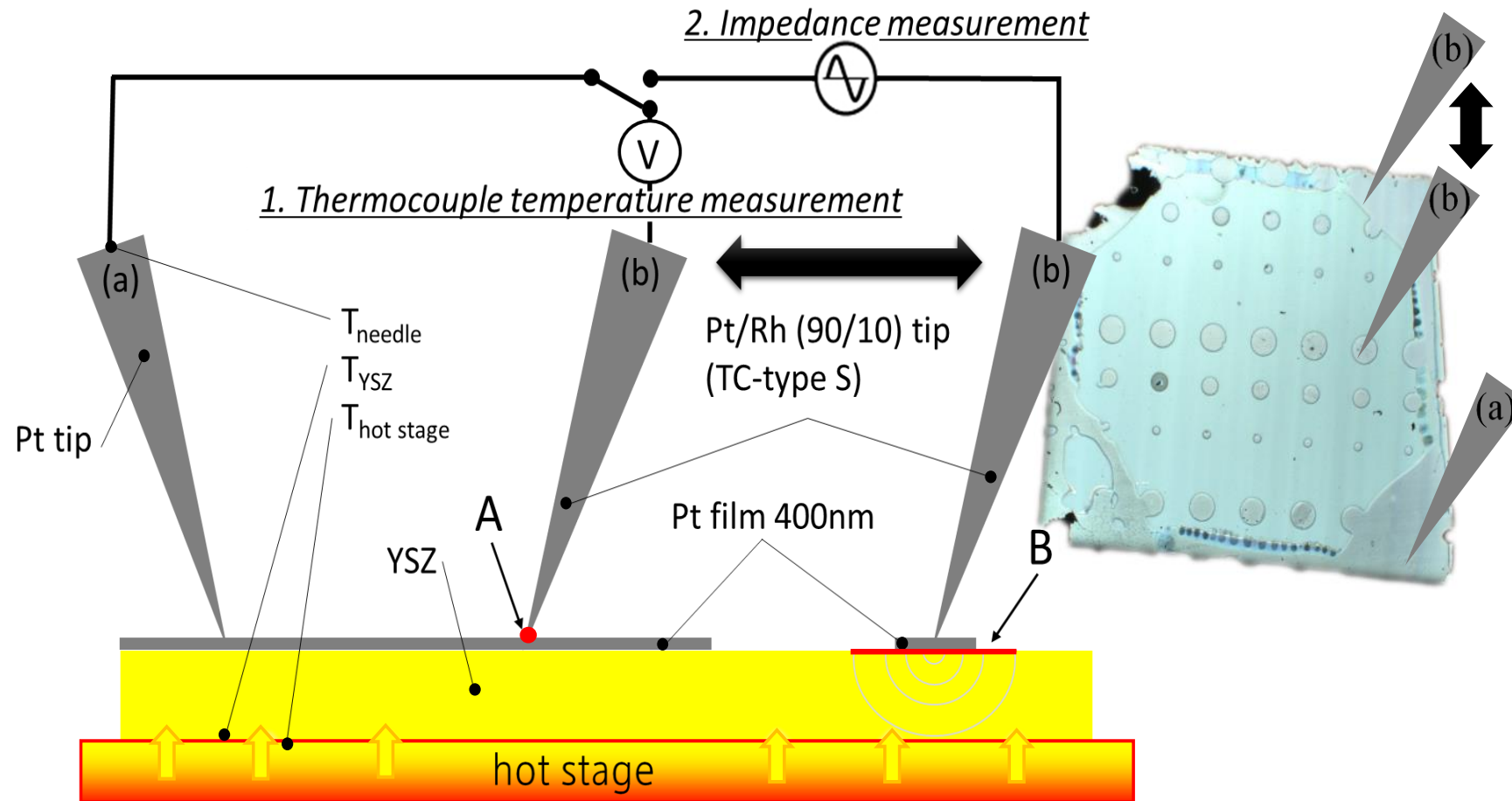


$$D_b(z) = D_b(z=0) \cdot \left(1 + \Delta \frac{z}{h} \right)$$

Voltage effect on oxygen tracer diffusion

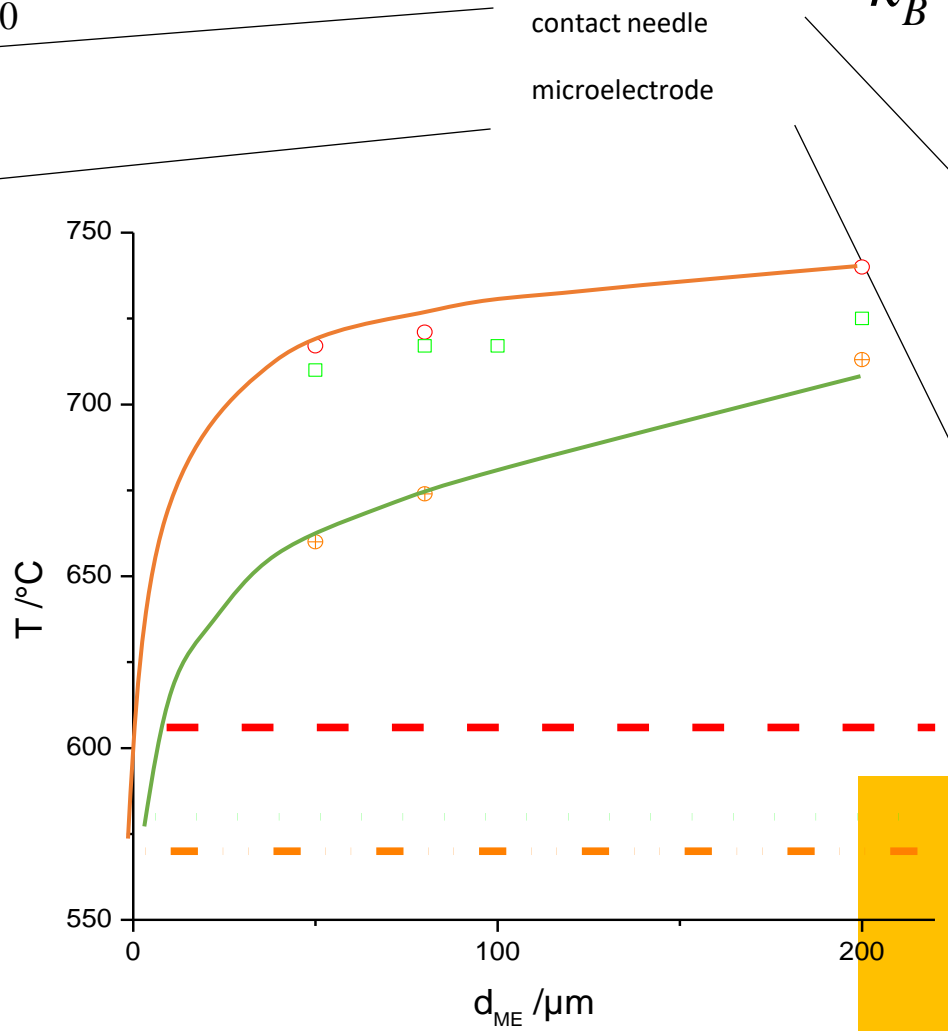
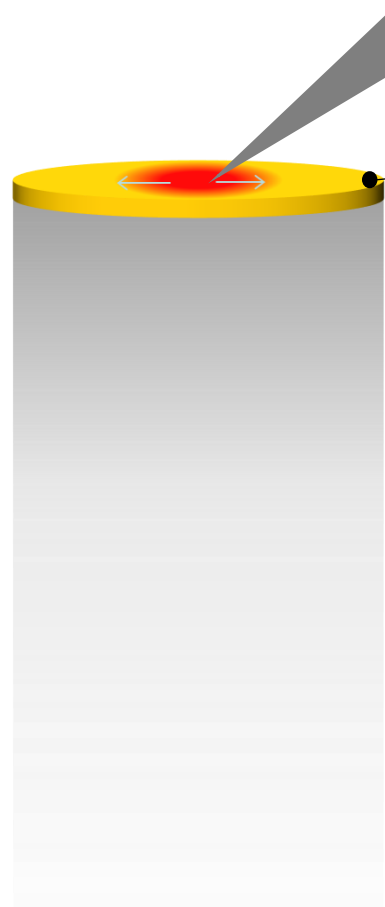


Micro-thermocouple

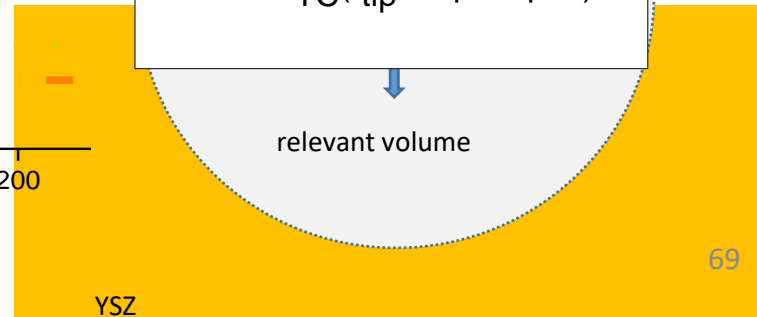


Visualization of temperature gradients

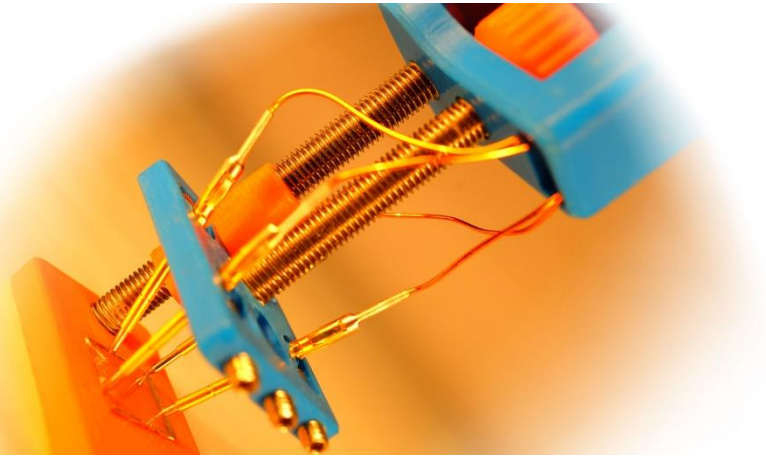
$$\sigma_{ion} = \frac{1}{2d_{ME}R_0} = \sigma^* \cdot e^{-\frac{E_a}{k_B T}} \quad \longrightarrow \quad T_{spr} = \frac{E_a}{k_B \cdot \ln(2d_{ME}R_0)}$$



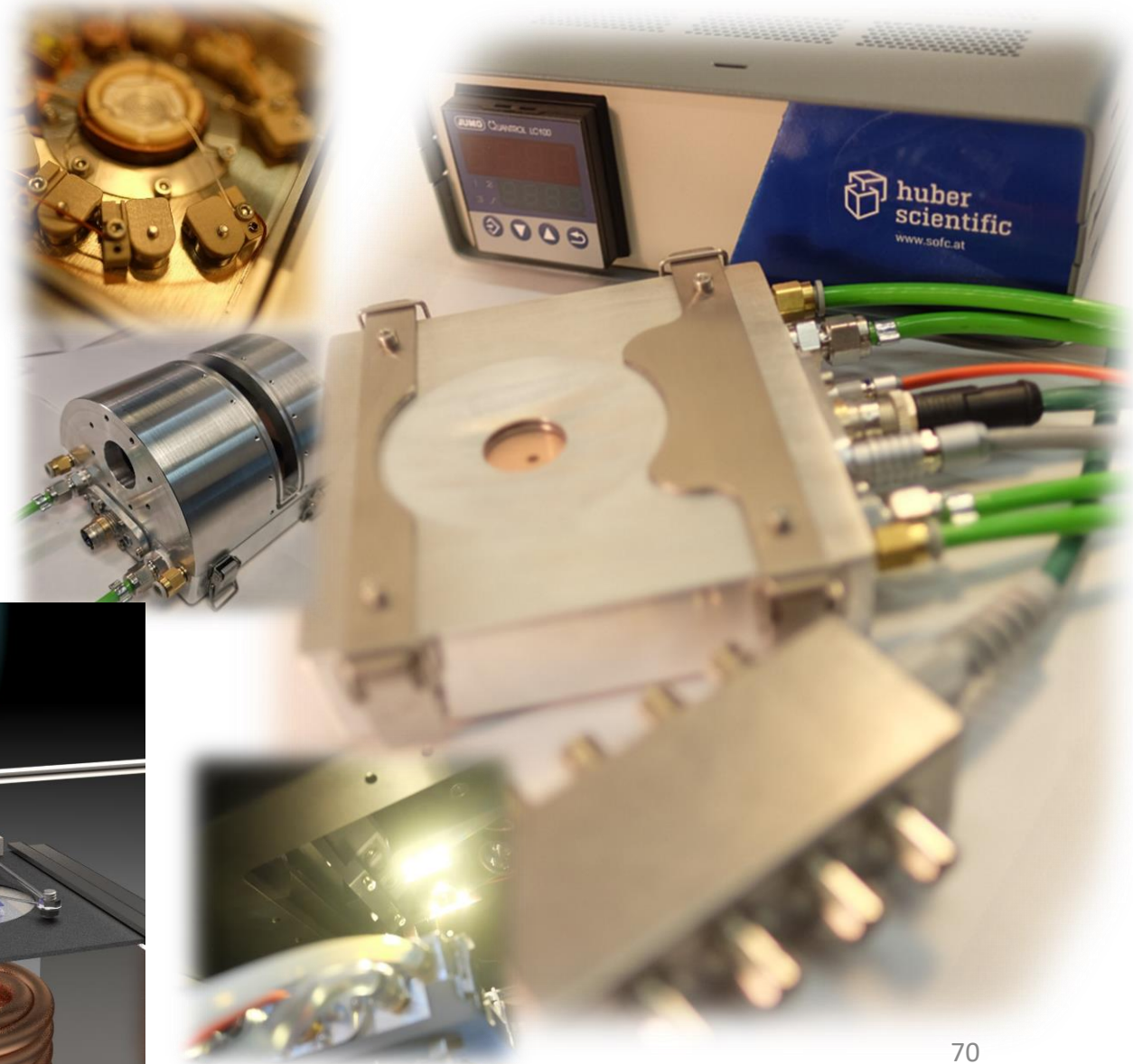
- $T_{spr}(r_{tip}=2\mu m \text{ closed})$
- $T_{spr}(r_{tip}=2\mu m \text{ open})$
- ⊕ $T_{spr}(r_{tip}>10\mu m \text{ open})$
- $T_{TC}(r_{tip}=2\mu m \text{ closed})$
- - $T_{TC}(r_{tip}=2\mu m \text{ open})$
- · - $T_{TC}(r_{tip}>10\mu m \text{ open})$



IN SITU NEUTRON REFLECTIVITY



MINI CHAMBER FOR THIN FILMS & DEVICES

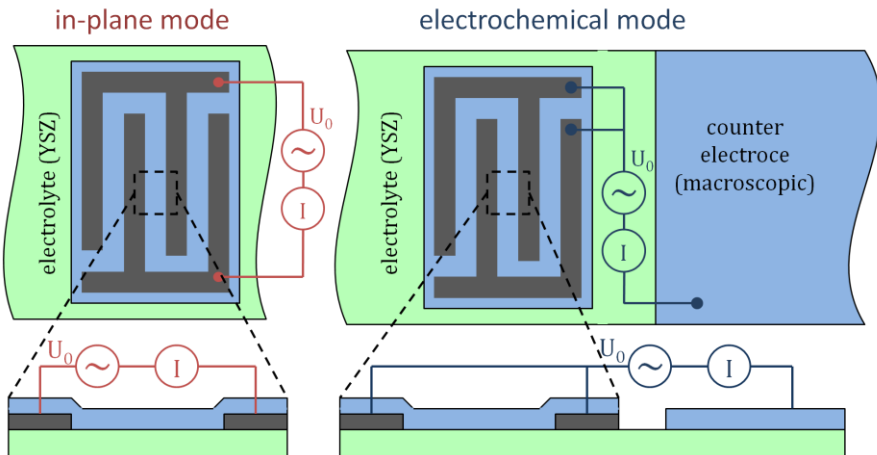
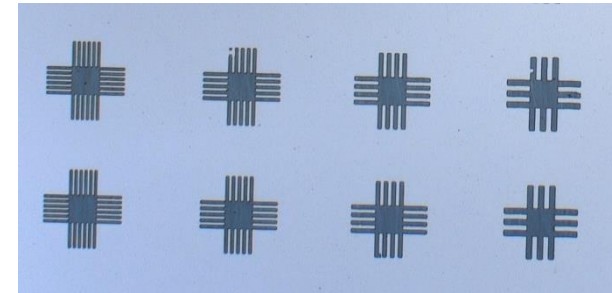
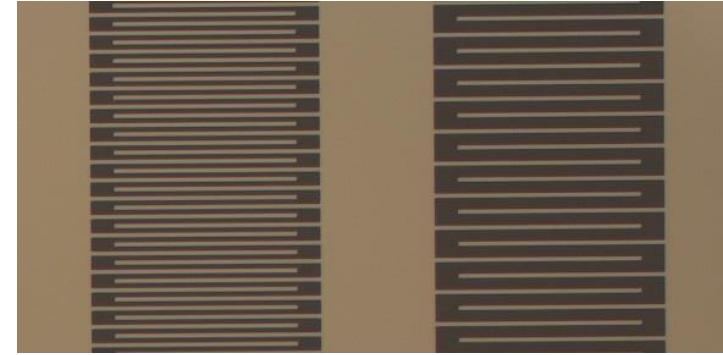


IN SITU I-PLD & I-PVD HEATER

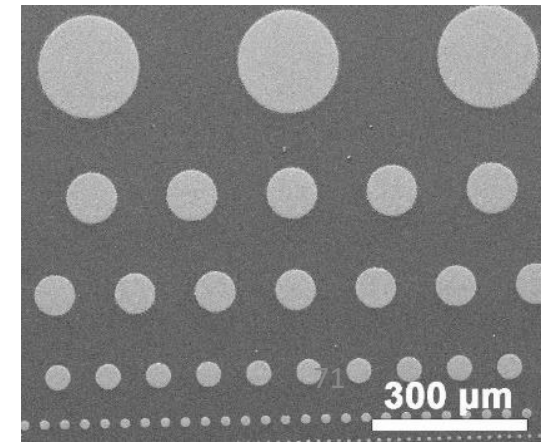
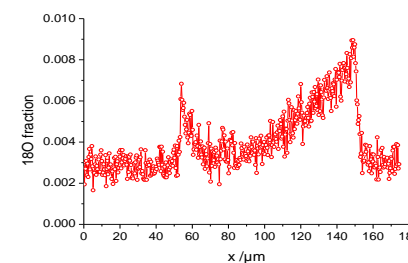
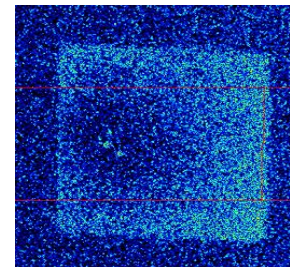
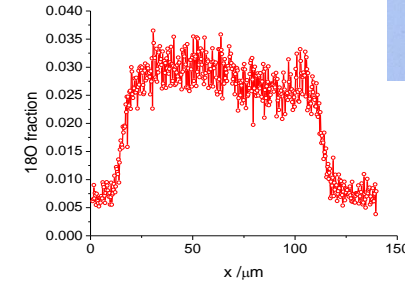
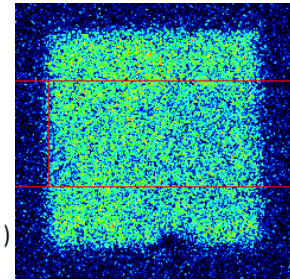


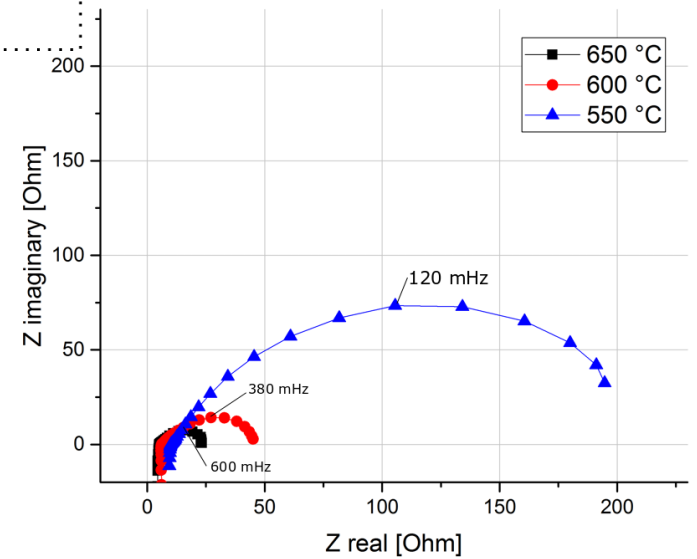
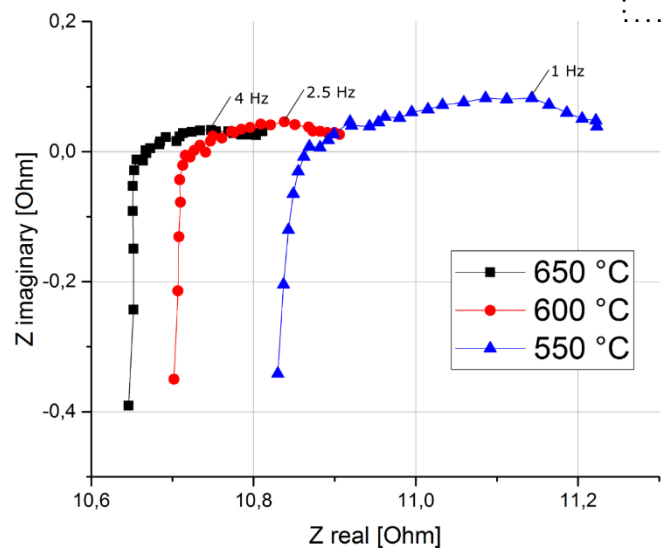
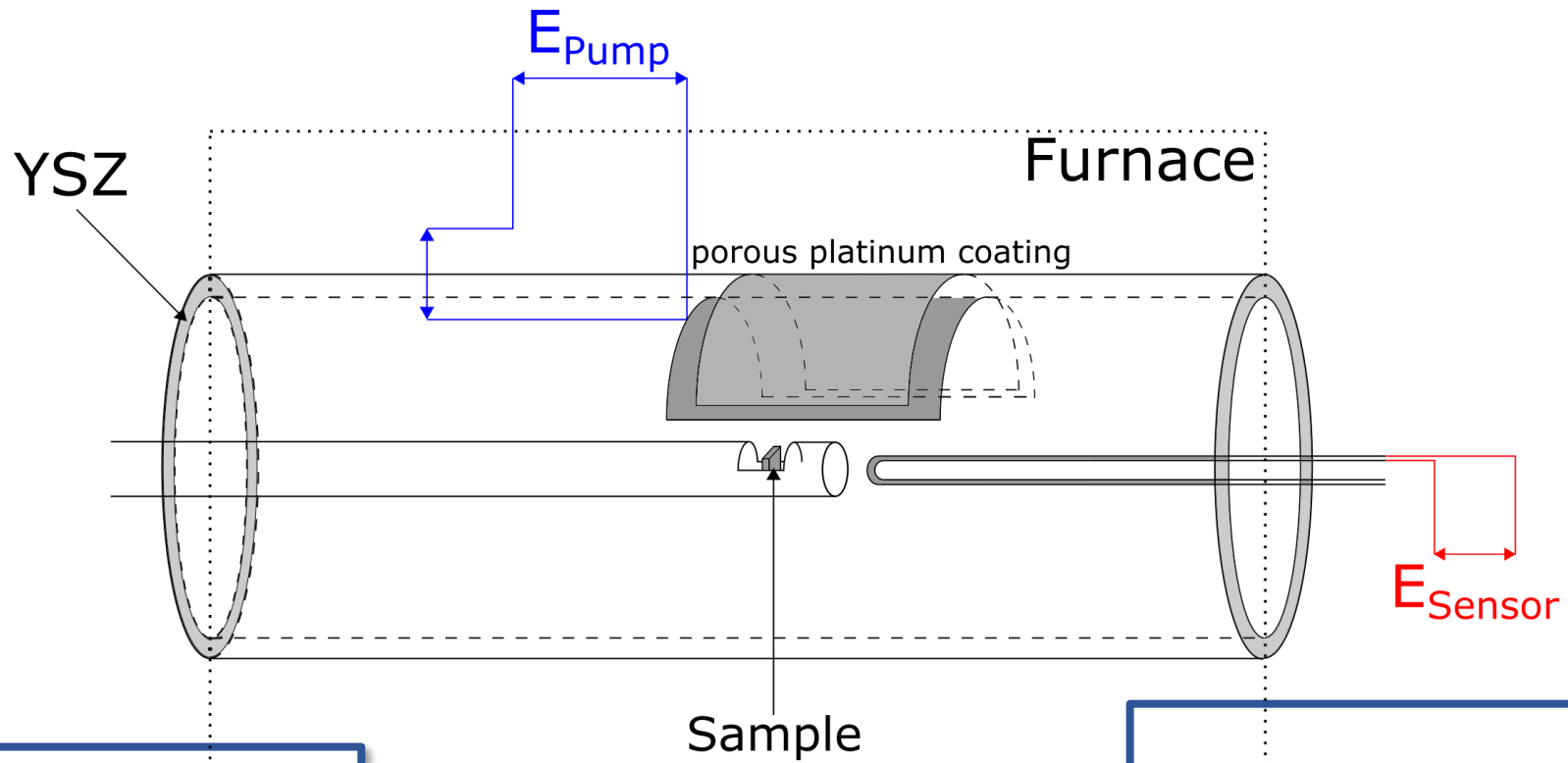
Advantages of micro patterned thin film electrodes

- Well-defined geometry (variable L3PB, ...)
- Reference electrode can be omitted
- Large number of electrodes on each sample
- Direct access to active surfaces in SIMS-studies, ...
- Current voltage **measurement measurements**

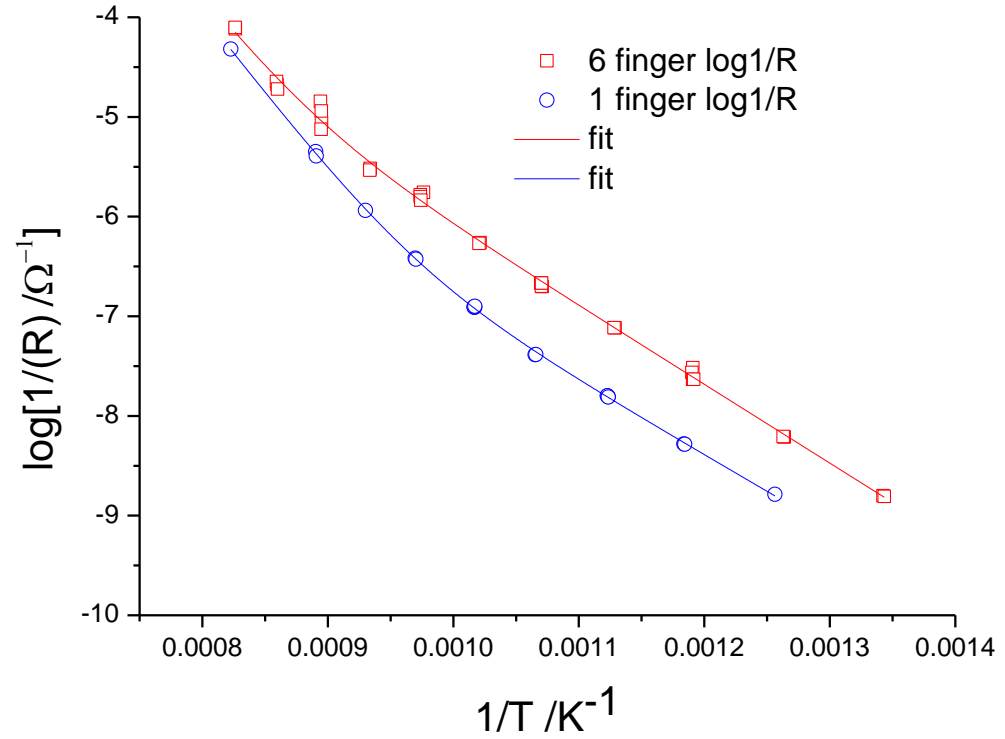
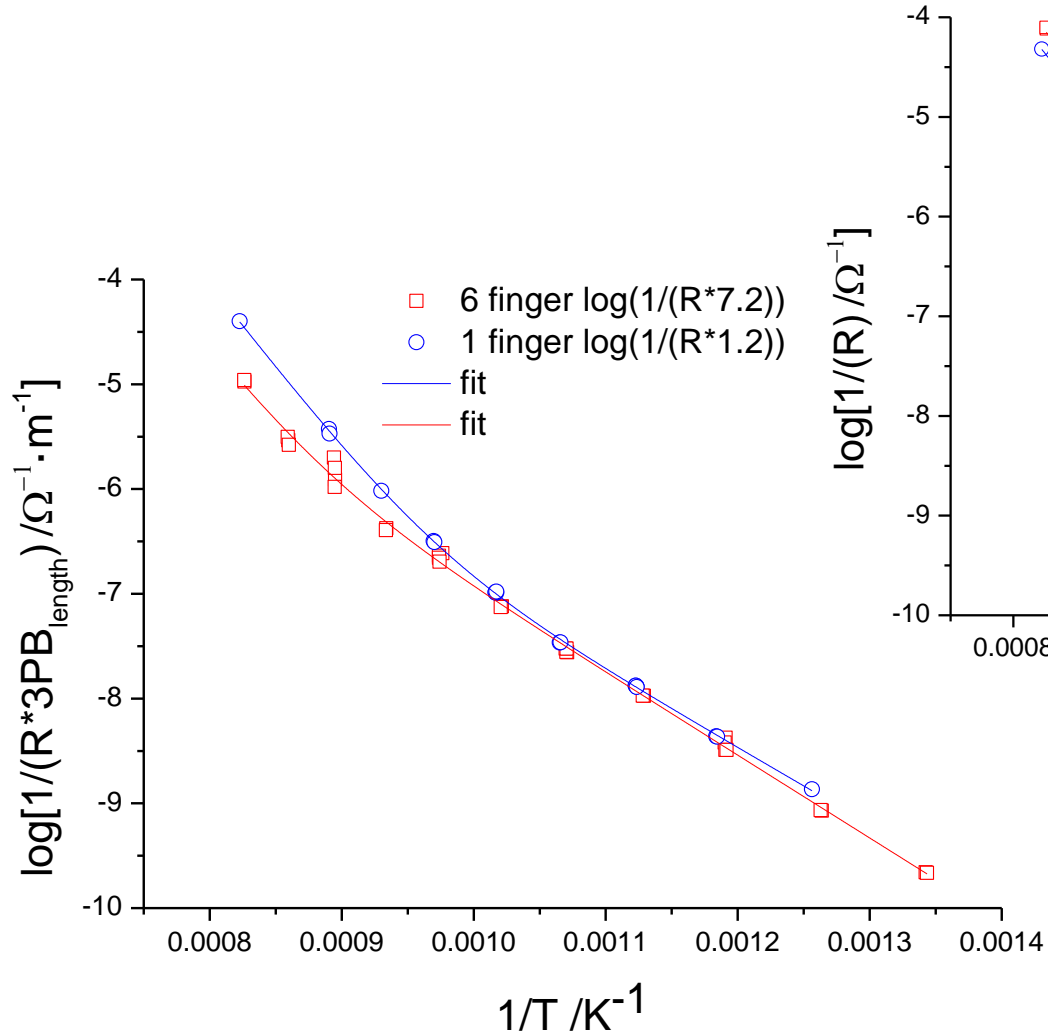
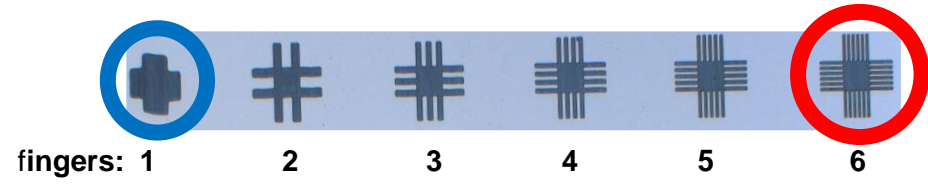


- MIEC film ($\text{Sr}(\text{Ti}_{0.7}\text{Fe}_{0.3})\text{O}_{3-\delta}$)
- current collectors
- electrolyte (YSZ)





Ridge electrodes, variation of 3PB

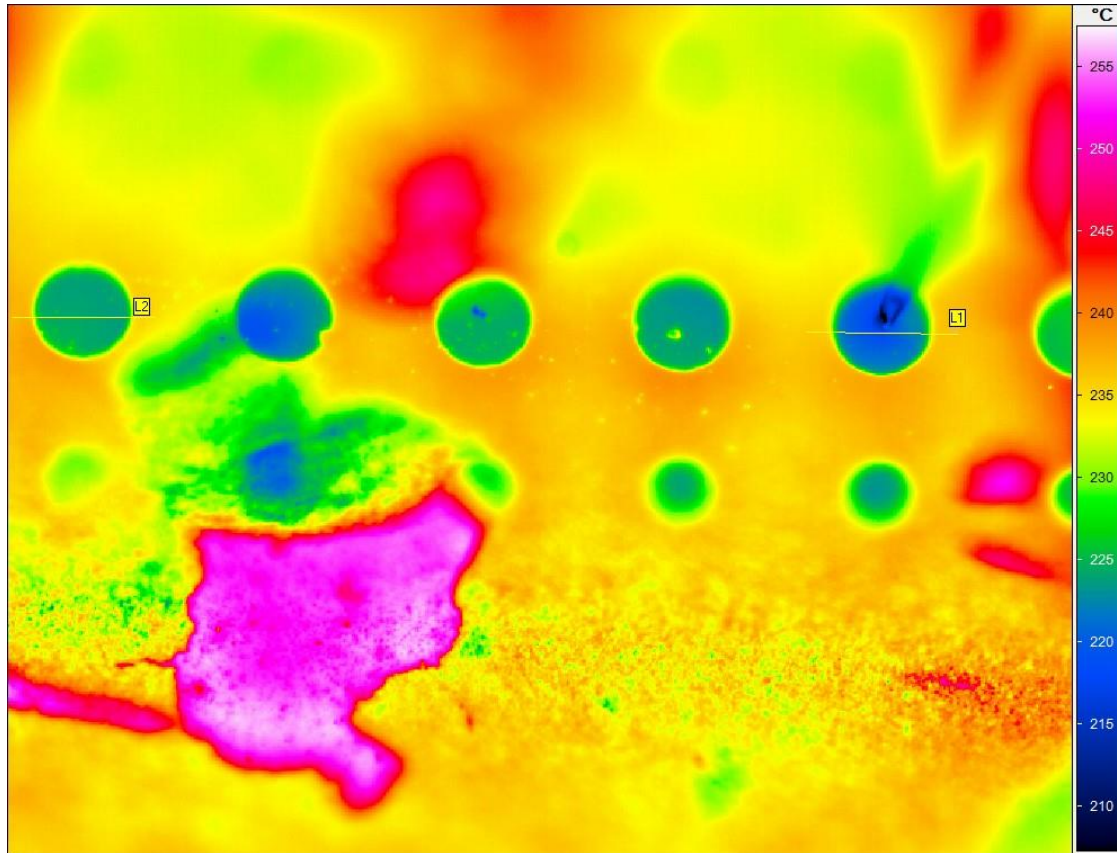


thickness: 240 nm

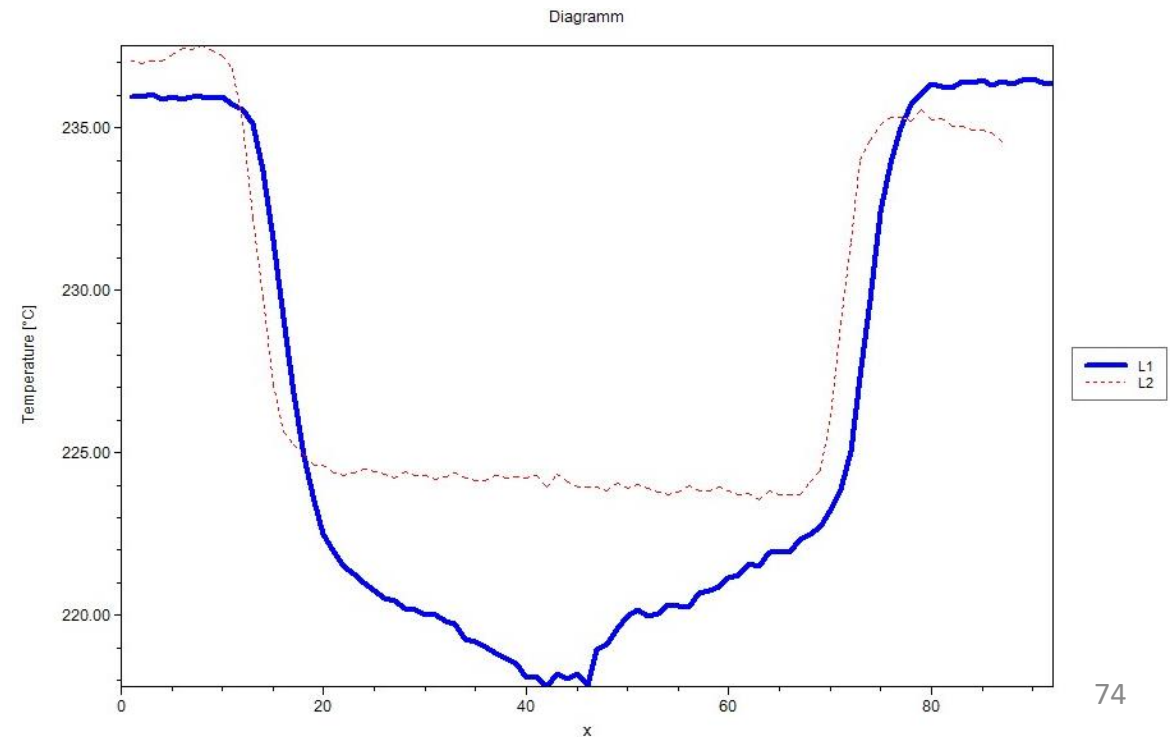
all electrodes have the same surface area

Infrared camera

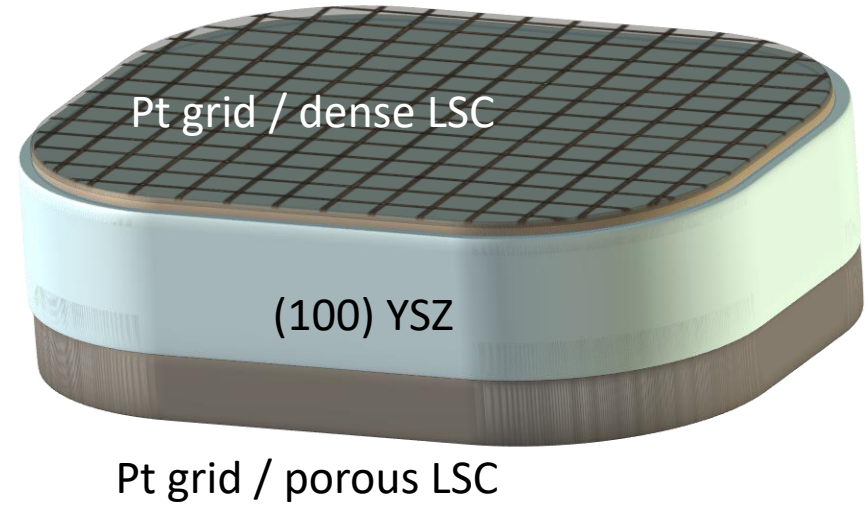
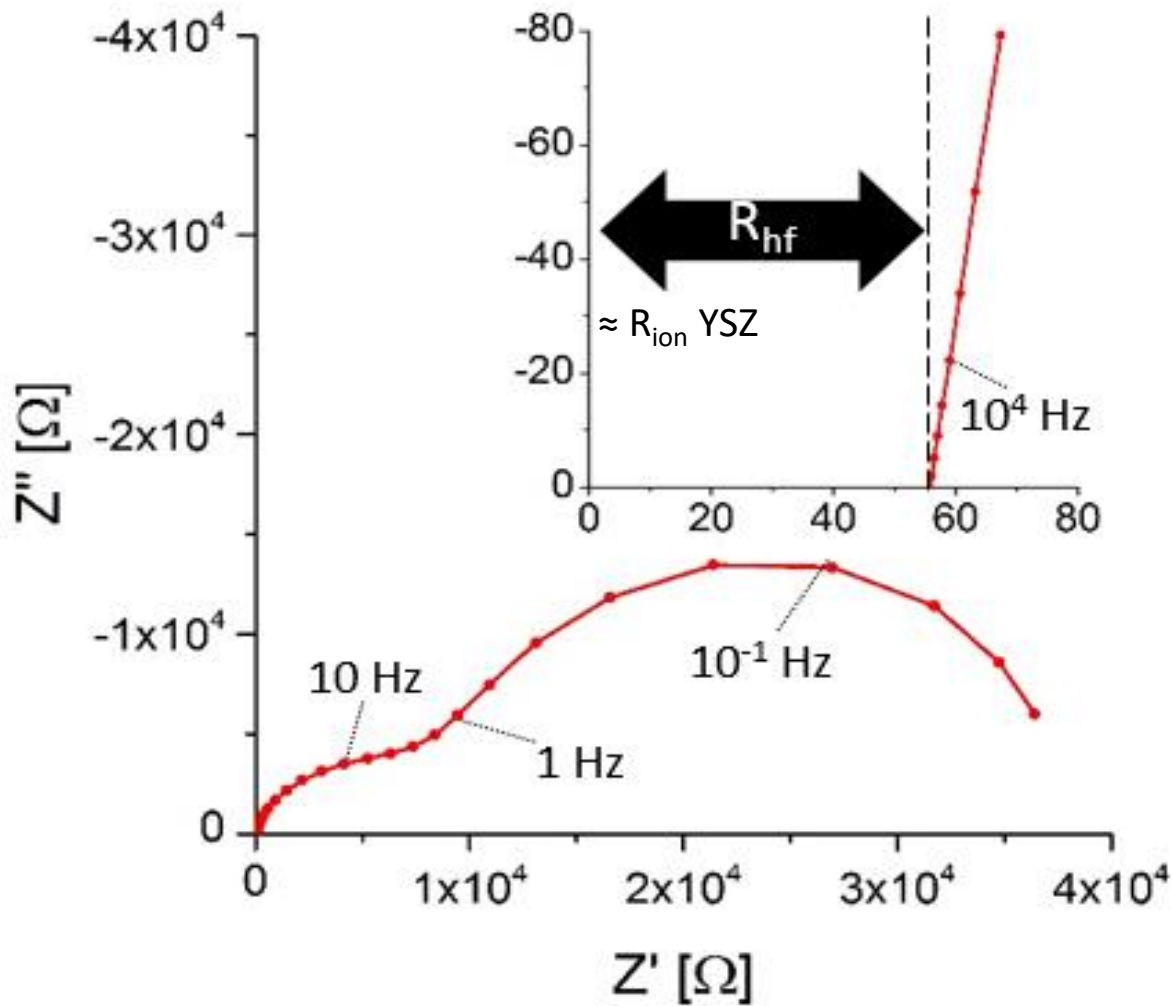
- 200 μm LSM electrode
- 300 $^{\circ}\text{C}$ furnace temperature
- visualizing temperature gradient



Infratec, ImageIR[®] 9300

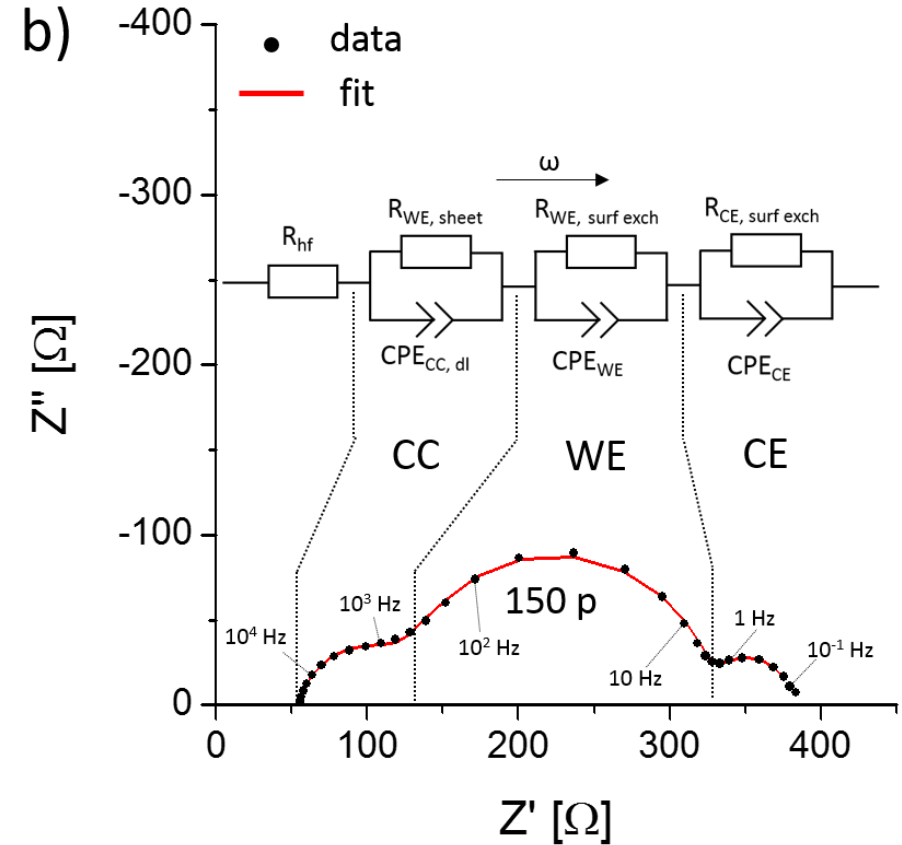
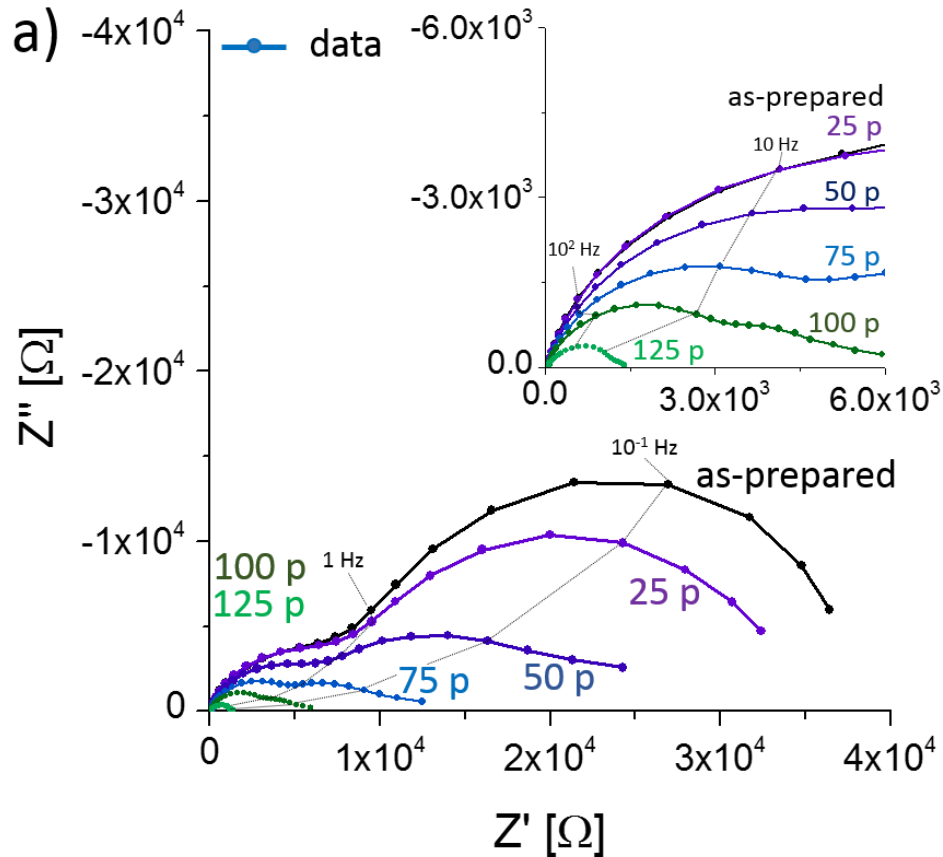


Temperature control



- High frequency resistance R_{hf} is dominated by the ionic oxygen transport resistance of (100) YSZ
- Calibration via reference measurements of YSZ

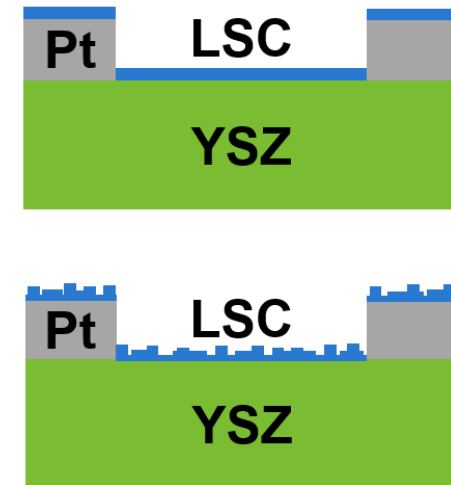
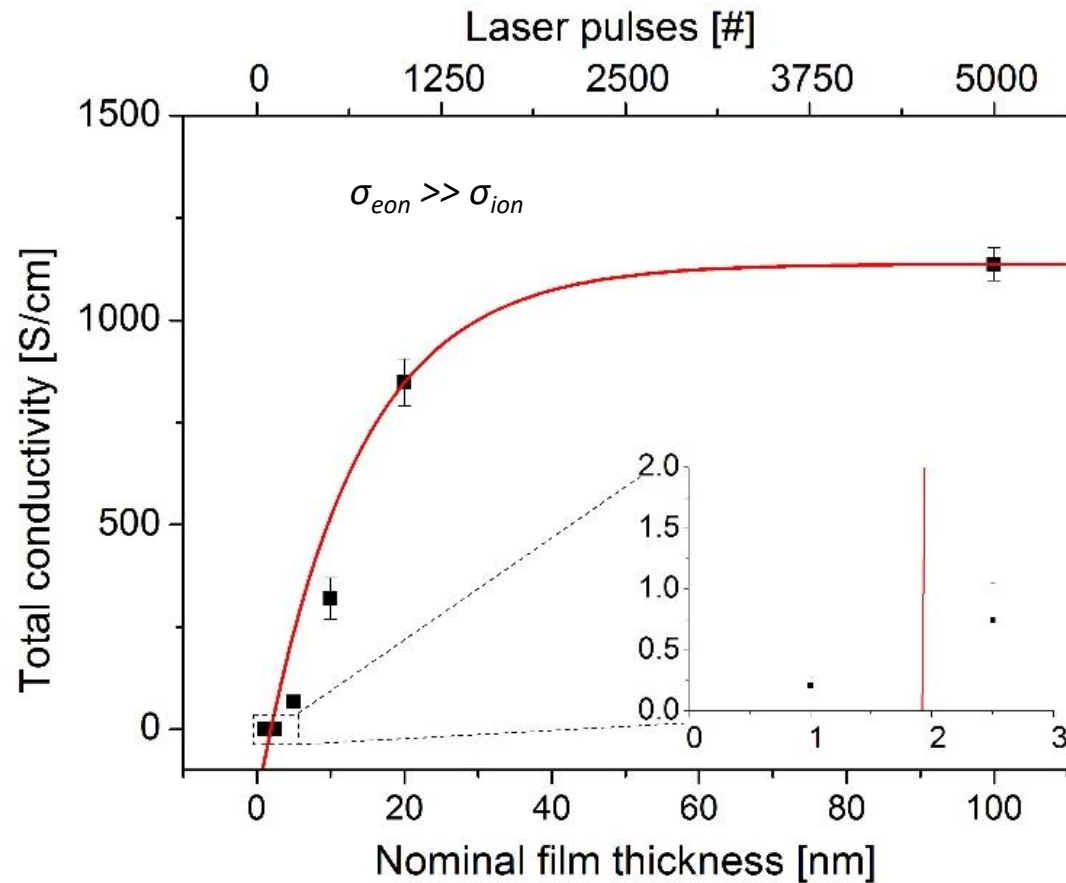
Impedance in the first 3 nm LSC



- PLD at 600°C and $4 \cdot 10^{-2}$ mbar $p(\text{O}_2)$, 10 mVAC for impedance
- At the beginning impedance is dominated by Pt grid
- > 125 pulses: 4 resistive contributions can be distinguished

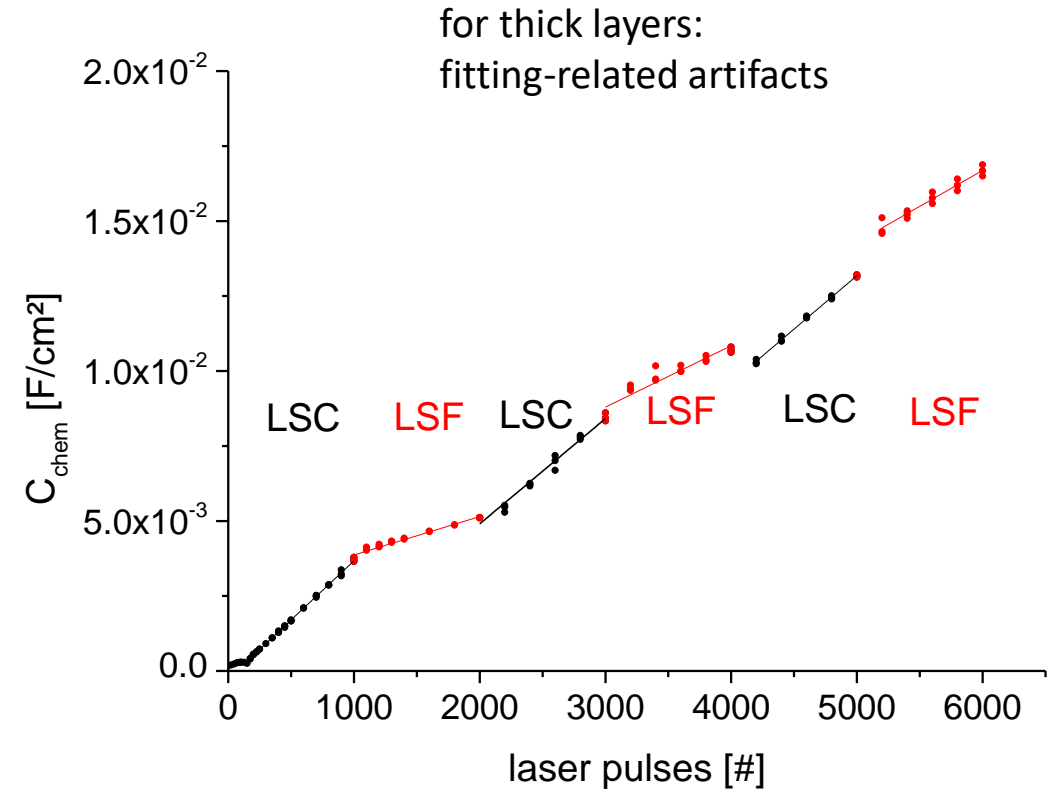
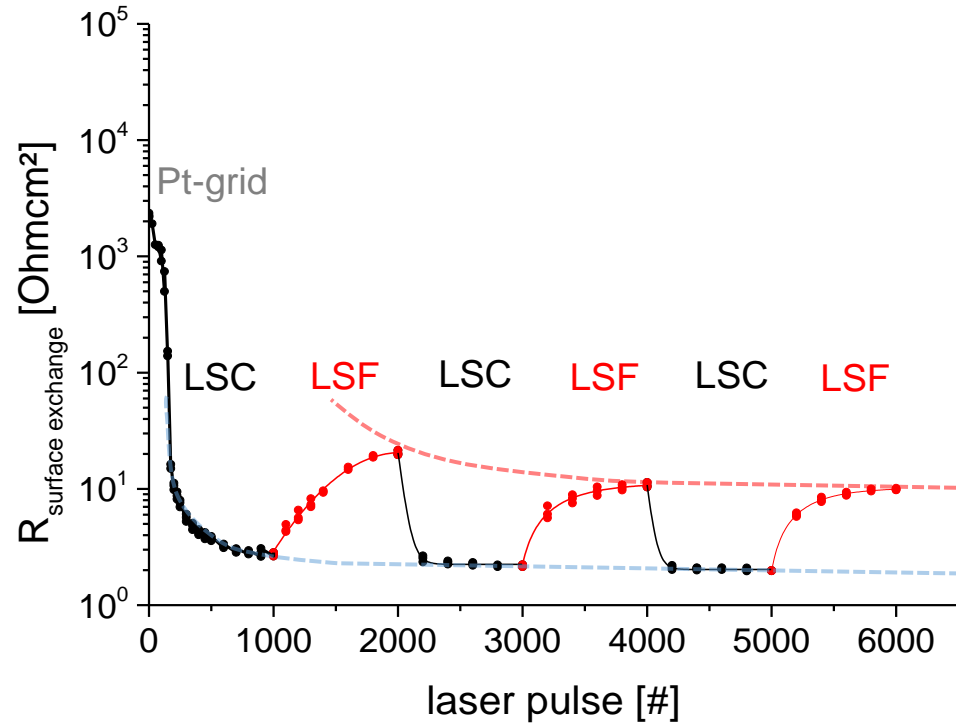
150 pulses = 3 nm

Sheet resistance of the growing film



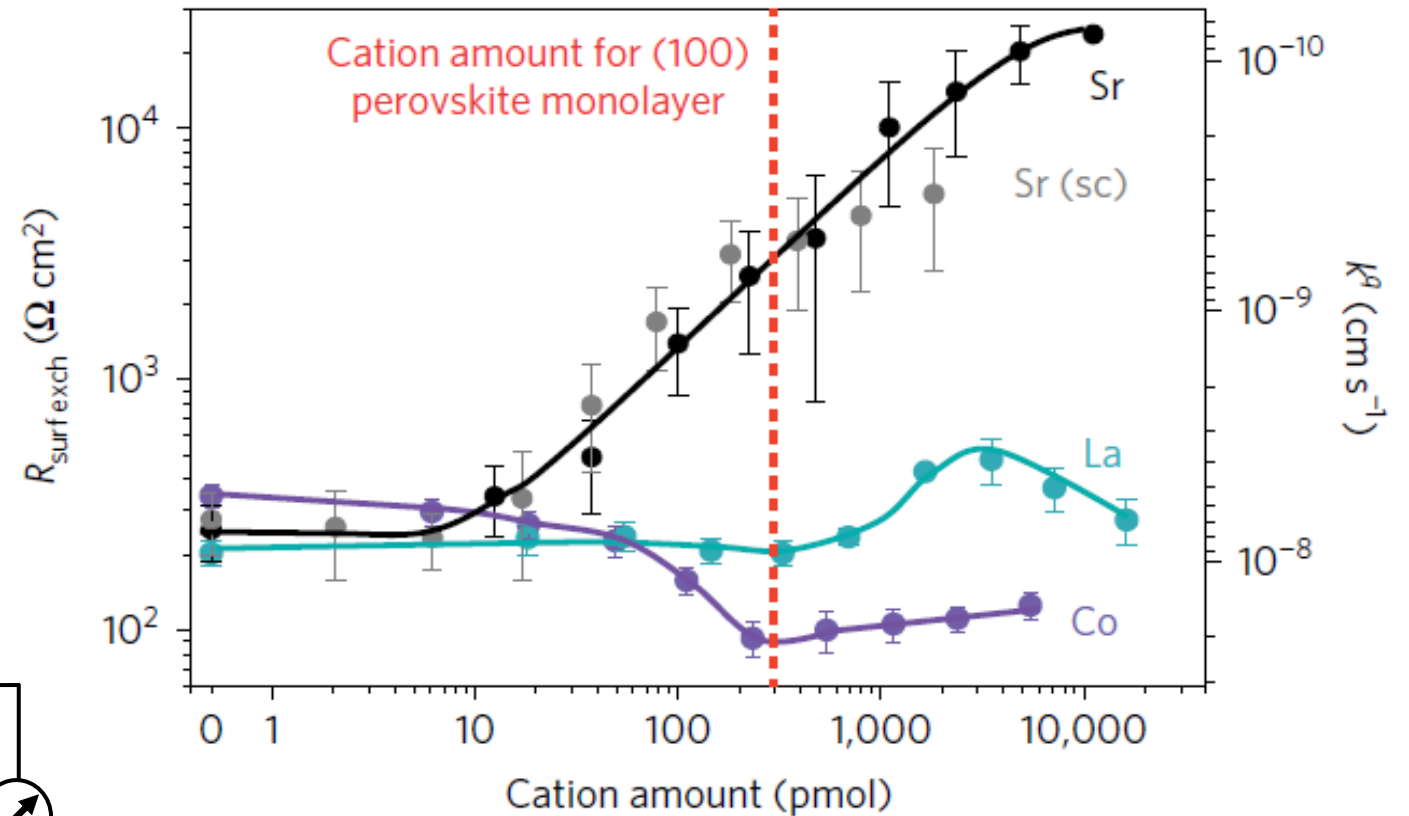
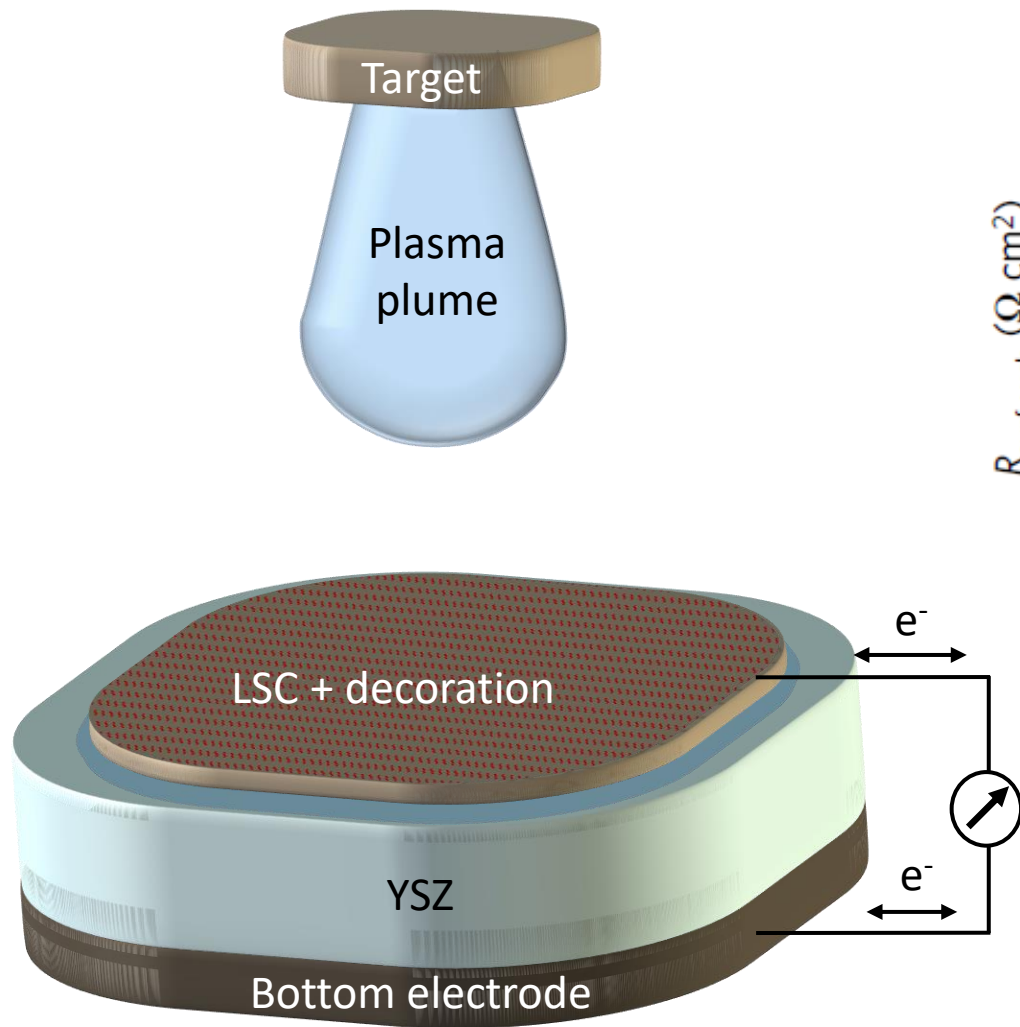
- Ex situ 4-point Van-der-Pauw measurements
- Expected LSC conductivity
- Slight deviation from ideal behavior \rightarrow non-ideal growth

Multilayers of $\text{La}_{0.6}\text{Sr}_{0.4}\text{CoO}_{3-\delta}$ and $\text{La}_{0.6}\text{Sr}_{0.4}\text{FeO}_{3-\delta}$



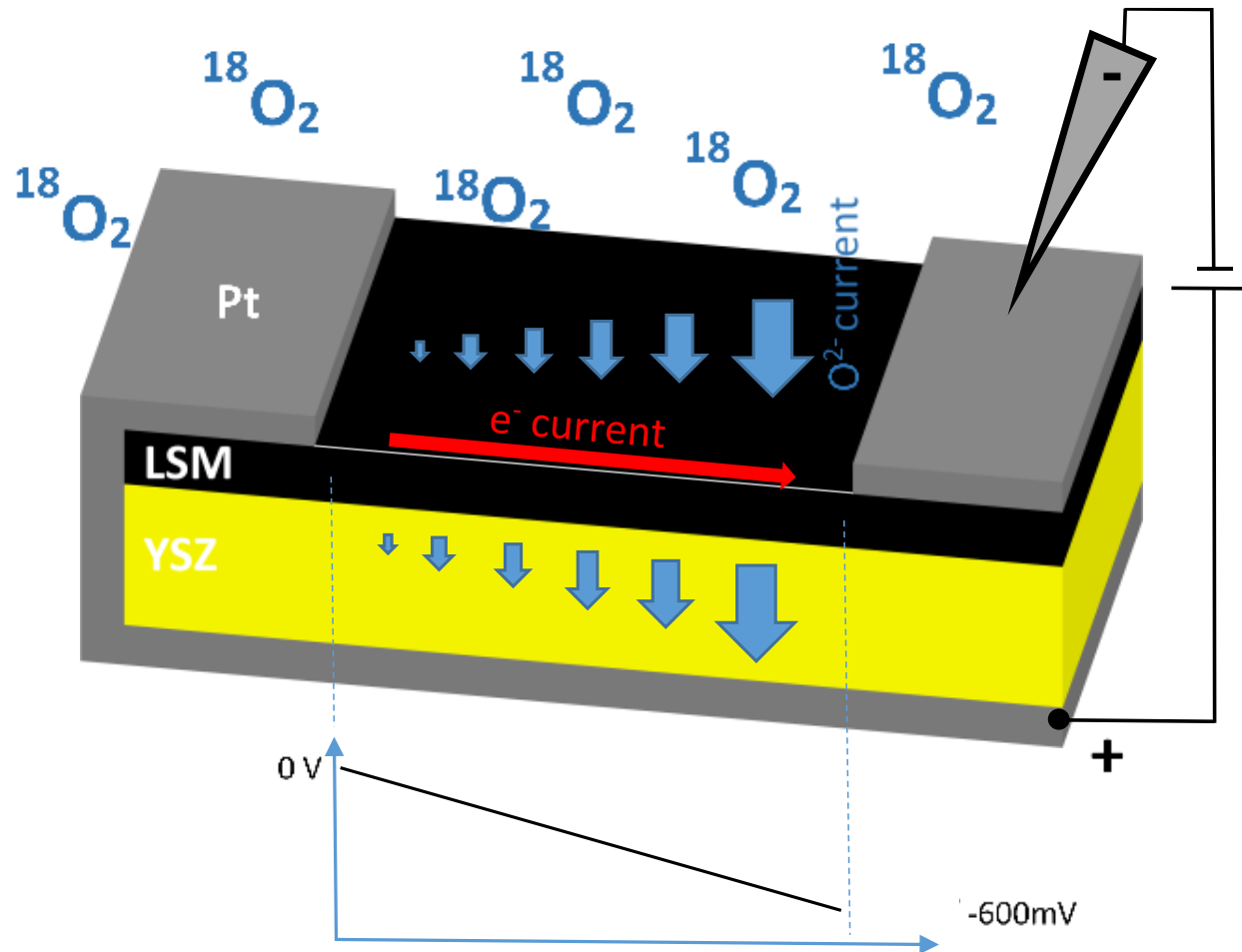
- Multilayers show transition between different surfaces (R_s)
- Charge carrier concentration from C_{chem}

Sub-monolayer decoration layers



- **Huge impact:**
add 13% of a ML \rightarrow +100% resistance
- **Few active centers on the surface**
- **Co enhances, Sr reduces activity**

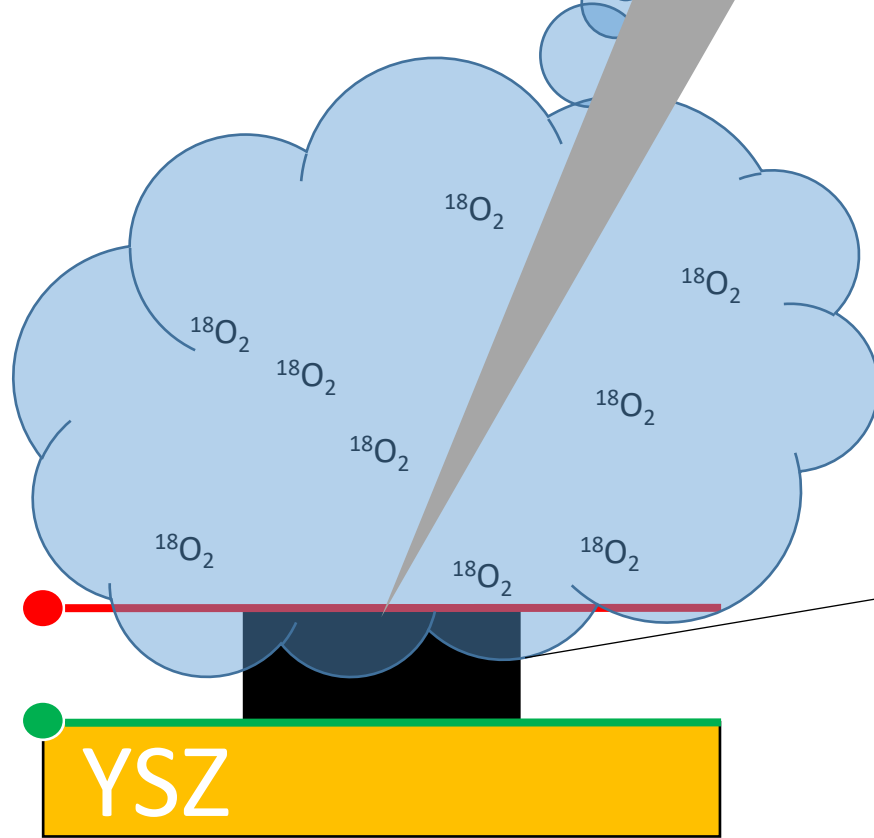
New experimental design for polarization experiments



motivation:

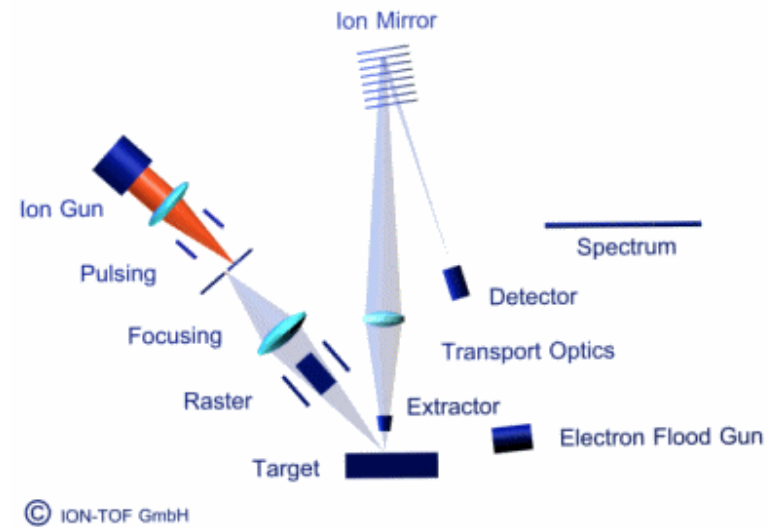
- Develop a simple method to study voltage assisted tracer exchange
- Easy to contact
- Highly accurate applied voltage
- Different polarized thin film on one and the same sample

SIMS



and ^{18}O exchange with polarization

Electrode



in situ



ex situ

cooling down changes experiment

sufficient resources? (time & money)

surface with analytic tools accessible

in situ ex situ same surface process?

process only visible under experimental conditions data possible to interpret?

impurities cause problems

oxidation → reductions make it visible

switch the catalyst on and off

observe the process. e.g. from the interface

expert in two fields ... e.g. deposition and measuring at the same time